

Fluid Modeling of the Plasma-Assisted Conversion of Greenhouse Gases to Value-Added Chemicals in a Dielectric Barrier Discharge

Proefschrift voorgelegd tot het behalen van de graad van doctor
in de wetenschappen: chemie aan de Universiteit Antwerpen
te verdedigen door

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**Fluid Modelling van de plasma-geassisteerde omzetting
van broeikasgassen naar chemicaliën met toegevoegde
waarde in een diëlektrische barrière ontlading**

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Chapter 1

Introduction

Socially, environmentally and economically a growing demand is being imposed for sustainability in the way energy resources are utilized. A global sustainable energy strategy that meets the increasing demand is based on an improvement of the energy efficiency of the current technologies and a more intensifying diversification of the energy resources with a huge preference for lower carbon resources.

1.1. Global Energy Demand

In 1974 the International Energy Agency (IEA) was established to promote energy security amongst its member countries (Belgium is a founding member) through collective response to physical disruptions in oil supply, and to provide authoritative research and analysis on ways to ensure reliable, affordable and clean energy for its 29 member countries and beyond.¹ The IEA annually publishes a World Energy Outlook which presents updated projections for the evolution of the global energy system, as well as detailed insights on the prospects for fossil fuels, renewables, the power sector and energy efficiency and analysis on trends in CO₂ emissions and fossil-fuel and renewable energy subsidies. The World Energy Outlook reports of 2014² and 2015³ state that the energy use worldwide is set to grow by one-third to 2040, driven primarily by India, China, Africa, the Middle East, Southeast Asia and Latin America.

Pledges made prior to the 21st Conference of the Parties to the United Nations Framework Convention on Climate Change (COP21/CMP11; November-December, 2015) indicate that future energy policy intentions should result in a boost to lower-carbon fuels and technologies worldwide. As a result it is expected that the share of non-fossil fuels will increase from 19% of the global mix today to 25% in 2040. Therefore, the world's energy supply mix will be divided into four almost-equal parts by 2040: oil, gas, coal and low-carbon sources.³ Although the demand for all fossil fuels is still increasing, natural gas, which is the least-carbon intensive, is the only one that sees its share rise by 2040. For instance, the share of oil will decrease from 34% in 2007 to 25% in 2040 and also the future use of coal, which resources are

abundant and which supply is secure, will be constrained if the global policy is to reduce the emission of carbon dioxide.²⁻⁴

A similar story can be found in the 23rd edition of the World Energy Resources Survey published in 2013 by the World Energy Council.⁵ Formed in 1923, the Council is the UN-accredited global energy body, representing the entire energy spectrum, with more than 3000 member organizations located in over 90 countries and drawn from governments, private and state corporations, academia, NGOs and energy-related stakeholders.⁶

Globally, fossil fuel resources are still plentiful and will last for decades, but it becomes more difficult to recover them and there can be no guarantee that they will be exploited fast enough to meet the level of demand. The availability of energy resources is, however, of paramount importance to the society. Access to reliable, affordable commercial energy provides the basis for heat, light, mobility, communications and agricultural and industrial capacity in modern society and in this way energy stipulates the degree of civilization.⁷ Besides, the transition of the energy market towards lower-carbon resources, also an enhancement in energy efficiency is very important in order to limit the world energy demand.

1.2. Reducing Greenhouse Gas Emissions

Furthermore, the recovery, production and use of fossil fuels are accompanied by the emission of greenhouse gases and contribute in this way to global warming. Climate change due to anthropogenic greenhouse gas emission is a growing concern for the global society. Anthropogenic

greenhouse gas emissions have increased since the pre-industrial era and have led to atmospheric concentrations of carbon dioxide (CO₂), methane (CH₄) and nitrous oxide (N₂O) that are unprecedented in at least the last 800,000 years. It is extremely likely that these greenhouse gas emissions have been the dominant cause of the observed global warming since the mid-20th century.⁸

Following the Synthesis Report on Climate Change⁸ published by the Intergovernmental Panel on Climate Change⁹ in 2014, a new international agreement on climate change was made at the 21st Conference of the Parties to the United Nations Framework Convention on Climate Change (COP21/CMP11; November-December, 2015), to keep global warming below 2°C. At the World Economic Forum 2016 Annual Meeting in Davos, Switzerland (January 2016), this new commitment to action on climate change was pointed out as one out of 10 key global challenges that matter to the world, stated as “Climate change: can we turn words into action?”. The International Council of Chemical Associations (ICCA)¹⁰, representing chemical manufacturers all over the world, and its member organization, i.e., the European Chemical Industry Council (Cefic)¹¹, which is the main European trade association for the chemical industry, strongly endorsed the international efforts to reach a binding global agreement at COP21. In the last decades, the chemical industry made its efforts to reduce greenhouse gas emissions, and today the European chemical industry uses less than half the energy it used back in 1990. Thus, its greenhouse gas emissions have fallen by 54% on 1990 levels, while its production grew by 70%. ICCA and Cefic believe that the chemical industry is also a pillar of tomorrow’s low-carbon economy

by developing innovative solutions, which will be crucial to combating climate change.¹⁰⁻¹¹

1.3. Natural Gas - Methane (CH₄)

In a world in which fossil fuels make the day, natural gas has the most significant growth potential and so it becomes more and more an interesting alternative for crude oil as feedstock for the chemical industry. Table 1 gives an overview of the benefits and drawbacks of natural gas as an energy resource. Natural gas is currently the third most used energy resource in the world after crude oil and coal,²⁻³ but the lifetime of gas resources is much longer than for oil and its lower carbon content makes natural gas the cleanest of all fossil-based fuels. Therefore, natural gas will continue making significant contribution to the world energy economy as it also is a flexible fuel. However, the exploration, development and transport of gas usually require significant upfront investment. In addition to power generation, natural gas is expected to play an increasing role as a transport fuel.⁵

Table 1. The benefits and drawbacks of natural gas.

(adopted from WER 2013 Survey⁵)

Benefits	Drawbacks
Cleanest of fossil fuels	Fields increasingly off-shore and in remote areas
Flexible and efficient fuel for power generation	High upfront investment requirement for transport and distribution system
Increasing proved reserves (reassessments and shale gas)	Increasingly long supply routes and high cost of infrastructure

Natural gas is a mixture of hydrocarbons, of which methane (CH_4) is the principal component. Methane, which is also an important greenhouse gas, is an odorless, colorless, non-toxic gas which is lighter than air. It is currently mainly being used for home and industrial heating and for the generation of electrical power. On the other hand, methane is a greatly underutilized resource for the production of chemicals and liquid fuels, mainly because it is one of the most stable molecules.¹² Direct synthesis of hydrocarbons starting from methane is not yet feasible and the conventional indirect methods for partial and total oxidation of methane have poor yields and require high amounts of energy.¹³ The utilization of natural gas as a chemical resource is currently limited to the production of synthesis gas (i.e., syngas: $\text{H}_2 + \text{CO}$) by steam reforming, which is a highly energy-intensive process.¹⁴

A sustainable process for the conversion of the abundant methane reserves into more value-added chemicals and fuels is therefore renowned as a challenge for the 21st century.¹² More in particular, the development of a process for the direct synthesis of higher hydrocarbons and oxygenates from methane in an energy-efficient way towards economy and environment would offer significant benefits, because this will circumvent the very expensive syngas step.¹⁵

1.4. Carbon Dioxide (CO₂)

Carbon Dioxide (CO₂), naturally present in the atmosphere as part of the natural circulation of carbon among the atmosphere, oceans, soil, plants, and animals, and thus being a vital gas for life on earth, is the primary greenhouse gas emitted through human activities.¹⁶ It is a very stable molecule that requires a lot of energy to be activated for the majority of synthetic routes to produce chemicals. Therefore, a first objective in the mitigation of CO₂ emissions is the process of Carbon Dioxide Capture and Storage (CCS), as pointed out in a special report published in 2005 by the Intergovernmental Panel on Climate Change.¹⁷ Nowadays, it is clear that aside from the reduction of CO₂ emissions to the atmosphere and the use of CCS for this purpose, also the energy efficient utilization of (captured) CO₂, as an important carbon resource to create products, will be a crucial step in order to achieve an economically viable low-carbon economy.

In 2011 Damiani et al.¹⁸ published a perspective concerning the United States Department of Energy's R&D program, to reduce greenhouse gas emissions through the beneficial use of CO₂. A vision for smart CO₂ transformation in Europe, enabling the European industry to become more resource-efficient, sustainable and competitive, was published in November 2015. This vision document, designed as part of the Smart CO₂ Transformation (SCOT) project, is a collaborative European project focused on accelerating the market development of CO₂ utilization and supported by funding from the European Seventh Framework program.¹⁶ Both documents stress the potential of CO₂ as a carbon resource and the importance of the transition into a world where CO₂ is used as feedstock for making many products. Damiani et al.¹⁸ state the benefits of CO₂ utilization as follows: it can generate

revenue to offset capture costs associated with CCS, it contributes to CO₂ emissions reduction, and it reduces the demand for fossil fuels. In the SCOT vision document,¹⁶ also three main reasons are listed why Europe should focus on CO₂ utilization: (i) it can be one of the major growth areas in Europe's future low-carbon circular economy, (ii) it can help to facilitate Europe's energy transition and (iii) it can contribute to achieving Europe's aims for decreasing carbon emissions. The goal is to identify and develop a range of novel technologies that can beneficially use CO₂. It is clear from both documents that the use of CO₂ for chemical production is one of the priority research areas concerning CO₂ utilization.

Today, CO₂ utilization is mainly limited to the direct use, i.e. without a conversion step, as an inert agent for food packaging, in carbonated drinks, in refrigeration systems, in fire extinguishers, as a solvent, and for enhanced oil recovery (particularly in the United States), as well as the indirect use for the chemical production of mainly urea, a small amount of methanol and an even smaller amount of a wide variety of other products.¹⁶⁻¹⁸ Ongoing research on the conversion of CO₂ in value-added chemicals is primarily focusing on the formation of carbon monoxide (CO), methanol, polymers, urea, carboxylates, carbonates, olefins, etc.¹⁶ Figure 1 gives an overview of the use of CO₂ and the research areas supported by the United States Department of Energy. In order to convert CO₂ into products, an energy source, such as heat or electricity, or material inputs, such as fly ash, hydrogen or epoxides, is required.¹⁶ To become of added value, it is crucial that new CO₂ utilization processes have a lower carbon footprint than their equivalent classical processes using fossil fuel routes for the production of the same product.

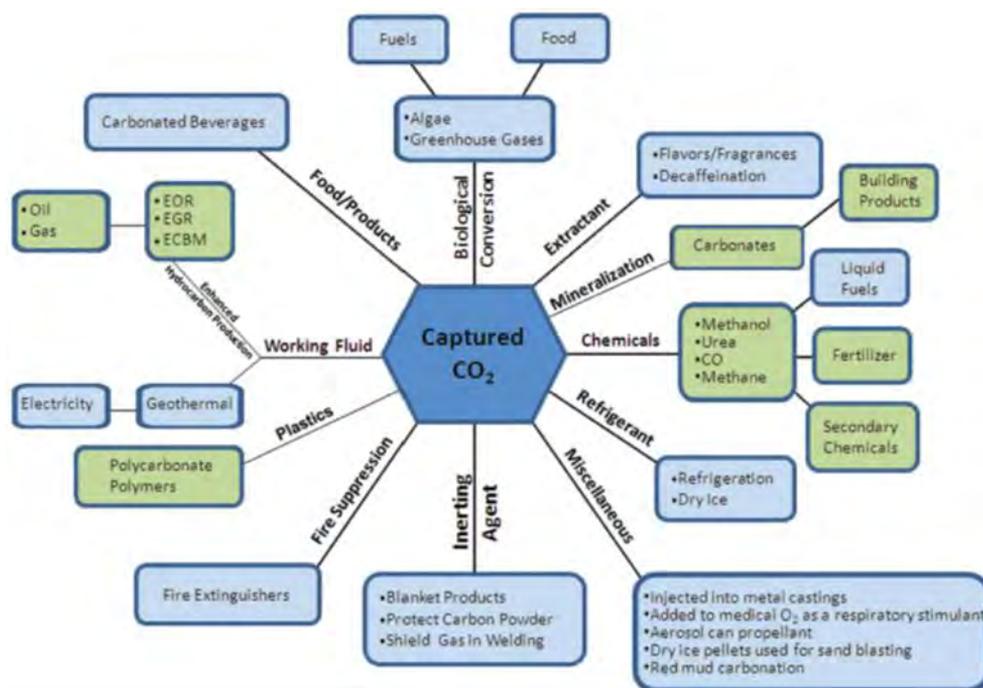


Figure 1. Overview of the use of CO₂. The research areas supported by the United States Department of Energy are shown in green.¹⁸

1.5. Value-Added Chemicals

The value-added chemicals of interest in this research are higher hydrocarbons, such as ethane (C₂H₆), ethylene (C₂H₄), acetylene (C₂H₂), propane (C₃H₈) and Propylene (C₃H₆), syngas, i.e., a mixture of carbon monoxide (CO) and hydrogen gas (H₂), also called synthesis gas, as well as oxygenates, such as methanol (CH₃OH) and formaldehyde (CH₂O).

C₂H₆ is mainly used in the chemical industry as a feedstock for the production of C₂H₄, which is considered as the most important feedstock in the chemical industry.¹⁹ C₂H₄ is mainly used for the formation of polyethylenes, which are the world's most widely used plastics. Besides, it

also forms the basis for the formation of ethylene oxide, which is used in surfactants, and for the formation of ethylene glycol, which is applied as automotive antifreeze, as well as for many other applications. C_2H_2 is mainly utilized as a fuel source and as a chemical building block for the formation of ethylene and different polymerization products, which are applied in the plastic industry. C_3H_8 is the main component of liquefied petroleum gas (LPG), which is used as vehicle fuel. C_3H_6 forms the basis for the formation of polypropylene, which is typically used in the manufacturing of packaging and textiles.

Syngas is used as a fuel source or as an intermediate for the production of other chemicals. Classical processes, including steam reforming, partial oxidation and CO_2 reforming of methane, typically produce syngas with H_2/CO molar ratio greater than 3, less than 2 and less than 1, respectively.²⁰⁻²¹ The H_2/CO molar ratio from steam reforming (>3) is much higher than that required by the stoichiometry for many synthesis processes. A low H_2/CO molar ratio is desirable for many industrial synthesis processes, such as the Fischer Tropsch synthesis or the synthesis of valuable oxygenated chemicals. A H_2/CO ratio of about 2 is preferred for the formation of methanol out of syngas.²² Methanol can even be produced from syngas with a H_2/CO molar ratio as low as 0.5, when the system can simultaneously carry out methanol synthesis and the water-gas-shift reaction.²⁰⁻²¹

H_2 is mainly used for the processing of fossil fuels, the production of ammonia and methanol, and as fuel in fuel cells. Furthermore, it is used in the production of carbon steels, special metals and semiconductors. In the electronics industry, H_2 is employed as a reducing agent and as a carrier gas.²³

CO is used to make a variety of chemicals such as acids, esters and alcohols, as well as for the reduction of ores and in the manufacture of metal carbonyls.²³

Methanol is a primary liquid petrochemical, which is of great importance in the chemical and energy industries, because it can be easily stored and transported.²⁴ Methanol is one of the most commonly used raw materials in the chemical industry. More than one-third of it is used in the production of formaldehyde; the rest is mainly utilized to produce acetic acid and gasoline octane improvers. Additionally, the direct use of methanol as fuel in internal combustion engines and fuel cells opens up the possibility of methanol powered vehicles and consumer electronics.²⁵ Formaldehyde is a common building block for the synthesis of more complex compounds, which are used in a wide range of products.

Chapter 2

Plasma-Assisted Gas Conversion

The major difficulty for the direct conversion of methane and carbon dioxide into value-added chemicals is that both are very stable molecules that require a large amount of energy for activation of the stable C-H and C-O bonds, respectively. Conventional methods, which make use of a high temperature and pressure and a noble catalyst, require high amounts of energy. In the last decades, there is an increasing interest in using plasma technology for gas conversion. Atmospheric pressure non-thermal low-temperature plasmas can offer a distinct advantage, because they enable in a unique way gas phase reactions at ambient conditions.

2.1. What is a Plasma?

Plasmas are ionized gases. Hence, they consist of positive (and negative) ions and electrons, as well as neutral species. The ionization degree can vary from 100% (fully ionized gases) to very low values (e.g. 10^{-4} – 10^{-6} ; partially ionized gases).²⁶ A plasma is generated by supplying energy to a neutral gas, causing the formation of charge carriers. The charged species are considered to be balanced in the bulk of the plasma, giving plasmas the characteristic of quasi-neutrality. These unique properties make that the plasma state is often called the 'fourth state of matter', next to solid, liquid and gas. The name 'plasma' was introduced in 1929 by Irving Langmuir who chose this name, because the multi-component, strongly interacting ionized gas reminded him of blood plasma.²⁷

Almost all visible matter in the universe is in the plasma state. Examples of natural plasmas are the stars, the solar wind, the earth's ionosphere, the aurora borealis and lightning. Besides these astropasmas, two main groups of laboratory plasmas can be distinguished, i.e. the high-temperature or fusion plasmas, and the so-called low-temperature plasmas or gas discharges. A subdivision can be made between plasmas which are in thermal equilibrium and those which are not in thermal equilibrium. Thermal plasmas are characterized by the fact that the temperature of all species in the plasma is the same. High temperatures are required to form these equilibrium plasmas, typically ranging from 4000 K to 20 000 K.²⁶ In non-thermal plasmas the temperature of the electrons is much higher than that of the heavy particles (ions, atoms, molecules). The most commonly used method to generate and sustain a low-temperature plasma is by applying a sufficiently high electric field to a neutral gas, which partially breaks it down, turning some atoms or

molecules into positive ions and generating free electrons. These charge carriers are accelerated by the electric field, and new charged particles may be created when these charge carriers collide with gas molecules or with the electrodes. The resulting avalanche of charged particles is eventually balanced by charge carrier losses, creating a steady-state plasma.²⁸

There exists a wide variety of non-thermal gas discharge plasmas, each with its own characteristics and employed in a large range of applications. Based on the temporal behavior of the sustaining electric field, gas discharges can be classified as direct current (dc), alternating current (ac) or pulsed discharges.²⁸ An example of a non-thermal ac discharge is the dielectric barrier discharge (DBD), which is the type of plasma under study in this dissertation and will therefore be explained in more detail in the next section. An overview of the most important gas discharge plasmas and their applications can be found in Bogaerts et al.²⁶ and Conrads et al.²⁸. Table 2 shows the most important gas discharges along with their parameters and possible applications.

Table 2. Plasma sources and their parameters.(modified from Conrads et al.²⁸)

Physics	Pressure (mbar)	n_e (cm^{-3})	T_e (eV)	Application
Dielectric barrier discharge	1000	10^{14}	5	Ozone, microelectronics, chemistry
Corona	1000	10^{13}	5	Ozone, chemistry
Microwave	10-1000	10^{13}	1-2	Chemistry, microelectronics
Spark	$1000-10^4$	10^{17}	1	Chemistry, water treatment
Gliding arc	1000	$10^{12}-10^{17}$	1	Chemistry
Nanosecond pulsed	1000	10^{12}	5	Chemistry
DC glow	10^{-3} -100			
Cathode region			100	Sputtering, deposition
Negative glow		10^{12}	0.1	Chemistry, radiation
Positive column		10^{11}	1-10	Radiation
Hollow cathode	10^{-2} -800	10^{12}	0.1	Radiation, chemistry
Magnetron	10^{-3}			Sputtering
RF capacitive	10^{-3} -10	10^{11}	1-10	Microelectronics, sputtering
RF inductive	10^{-3} -10	10^{12}	1	Microelectronics, etching
Electron beam	10^{-2} -1	10^{12}	1	Microelectronics

2.2. Dielectric Barrier Discharge

A dielectric barrier discharge (DBD) or so-called silent discharge is an electrical discharge that is generated between two electrodes of which at least one is covered with a dielectric material made of glass, quartz, alumina, etc. The gap between the two electrodes is typically a few millimeters. An ac voltage with an amplitude from 1 kV to 100 kV and a frequency of a few Hz to MHz is usually applied to this kind of discharges. Typical electrode

arrangements of planar and cylindrical DBDs are shown in Figure 2. For gas conversion purposes mostly a cylindrical reactor is used. A DBD has the advantage, unlike other non-equilibrium discharges, that it can be operated at atmospheric pressure, while remaining at ambient temperature.

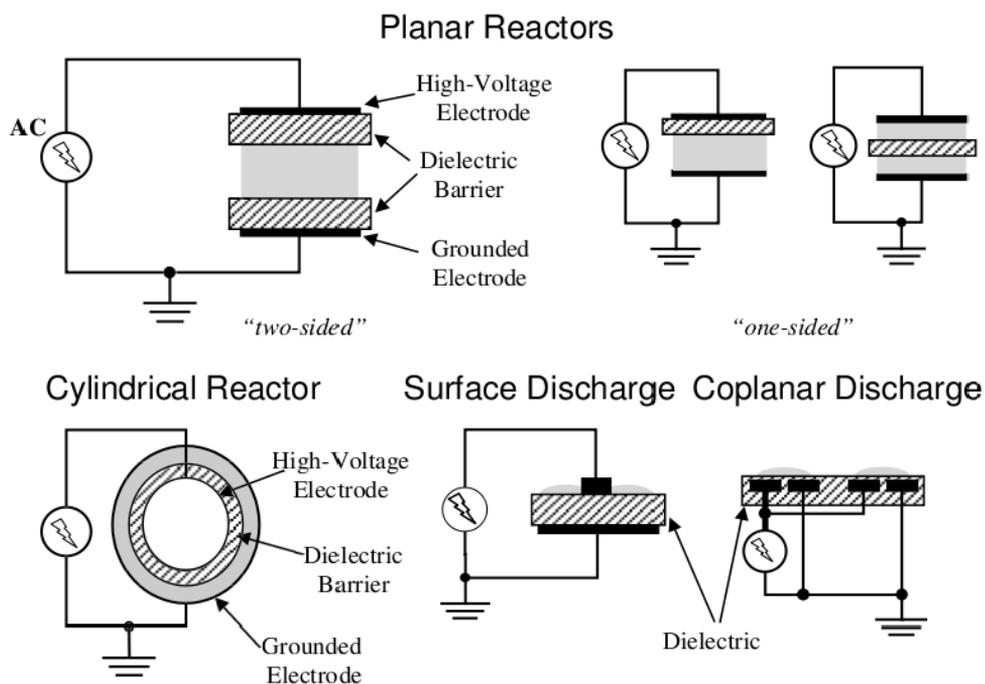


Figure 2. Typical electrode arrangements of barrier discharges.²⁹

The first experimental investigations with a DBD were reported in 1857 by Werner von Siemens. The research was mainly focused on the generation of ozone by blowing air or oxygen through a narrow annular gap between two coaxial glass tubes in which a DBD was maintained by an alternating electric field of sufficient amplitude. The novelty of this setup was that the electrodes, which were made of tinfoil, were not in direct contact with the plasma, which

considerably increased their lifetime. In the following decades, ozone and nitrogen oxide formation in DBDs became an important research topic.³⁰

Today, these silent discharge ozonizers are effective tools, and a large number of ozone installations based on plasma technology are being used worldwide for water treatment. DBDs are nowadays also used to pump CO₂ lasers, to generate excimer radiation in the UV and VUV spectral regions, in various thin-film deposition processes, and for plasma display panels. In recent years, DBDs are increasingly being used as reactor set-up for gas treatment or gas conversion, which is the objective of this dissertation. Detailed information on the history of a DBD and the wide variety of applications for which a DBD is used can be found in literature.^{26, 28, 30-36}

2.3. Breakdown: The Initiation of Reaction Kinetics

In a DBD reactor typically operating at atmospheric pressure, a large number of short-living current filaments, so-called microdischarges, which are randomly distributed both in time and in space, appear during breakdown.³⁷ It can be presumed that the plasma is enclosed in the volume surrounded by these microdischarges. Three separate steps can be distinguished during the life cycle of one such filament: (i) the formation of the discharge, i.e., the electrical breakdown, (ii) the subsequent current pulse or transport of charge across the gap, and (iii) simultaneously the excitation of the atoms and molecules present, and thus the initiation of the reaction kinetics. The durations of these three steps are of different orders of magnitude. The local breakdown is usually completed within nanoseconds, the current transport takes typically 1-100 ns, while the chemistry can last from nanoseconds to

seconds.³¹ Approximate time-scales for the different processes involved are given in Figure 3.

By applying an increasing voltage to the electrodes, breakdown is induced once the electric field inside the gap exceeds the corresponding reduced Paschen field of the gap. The Paschen voltage is given by the smallest constant voltage needed to initiate breakdown in the gap. This breakdown voltage depends on the gas composition and on the reactor configuration, i.e. the gas pressure and the gap width. The reduced Paschen field is obtained by dividing the Paschen voltage by the product of the gas pressure and the gap width.³¹

Each microdischarge has an almost cylindrical plasma channel and typically a diameter of the order of some 100 μm . They are usually very short-lived, on the order of 100 ns or less. Both the diameter and the duration depend upon the gas used and the pressure.³¹ The number of microdischarges is proportional to the voltage applied on the electrodes.³⁷⁻³⁸ The current flows entirely within the filaments and is limited by the dielectric barrier(s) between the electrodes. Thus, the dielectric serves a dual purpose. It limits the amount of charge and energy imparted to an individual microdischarge and, at the same time, it distributes the microdischarges over the entire electrode area. Typically the current density in the filaments is 100–1000 A cm^{-2} , the electron density is 10^{14} – 10^{15} cm^{-3} , and typical electron energies are in the range of 1–10 eV.^{28, 30, 39} Typical charges transported by individual microdischarges are of the order of nC, and typical energies of the order of μJ .⁴⁰ Over long time periods, the microdischarges, which are randomly distributed by the way they are initiated, will thus evenly fill the available volume.

The exchange of energy between the accelerated electrons and the atoms and molecules occurs within the microdischarges. The fairly energetic

electrons collide with the gas molecules and excite them and thus transform some of their kinetic energy into internal energy of the gas molecules. Due to the high electron energy, this energy exchange can be very efficient. It is not unusual that 90% of the kinetic energy or more is transformed into stored energy.³¹ Elastic losses are therefore very low, and initially very little energy is lost as heat.³¹ The excited species formed in the microdischarge filaments can diffuse into the regions between the filaments, which are free of charged particles, and initiate the chemical reactions (see below) before the next discharge strikes at the same location. This separation of electron-producing regions and chemically active regions can be very beneficial.³⁹

More information about the formation of these microdischarges and the characteristics of a DBD can be found in literature.^{28, 30-31, 34, 37, 39-41}

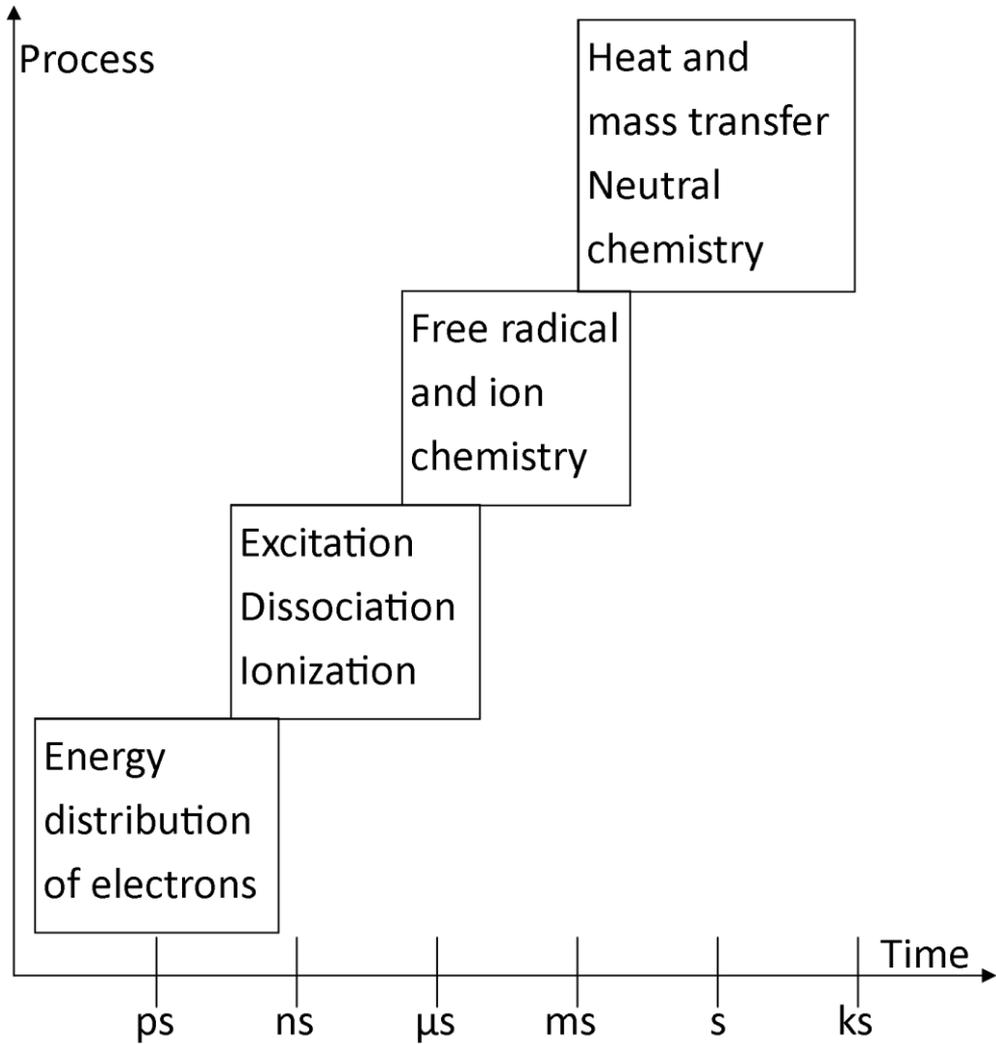


Figure 3. Time-scale of the relevant processes of a filamentary DBD.

(modified from Wagner et al.²⁹)

2.4. The Plasma Chemistry

The excited molecules can now, due to their high internal energy, either dissociate or initiate other reactions.³⁹ The main types of reactions occurring in the plasma are listed in Table 3, for an arbitrary gas (called A_2). Different plasma activation mechanisms cause vibrational and electronic excitation, as well as ionization and dissociation of species, and in this way gas conversion processes are induced. Reactive species in the discharge (free radicals, electrons, ...) will cause decomposition of the molecules, initially present in the gas mixture, and afterwards recombination will lead to the formation of value-added and/or less hazardous end products. Every reaction is characterized by a few main characteristics, such as the reactants, the products, the pressure, the temperature, the heat of the reaction, and the rate coefficient.³⁹

These plasma chemistry processes, taking place at atmospheric pressure and ambient temperature, make a DBD reactor of interest for the conversion of greenhouse gases to higher hydrocarbons, oxygenates and syngas. Nowadays a lot of research is carried out on the use of a DBD for the conversion of CH_4 and CO_2 , as will be clear from the next chapters in this dissertation. However, there are still a lot of issues open for discussion. More specifically, a lot of research work still has to be performed with respect to improving the energy efficiency and the selectivities of the end products, in order to come to a sustainable industrial process, which is competitive with currently existing or other emerging technologies. In order to optimize such a process to become competitive, it is essential to understand the huge underlying plasma chemistry acting in the conversion processes. This is exactly the purpose of this PhD dissertation, where we try to obtain a better insight in

the plasma chemistry, by means of fluid modeling, as elaborated in the next chapter.

Table 3. Overview of the main plasma reactions for an arbitrary gas, called A_2 .

(adopted from Eliasson et al.³⁹)

Electron/Molecular Reactions	
Excitation	$e^- + A_2 \rightarrow A_2^* + e^-$
Dissociation	$e^- + A_2 \rightarrow 2 A + e^-$
Attachment	$e^- + A_2 \rightarrow A_2^-$
Dissociative Attachment	$e^- + A_2 \rightarrow A^- + A$
Ionization	$e^- + A_2 \rightarrow A_2^+ + 2 e^-$
Dissociative Ionization	$e^- + A_2 \rightarrow A^+ + A + 2 e^-$
Recombination	$e^- + A_2^+ \rightarrow A_2$
Detachment	$e^- + A_2^- \rightarrow A_2 + 2 e^-$
Atomic/Molecular Reactions	
Penning Dissociation	$M^* + A_2 \rightarrow 2 A + M$
Penning Ionization	$M^* + A_2 \rightarrow A_2^+ + M + e^-$
Charge Transfer	$A^\pm + B \rightarrow B^\pm + A$
Ion Recombination	$A^- + B^+ \rightarrow AB$
Neutral Recombination	$A + B + M \rightarrow AB + M$
Decomposition	
Electronic	$e^- + AB \rightarrow A + B + e^-$
Atomic	$A^* + B_2 \rightarrow AB + B$
Synthesis	
Electronic	$e^- + A \rightarrow A^* + e^-$, $A^* + B \rightarrow AB$
Atomic	$A + B \rightarrow AB$

Chapter 3

Fluid Modeling: An Insight in the Plasma Chemistry

Plasma modeling can offer the experimentalist the necessary information to understand the role of the different species in the immensity of chemical reactions taking place in the discharge gap. The aim of our research is to describe in detail the plasma chemistry in an atmospheric pressure DBD in different gas mixtures with CH_4 and/or CO_2 , by means of a 1D fluid model. More information about the fluid model applied for this research can be found in this chapter.

3.1. Motivation for Numerical Simulations

Experimental observations are the base for understanding natural phenomena. They lead to new theories and the discovery of proportionalities, which allows mathematical formulations of these theories. These descriptions can be tested and improved by additional observations up till the point where these observations become too difficult.²⁷ Obstacles for such observations are for example that the phenomenon happens too fast, or that the setup becomes too small or too large, or that the materials under study are very expensive or very dangerous, or that the phenomenon involves many different theoretical aspects at the same time, so that the link between theory and experiment is rather complicated.^{27, 42}

Modeling or simulation of a phenomenon or experiment can offer here a solution to circumvent these issues. Models are used to theoretically interpret and predict experimental observations. In physics, the word “model” is used to indicate a system of equations, data, and assumptions, which gives a mathematical representation of all the major features of a certain physical phenomenon.⁴² The equations used in the model can be solved exactly or numerically. The latter means that they have to be discretized in both space and time, so that by choosing an appropriate initial condition and by respecting the boundary conditions, the described system is recalculated again and again, so that it iteratively evolves into the desired converged solution. Both the exact and the numerical solutions of these equations have their advantages and disadvantages, but in general, numerical methods are increasingly being used, because they are able to describe enormously complex systems and they can be defined much more generally than the exact solutions.²⁷

Also in the field of gas discharges and plasma technology numerical simulations are a useful tool to describe the discharge physics or the plasma chemistry. There exist various useful theoretical descriptions to describe the physics and chemistry in the gas discharges studied in this dissertation. Different possible simulation methods for this purpose, such as an analytical approach, a kinetic approach, a fluid model or a hybrid model, as well as their advantages and disadvantages, are discussed by Martens²⁷. In order to describe the DBD plasma under study in this work, we decided to adopt a fluid model for the reasons given in next section.

3.2. The Fluid Approach

In a fluid model the various discharge species (electrons, molecules, radicals, ions) are described in terms of average, hydrodynamic quantities, such as density, momentum and energy.²⁷ The space and time variation of these quantities is described by fluid equations, which are derived by taking the velocity moments of the Boltzmann equation. The Boltzmann equation⁴³ describes the evolution of the density $f(\vec{r}, \vec{v}, t)$ of a single particle species in the phase space spanned by configuration space \vec{r} and velocity space \vec{v} . Often the Boltzmann equation is written as:

$$\frac{\partial f}{\partial t} + \vec{v} \cdot \frac{\partial f}{\partial \vec{r}} + \vec{a} \cdot \frac{\partial f}{\partial \vec{v}} = \left(\frac{\partial f}{\partial t} \right)_c \quad (1)$$

where \vec{a} is the acceleration of the particle and $(\partial f / \partial t)_c$ is the change of the distribution function f due to collisions.²⁷ More detailed information on the continuity equations for density, momentum and energy obtained from the Boltzmann equation is given below. Surface processes are accounted for in

the boundary conditions of the fluid equations. Usually the fluid equations are coupled to macroscopic Maxwell equations, such as Poisson's equation, which describes the effect of space charge on the electric field. In this way, a complete, self-consistent description of the discharge is obtained. Note that the assumptions made in this approach can only be applied over a limited range of discharge conditions. Detailed information on this can be found in Hagelaar⁴². However, for the DBD under study, the fluid approach is very useful and quite reliable. A great advantage of fluid models is that they can simulate the time evolution of a discharge in one or two spatial dimensions within a manageable period of computation time, i.e., a few hours, even for a complex plasma chemistry, as illustrated in the next chapters. On the other hand, in a fluid model each type of species is considered as one group, and therefore a fluid model cannot describe the behavior of the species individually. Furthermore, it is supposed that the plasma must have a high enough density so that it resembles a continuum.²⁷ It is assumed that the species are more or less in equilibrium with the electric field, i.e., the energy gain due to the electric field is more or less balanced by the energy loss due to collisions, which is not always the case, e.g., for energetic electrons in a plasma. In addition, a fluid model requires input data on macroscopic properties of the species, which are based on assumptions of the particle energy distribution function.⁴² Moreover it is not so easy to describe filaments in a DBD by means of a fluid model.

3.3. Plasimo's MD2D: The Fluid Model Applied

The model employed in this study is a one-dimensional fluid model, called Plasimo's MD2D.⁴⁴⁻⁴⁵ Originally, MD2D was developed to describe the behavior of microdischarges in display technology, such as plasma addressed liquid crystal (PALC) and plasma display panel (PDP) technology.^{42, 46-48} Later the model was transformed and extended by Brok and van Dijk, and incorporated into Plasimo.⁴⁹ In this way the model has previously been used for investigating the breakdown phenomena in fluorescent lamps,⁴⁹⁻⁵¹ the discharge characteristics of the plasma needle used for biomedical applications,⁵² the behavior of DBDs at low pressure⁵³ and the characteristics of DBDs used as ionization source in analytical spectrochemistry.⁵⁴⁻⁵⁶

Analogous to other fluid models used for the description of low temperature plasmas,^{43, 57-60} the MD2D fluid model is based on a set of balance equations derived from the Boltzmann transport equation (see previous section).

The first equation is the particle continuity equation, which describes the continuity of each type of species p incorporated in the model, in terms of its density n_p , flux $\vec{\Gamma}_p$ and source S_p as a function of time and space:

$$\frac{\partial n_p}{\partial t} + \vec{\nabla} \cdot \vec{\Gamma}_p = S_p \quad (2)$$

The source term S_p is obtained by considering the volume reactions in which species p are produced or lost.

The second equation is the drift-diffusion equation, which describes the flux $\vec{\Gamma}_p$ of each type of species p by means of the summation of a drift component

(only for the charged species), driven by the electric field \vec{E} , and a diffusion component, caused by the gradient of the density:

$$\vec{\Gamma}_p = \pm \mu_p \vec{E} n_p - D_p \vec{\nabla} n_p \quad (3)$$

μ_p and D_p denote here the mobility and diffusion coefficient of species p .

For the electrons also the electron energy balance equation is solved. The assumption that the energy is directly related to the local electric field is not valid for electrons, because they have a much lower mass compared with the heavy particles. Electron parameters are therefore expressed as a function of the average energy $\bar{\varepsilon}$ which results from the following balance equation:

$$\frac{\partial(n_\varepsilon)}{\partial t} + \vec{\nabla} \cdot \vec{\Gamma}_\varepsilon = S_\varepsilon \quad (4)$$

S_ε is again a source term, which depends on the heating by the electric field and on the energy gained or lost in the various reactions. n_ε is the electron energy density:

$$n_\varepsilon = n_e \bar{\varepsilon} \quad (5)$$

and $\vec{\Gamma}_\varepsilon$ denotes the electron energy flux:

$$\vec{\Gamma}_\varepsilon = \frac{5}{3} \bar{\varepsilon} \vec{\Gamma}_e + q \quad (6)$$

where q is the heat flux, which is assumed to be proportional to the gradient of the electron mean energy:

$$q = -\frac{5}{3} n_e D_e \nabla \bar{\varepsilon} \quad (7)$$

Substitution of equation (7) and equation (3) for $\vec{\Gamma}_e$ transforms equation (6) into a drift-diffusion equation for the electron energy flux:

$$\vec{\Gamma}_{\bar{\varepsilon}} = -\frac{5}{3}\mu_e\vec{E}n_e\bar{\varepsilon} - \frac{5}{3}n_eD_e\vec{\nabla}\bar{\varepsilon} \quad (8)$$

The first term is called the hydrodynamic flux of enthalpy and the second term is the heat conduction flux.

This set of partial differential equations is coupled to the Poisson equation, which delivers the electric field distribution:

$$\vec{\nabla} \cdot (\varepsilon_m \vec{\nabla} \varphi) = -\vec{\nabla} \cdot (\varepsilon_m \vec{E}) = -\sum_p q_p n_p \quad (9)$$

φ is here the electric potential as a function of time and space, ε_m is the permittivity of the medium (i.e. the plasma and the dielectrics) and q_p is the charge of species p . This Poisson equation is not only solved within the plasma, but also inside the dielectrics of the DBD plasma, where it reduces to:

$$\nabla^2 \varphi = 0 \quad (10)$$

because no charges are present inside the dielectrics.

The effect of charge accumulation on the surface of the dielectric materials is considered using Gauss's law:

$$\varepsilon_{dielectric} \vec{E}_{dielectric} \cdot \vec{u}_n - \varepsilon_{gas} \vec{E}_{gas} \cdot \vec{u}_n = \sigma \quad (11)$$

where $\vec{E}_{dielectric}$ and \vec{E}_{gas} are the electric field inside the dielectric and in the gas, respectively, \vec{u}_n is the unit vector normal to the wall, where the charge accumulation occurs. σ is the surface charge density on the dielectric, calculated from the charged particle fluxes directed to the surface.

Furthermore, at the open boundaries of the reactor, where the gas enters and leaves the reactor, homogeneous Neumann boundary conditions are employed, meaning that the derivatives of the plasma quantities in the

direction perpendicular to these boundaries are set to zero; this applies to the densities of all the active species, the electron energy density and the electric potential. At the physical boundaries, i.e., the electrodes and the dielectric, the boundary conditions for n_p and n_e are given by the expressions for the flux densities $\vec{\Gamma}_p$ and $\vec{\Gamma}_e$. These boundary conditions are determined by the reflection coefficients and the secondary electron emission coefficients of the different species included in the model. Besides, the correct electrode properties and dielectric properties are defined in the model. Detailed information about the boundary conditions used in this fluid model can be found in Mihailova et al.⁶¹.

The coupled differential equations are solved by the so-called “modified strongly implicit method”,⁶² using an extra stabilization method,⁴² until convergence is reached over the discharge cycles. The electron transport parameters and rate coefficients are not updated with each iteration, but they are updated whenever the densities of the molecules change a few percent. A more detailed description of the physics used in the model and of the numerical methods that are used is reported by Hagelaar⁴² and by Brok et al.⁴⁹.

Because the aim of our research is to determine the conversion of the inlet gases and the yields of the reaction products, calculations are carried out for a residence time up to 20 s. To limit the calculation time, the fluid model is used to follow all species as a function of time with a maximal time step in the order of 10 ns, until a periodic steady state is reached for the charged species. This takes typically 2 ms or 20 ac periods. Subsequently, the time averaged electron density, electron energy and rate coefficients of electron impact reactions are calculated and taken as a constant input for a reduced fluid

model, in which the electron energy balance equation and the Poisson equation are not solved. In this second part, the conversion of the molecules is calculated with a larger time step in the order of 100 μs . Back-coupling to the short time step calculations is carried out regularly, to update the electron energy and density and the rate coefficients of the electron impact reactions if necessary. This decoupling of the model into charged species kinetics and neutral chemistry kinetics allows to increase the calculation speed with a factor of 10^4 . Typically, the calculations carried out in this PhD work take about 2 or 3 days on today's personal computers.

3.4. The Reactor Set-Up under Study

The numerical model is applied to an atmospheric pressure cylindrical DBD (see Figure 4). The reactor consists of two coaxial electrodes. The inner electrode (stainless steel) has an outer diameter of 22 mm. The outer electrode (chrome) has a diameter of 29.3 mm and at the inside it is in contact with a dielectric tube made of alumina. The alumina tube has an inner diameter of 26 mm and a wall thickness of 1.6 mm, leading to a discharge gap of 2 mm between both cylinders, i.e., the region where the gas flows through the reactor. The outer electrode is powered, whereas the inner electrode is grounded. The background gas temperature is 300 K and assumed to be constant in time and uniform in space. This is justified, because in a DBD there is only local heating due to the discharge filaments. However, the latter only take a very small fraction of the reactor volume for several nanoseconds, with a repetition in the microseconds scale, yielding a volume-corrected filament frequency of about 0.01% per discharge period.⁶³ Thus overall, the gas heating

is very limited. Furthermore, often a water jacket is used in experiments to cool the reactor and keep the reactor temperature constant at about 300 K.^{25, 64-68} The total length of the reactor in the experiment is 120 mm. A residence time of 20 s corresponds for this set-up to a gas flow rate of about 0.05 L·min⁻¹. More detailed information on the reactor set-up under study has been reported by Paulussen et al.⁶⁸

In the model, however, only a segment of 1.5 mm long is considered. This is done to limit the calculation time and to avoid having to deal with filament formation in the reactor, as this cannot yet be simulated with the present model. On the other hand, by using 3 grid cells, instead of 1, in the axial direction, it is possible to describe the boundary conditions (see Section 3.3.) in a proper way in both the axial and the radial direction.

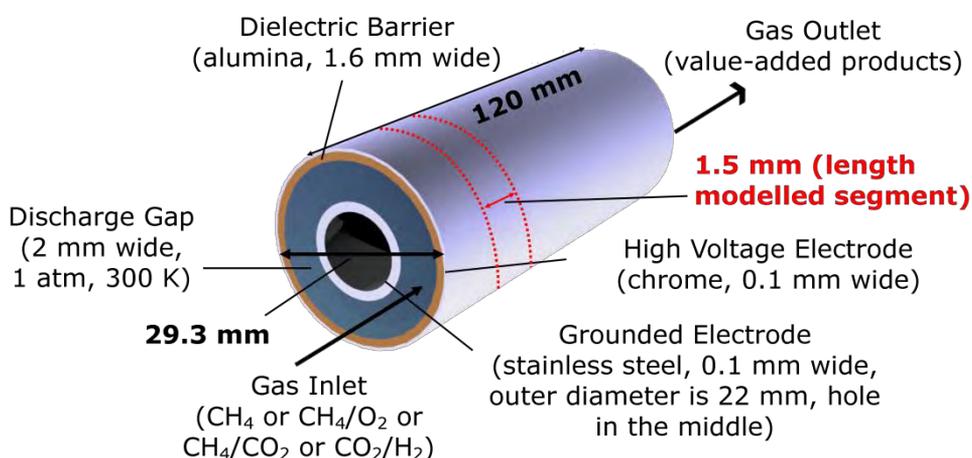


Figure 4. Schematic diagram of the reactor under study.

It needs to be realized that the effect of gas flow in the reactor is not modeled explicitly. Indeed, the real reactor can be considered as a kind of plug flow reactor, hence the concentration of the species varies as a function of the position in the reactor when the gas flows through. However, in the model this can be approximated by considering the reactor as a batch reactor, where the concentration of the species varies as a function of the residence time. Indeed, the variation of the concentrations as a function of time in a batch reactor is the same as the variation as a function of position in a plug flow reactor. In other words, the effect of gas flow is accounted for by studying the time variation of the species concentrations, where the residence time is calculated as the reactor volume divided by the gas flow rate.

3.5. Transport and Wall Interaction Coefficients

The species and reactions included in the different gas mixtures under study in this dissertation will be discussed in Chapter 4 for pure CH₄, in Chapter 5 for CH₄/O₂ and CH₄/CO₂, and in Chapter 6 for CO₂/H₂. Here we will discuss the determination of their transport coefficients for diffusion and mobility (only for the charged species), their sticking coefficients and their secondary electron emission coefficients, as this determination is generally valid for the different chapters.

The diffusion coefficient D_{ij} (m²·s⁻¹) of the neutral species j in the background gas i is obtained by the Chapman-Enskog equation:⁶⁹⁻⁷⁰

$$D_{ij} = \frac{3k_b T \sqrt{\frac{4\pi k_b T}{2m_{ij}}}}{16p\pi\sigma_{ij}^2\Omega_D(\Psi)} \quad (12)$$

where k_b is the Boltzmann constant, T is the background gas temperature (K), p is the total pressure (Pa), m_{ij} is the reduced mass (kg), σ_{ij} is the characteristic length (m) and Ω_D is the dimensionless diffusion collision integral. This collision integral, which is a function of the dimensionless temperature Ψ , is given by

$$\Omega_D = \frac{A}{\Psi^B} + \frac{C}{e^{D\Psi}} + \frac{E}{e^{F\Psi}} + \frac{G}{e^{H\Psi}} \quad (13)$$

where Ψ equals $k_b T / \varepsilon_{ij}$, $A = 1.06036$, $B = 0.15610$, $C = 0.19300$, $D = 0.47635$, $E = 1.03587$, $F = 1.52996$, $G = 1.76474$ and $H = 3.89411$.⁶⁹ σ_{ij} and ε_{ij} are calculated by

$$\sigma_{ij} = \frac{\sigma_i + \sigma_j}{2} \quad (14)$$

$$\varepsilon_{ij} = \sqrt{\varepsilon_i \varepsilon_j} \quad (15)$$

with σ (m) and ε (J) being the characteristic length and energy for every species in the 12-6 Lennard-Jones potential. These Lennard-Jones parameters were reported for most of the neutral species by Reid et al.⁶⁹ and by Svehla⁷¹ and for the other species they were obtained by linear interpolation.

Finally the diffusion coefficient D_j of the species j in the entire gas mixture, i.e., the sum of all background gases i , is obtained from the different D_{ij} -values using Blanc's law:⁷²

$$\frac{p_{tot}}{D_j} = \sum_i \frac{p_i}{D_{ij}} \quad (16)$$

with p_{tot} the total pressure and p_i the partial pressure of the background gas i .

The ion mobility $\mu_{i,j}$ ($\text{m}^2 \cdot \text{V}^{-1} \cdot \text{s}^{-1}$) of an ion j in the background gas i is calculated using the low electric field Langevin mobility expression:⁷²

$$\mu_{i,j} = 0.515 \frac{T}{p \sqrt{m_{ij} \alpha_i}} \quad (17)$$

with T again the background gas temperature (K), p the gas pressure (Pa), m_{ij} the reduced mass (amu) and α_i the polarizability (\AA^3) of the background gas, which was obtained from Böttcher et al.⁷³ Afterwards the mobility coefficient μ_j of the ion j in the entire gas mixture can be obtained in a similar way as the diffusion coefficient according to Blanc's law.

The mobility of the electrons and the rates of their collision reactions are described as parameters depending on the mean electron energy. These dependencies are calculated using the external Boltzmann solver Bolsig+,⁷⁴ which creates lookup tables for the mean electron energy, the electron mobility and the reaction rate coefficients as function of the reduced electric field. Accordingly, the electron mobility and the rate coefficients can be used as a function of the mean electron energy, which is calculated with the electron energy balance equation (see Section 3.3.).

From the ion mobility μ_j , the ion diffusion coefficient D_j of an ion j can directly be obtained using the Einstein relation, in order to remain consistent with the physical approximations used in the model:

$$D_j = \frac{k_b T_{ion}}{e} \mu_j \quad (18)$$

where k_b is again the Boltzmann constant, T_{ion} is the ion temperature (K), which is assumed to be equal to the background gas temperature, and e is the

elementary charge. The Einstein relation is also used to obtain the electron diffusion coefficient from the electron mobility.

The sticking coefficients for the different higher hydrocarbon radicals are based on reported values by Bohmeyer et al.⁷⁵ and by Eckert et al.⁷⁶ Although the reported sticking coefficients are defined for somewhat different conditions, a good indication of the trend of the coefficients can be deduced. The sticking coefficients for the oxygen containing radicals were assumed to be one. The sticking probabilities for the various molecules and the ions were assumed to be zero and one, respectively. Note that the description of the surface reactions in the model is currently limited to this rough approximation and therefore the calculated densities of the radicals and molecules might be overestimated. The calculated densities of the ions, on the other hand, might be underestimated, although this is not so likely, as sticking equal to one is quite realistic for the ions, because they are indeed mostly neutralized upon arrival at the walls. For the ions, also secondary electron emission is considered when they collide with the reactor wall. A secondary electron emission coefficient of 0.05 was assumed and a corresponding energy of 5 eV.

3.6. Definitions of Conversion, Yield and Selectivity

Besides typical plasma characteristics, such as species densities, rates of the various reactions, electron energy, etc., the model can also calculate the conversion of the inlet gases, as well as the yields and selectivities of the reaction products, which is of interest for the application of gas conversion, investigated in this PhD thesis. The definitions of the conversions X , the yields Y and the selectivities S are as follows. The definitions can be slightly different, depending on the gas or gas mixture under study. Therefore, the gases or gas mixtures to which these specific definitions apply, are given between brackets.

$$X_{CH_4/CO_2/O_2/H_2} = \frac{n_{CH_4/CO_2/O_2/H_2,converted}}{n_{CH_4/CO_2/O_2/H_2,feed}} \times 100\% \quad (19)$$

$$Y_{H_2} = \frac{n_{H_2}}{2 \times n_{CH_4,feed}} \times 100\% \quad (CH_4, CH_4/O_2, CH_4/CO_2) \quad (20)$$

$$Y_{C_xH_yO_z} = \frac{x \times C_xH_yO_z}{n_{CH_4,feed}} \times 100\% \quad (CH_4, CH_4/O_2) \quad (21)$$

$$Y_{C_xH_yO_z} = \frac{x \times C_xH_yO_z}{n_{CH_4,feed} + n_{CO_2,feed}} \times 100\% \quad (CH_4/CO_2) \quad (22)$$

$$Y_{C_xH_yO_z} = \frac{x \times C_xH_yO_z}{n_{CO_2,feed}} \times 100\% \quad (CO_2/H_2) \quad (23)$$

$$Y_{H_2O} = \frac{n_{H_2O}}{2 \times (n_{CH_4,feed} + n_{O_2,feed})} \times 100\% \quad (CH_4/O_2) \quad (24)$$

$$Y_{H_2O} = \frac{n_{H_2O}}{2 \times (n_{CH_4,feed} + n_{CO_2,feed})} \times 100\% \quad (CH_4/CO_2) \quad (25)$$

$$S_{H_2} = \frac{n_{H_2}}{2 \times n_{CH_4,converted}} \times 100\% \quad (CH_4, CH_4/O_2, CH_4/CO_2) \quad (26)$$

$$S_{C_xH_yO_z} = \frac{x \times C_xH_yO_z}{n_{CH_4,converted}} \times 100\% (CH_4, CH_4/O_2) \quad (27)$$

$$S_{C_xH_yO_z} = \frac{x \times C_xH_yO_z}{n_{CH_4,converted} + n_{CO_2,converted}} \times 100\% (CH_4/CO_2) \quad (28)$$

$$S_{C_xH_yO_z} = \frac{x \times C_xH_yO_z}{n_{CO_2,converted}} \times 100\% (CO_2/H_2) \quad (29)$$

$$S_{H_2O} = \frac{n_{H_2O}}{2 \times (n_{CH_4,converted} + n_{O_2,converted})} \times 100\% (CH_4/O_2) \quad (30)$$

$$S_{H_2O} = \frac{n_{H_2O}}{2 \times (n_{CH_4,converted} + n_{CO_2,converted})} \times 100\% (CH_4/CO_2) \quad (31)$$

In these definitions the parameter x denotes the stoichiometric balance coefficient, which corresponds also to the index in the compound name of C_xH_y or $C_xH_yO_z$. Furthermore, note that the yield and selectivity of CO are calculated with $Y_{C_xH_yO_z}$ and $S_{C_xH_yO_z}$, respectively, with $y = 0$, and that the yield and selectivity of the higher hydrocarbons (C_xH_y) are calculated with $Y_{C_xH_yO_z}$ and $S_{C_xH_yO_z}$, respectively, with $z = 0$.

3.7. Aim and Outline of the PhD Dissertation

The aim of this dissertation is to come to a better understanding of the huge plasma chemistry governing gas conversion processes in a DBD using numerical simulations. More specifically, the goal is to develop a reliable chemistry set for the description of the gas phase chemistry in pure CH₄, CH₄/O₂, CH₄/CO₂ and CO₂/H₂ gas discharges by 1D fluid modeling. In this way, calculation results can be obtained on the densities of the different plasma species, the conversions of the inlet gases, the yields and selectivities of the end products and the dominant reaction pathways for each of the gas mixtures studied. This allows us to determine whether or not a specific gas mixture is suitable for the production of a specific end-product of interest. Our calculation results are validated with reported results in literature and for pure CH₄ also with some experiments for the reactor set-up under study. Based on these results, we hope to clarify whether a sustainable competitive industrial process for gas conversion in a DBD can be developed in the future.

In the next chapters, the construction of the chemistry sets, as well as the obtained results for the different gas mixtures studied, are described. In **Chapter 4**, the fluid model is applied to describe the conversion of pure CH₄ into higher hydrocarbons. **Chapter 5** concerns the fluid modeling of the gas phase chemistry for partial oxidation (CH₄/O₂) and for dry reforming (CH₄/CO₂) of methane, focusing on the formation of oxygenates and syngas. In **Chapter 6**, the aim is to investigate the potential of the hydrogenation of carbon dioxide (CO₂/H₂) in a DBD using a fluid model.

Finally, in **Chapter 7**, a general conclusion is given, as well as an outlook for the future.

Chapter 4

The Conversion of CH₄ into Higher Hydrocarbons

The fluid model described in previous chapter is applied here to the conversion process of methane into higher hydrocarbons. The spatially averaged densities of the various plasma species as a function of time are discussed. Besides, the conversion of methane and the yields of the reaction products as a function of the residence time in the reactor are shown and compared with experimental data. Higher hydrocarbons (C₂H_y and C₃H_y) and hydrogen gas are typically found to be important reaction products. Furthermore, the main underlying reaction pathways are determined.

This chapter has been published as De Bie, C.; Verheyde, B.; Martens, T.; van Dijk, J.; Paulussen, S.; Bogaerts, A. Fluid Modeling of the Conversion of Methane into Higher Hydrocarbons in an Atmospheric Pressure Dielectric Barrier Discharge. *Plasma Process. Polym.* 2011, 8, 1033-1058.

4.1. Introduction

As discussed in Chapter 1, a sustainable process for the conversion of the abundant methane reserves into more value-added chemicals and fuels is renowned as a challenge for the 21st century. More in particular, the development of a process for the direct synthesis of higher hydrocarbons and oxygenates from methane in an energy-efficient way would offer significant benefits, because this will circumvent the very expensive syngas step. In this chapter the plasma chemistry governing the conversion of pure CH₄ into higher hydrocarbons (C_xH_y) is discussed.

Experimental results on the conversion in a pure methane plasma found in literature show that the typical end products are H₂ and higher hydrocarbons, mostly C₂H₆ and in a lower content C₃H₈, C₂H₄ and C₂H₂.^{13, 77-80} Modeling results on gas phase physics and chemistry in different kinds of methane containing discharges have been investigated extensively during the past thirty years.^{20, 81-109} A minority of them concerns the modeling of the plasma as a gas conversion reactor in pure CH₄.^{92, 103} Up to now, these numerical studies mostly concerned zero-dimensional simulations largely based on specific empirical input so that semi-empirical simulations were obtained, which are only valid for the experimental set-up under study. Only Yang⁹² used a more generic method to describe the gas conversion in a pure methane plasma, which can be generally used for this kind of gas discharges. In this paper again a 0D model was used, the plasma chemistry presented was limited and the presented results were rather preliminary.

In order to achieve our goal, i.e., to describe in detail the plasma chemistry in an atmospheric pressure DBD in different gas mixtures with CH₄ and/or CO₂,

we started by developing a 1D fluid model for an atmospheric pressure DBD in pure methane. In this chapter we present our most important results on the conversion of CH₄ into higher hydrocarbons. First of all, the spatially averaged densities of the various plasma species as a function of time will be discussed. Furthermore, the conversion of CH₄, and the yields and selectivities of the reaction products will be shown. Finally, the main underlying reaction pathways for the conversion of CH₄ into higher hydrocarbons will be pointed out.

4.2. Species Included in the Model

In order to describe the chemistry in a pure methane plasma, 36 different species (electrons, molecules, ions and radicals) are taken into account in the model. The selection of species is based on other modeling studies for methane discharges under various conditions.^{70, 81, 110} In addition to the feed gas CH₄, also H₂ and some higher order neutral molecules C₂H₆, C₂H₄, C₂H₂, C₂, C₃H₈ and C₃H₆ are considered in the model, as it was shown in literature that they are formed in the plasma at high densities.^{78, 80} High densities of C₂H₂ in the discharge may lead to polymerization and in order to deal with this, in a first attempt the polymerization product C₄H₂ is also included in the model. Furthermore, 11 radical species and 16 ionic species are taken into account corresponding to the products of dissociation and ionization reactions, respectively, of these high density molecules.

A methane plasma has a very strong electropositive character.⁷⁰ The negative ion densities are about one order of magnitude lower than the electron and the positive ion densities⁸²⁻⁸³ and therefore, negative ions are

not incorporated in the model. Although some vibrational excitation reactions are included in the model, vibrationally excited species are not taken into account separately in order to limit the number of species and reactions, and because vibrationally excited species are considered to be of minor importance in a DBD.¹¹¹⁻¹¹² Also rotationally and electronically excited species are not taken into account in the model. Indeed, the electron energy required for rotational excitations is negligible compared with this for vibrational excitations,^{70, 110} and all electronically excited states of methane lead to dissociation.¹¹³ Therefore, it is also assumed here that the electronically excited states for the higher order neutrals lead to dissociation. An overview of the different species taken into account in the model can be found in Table 4.

Table 4. Overview of the species included in the model, besides the electrons.

Molecules	Ions	Radicals
CH ₄	CH ₅ ⁺ , CH ₄ ⁺ , CH ₃ ⁺ , CH ₂ ⁺ , CH ⁺ , C ⁺	CH ₃ , CH ₂ , CH, C
C ₂ H ₆ , C ₂ H ₄ , C ₂ H ₂ , C ₂ , C ₃ H ₈ , C ₃ H ₆	C ₂ H ₆ ⁺ , C ₂ H ₅ ⁺ , C ₂ H ₄ ⁺ , C ₂ H ₃ ⁺ , C ₂ H ₂ ⁺ , C ₂ H ⁺ , C ₂ ⁺	C ₂ H ₅ , C ₂ H ₃ , C ₂ H, C ₃ H ₇ , C ₃ H ₅
H ₂	H ₃ ⁺ , H ₂ ⁺ , H ⁺	H
C ₄ H ₂		

4.3. Reactions Included in the Model

A consistent set of 367 gas phase reactions involving the 36 defined species was built to describe the plasma chemistry in the discharge gap. These gas phase reactions can be divided into four groups: 100 electron-neutral, 35 electron-ion, 92 neutral-neutral and 140 ion-neutral reactions. The electron-

neutral reactions include 6 momentum transfer, 15 vibrational excitation, 47 ionization and 32 dissociation reactions. The electron-ion reactions are all dissociative recombination reactions, because volume recombination is an important process at atmospheric pressure, which is logical because of the high densities. An overview of the reactions considered in the model is given in the Appendices.

The rates of the different reactions are calculated in the model from the densities of the colliding species and the corresponding reaction rate coefficients. For the electron-neutral and electron-ion reactions, an energy dependent reaction rate coefficient is used. The Boltzmann solver Bolsig+⁷⁴ (see previous chapter) is used to create the lookup tables for the rate coefficients of the electron-neutral reactions based on the energy dependent collision cross sections for these reactions. The references for the cross sections can be found in Table A.1. of the Appendices. The lookup tables for the electron-ion dissociative recombination reactions are built using the functions in combination with the branching ratios for the different channels of which a detailed overview is given in Table A.2. of the Appendices. The neutral-neutral and ion-neutral reactions are defined in the model with a constant reaction rate coefficient, for a fixed pressure and temperature of 1 atm and 300 K, respectively. The constant rate coefficients and the corresponding references for the neutral-neutral and ion-neutral reactions are summarized in Table A.3. and Table A.4. of the Appendices, respectively. Note that the rate coefficient of the recombination reaction of CH₃ with C₂H₅ resulting in the formation of C₃H₈ was estimated based on the matching between experimental results and our calculation results. The values reported in literature for this reaction are either too low¹¹⁴ (i.e., $5.60 \times 10^{-11} \text{ cm}^3 \cdot \text{s}^{-1}$,

which is equal to $2.29 \times 10^{-30} \text{ cm}^6 \cdot \text{s}^{-1}$ as adjusted for a three-body collision by dividing by the density of the background gas) or too high¹¹⁵ (i.e., $1.87 \times 10^{-23} \text{ cm}^6 \cdot \text{s}^{-1}$). Therefore, a rate coefficient of $1 \times 10^{-28} \text{ cm}^6 \cdot \text{s}^{-1}$ is assumed in the model.

4.4. Operating Conditions

The calculations are carried out at a fixed applied voltage of 6 kV and a frequency of 10 kHz, which are typical operating conditions applied in the experiments.⁶⁸ Experiments are performed for this DBD set-up to validate the calculated results. The analysis of the reaction product mixture is done by gas chromatography. A Trace GC from Thermo is equipped with two analysis channels. A first channel contains a thermal conductivity detector (TCD) to analyze the outcome of two serial installed packed columns: a Hayesep Q (80-100, 2m*1/8" Siltek) and a Molsieve 5A (80-100, 3m*1/8"). The second channel has a flame ionization detector (FID) installed after a RTX-1 capillary column (5 μ , 25m*0.53mm).

4.5. Results and Discussion

4.5.1. Densities of the Plasma Species

Figure 5 illustrates the calculated periodic behavior of the spatially averaged electron density on a linear (a) and on a logarithmic (b) scale as a function of time, for four periods of the applied voltage. The applied voltage as a function of time is also plotted. It is clear that multiple breakdowns in the gas appear each half period following the applied voltage. The difference in the electron

density behavior for the positive and the negative polarity of the applied voltage is due to the dissimilarity in surface dimensions and properties of the inner and outer electrode (only one of the electrodes is covered by a dielectric, see Figure 4). The overall spatially and time averaged electron density amounts to 10^{17} m^{-3} . The overall spatially and time averaged electron energy was calculated to be about 2 eV.

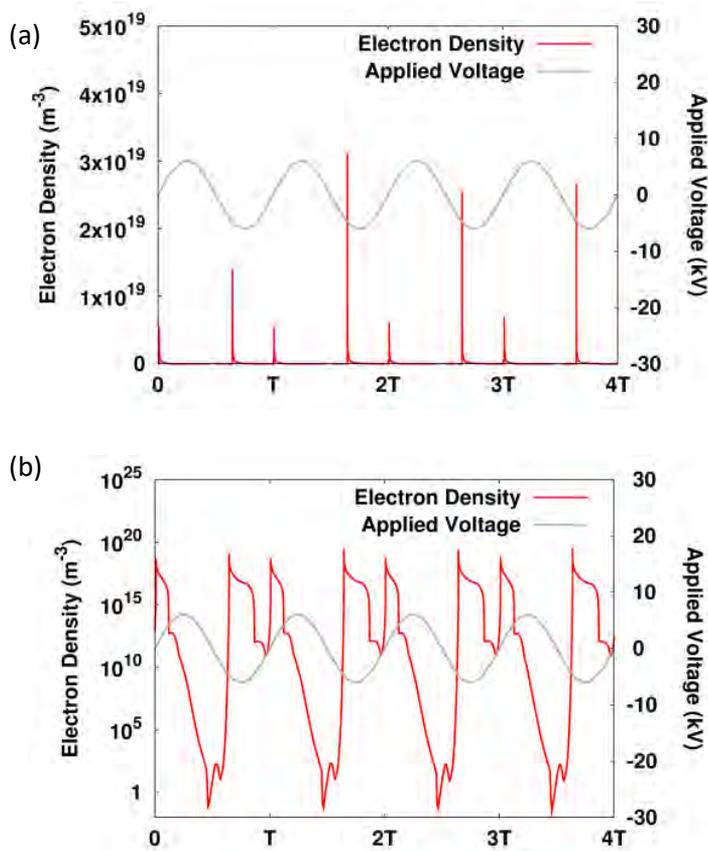


Figure 5. Spatially averaged electron density, on a linear (a) and a logarithmic (b) scale, as a function of time, as well as the applied voltage for four periods of time.

Note that the present model cannot deal with filament formation in the reactor. Therefore, the presented electric behavior corresponds to a DBD treated as a homogeneous glow discharge. Of course, this behavior is quite different from the experimental behavior, but we believe that the rest of our calculation results, such as conversion and yields, and the reaction pathways, are still valid.

The spatial variation of the electron density, total ion density and electron energy, taken at the maximum of its time profile, is depicted in Figure 6. It is clear that in the bulk plasma, the electron and ion densities are in the order of 10^{18} m^{-3} , and they are more or less equal to each other, providing charge neutrality in the bulk. However, close to the electrodes, the electron density drops to zero, and the total positive ion density is several orders of magnitude higher than the electron density, providing a net positive space charge. This behavior is typical for the sheath formation in a DBD.¹¹⁶ A different behavior is observed in the pre-sheath near the inner (grounded) electrode, where the ion density drops one order of magnitude, while near the dielectric barrier at the outer (powered) electrode, the ion density rises one order of magnitude. This different behavior is attributed to the fact that at this particular moment in time the powered electrode (covered by the dielectric barrier) is the cathode, which attracts the ions, while the grounded electrode is the anode, which repels the ions. Due to the acceleration of the electrons in the high electric field in the sheath, these electrons have an increased energy there.

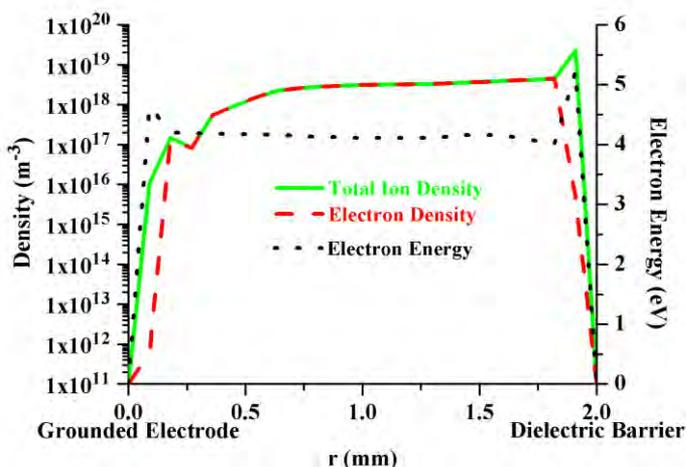


Figure 6. Calculated spatial profiles of the electron and total ion density (left axis) and electron energy (right axis) in the gap between both electrodes, taken at the maximum of their time profile. The inner (grounded) electrode is at the left, whereas the outer (powered) electrode with the dielectric layer is at the right.

Collisions of the electrons with the background gas molecules lead to the formation of radicals and ions. The number densities of these radicals and ions exhibit the same periodic behavior as the electron density. Figure 7 shows the spatially averaged radical densities as a function of time. In case of the radicals this periodic trend is superimposed on a rising or declining trend which acts over a longer time-scale until periodic steady state is reached. The variation through a period, i.e. the difference between the minimum and maximum value in one period, varies from less than one order of magnitude for C₂H₅, C₂H₃, C₃H₇, C₃H₅ and H, to several orders of magnitude for CH₃, CH₂, CH, C and C₂H. This can be explained by the fact that, except for C₂H, this last group of radicals is directly formed from the background gas CH₄ by electron impact dissociation, which is not the case for the higher order radicals. The overall spatially and time averaged radical densities vary from about 10¹² m⁻³

for the less abundant radicals to about 10^{20} m^{-3} for the most abundant radicals. The most abundant radicals are H, CH₃, CH₂, C₂H₅ and C₂H₃. The overall spatially and time averaged ion densities vary from almost zero to the order of 10^{16} m^{-3} for the most important ions (CH₅⁺, C₂H₅⁺, C₂H₄⁺, C₂H₃⁺).

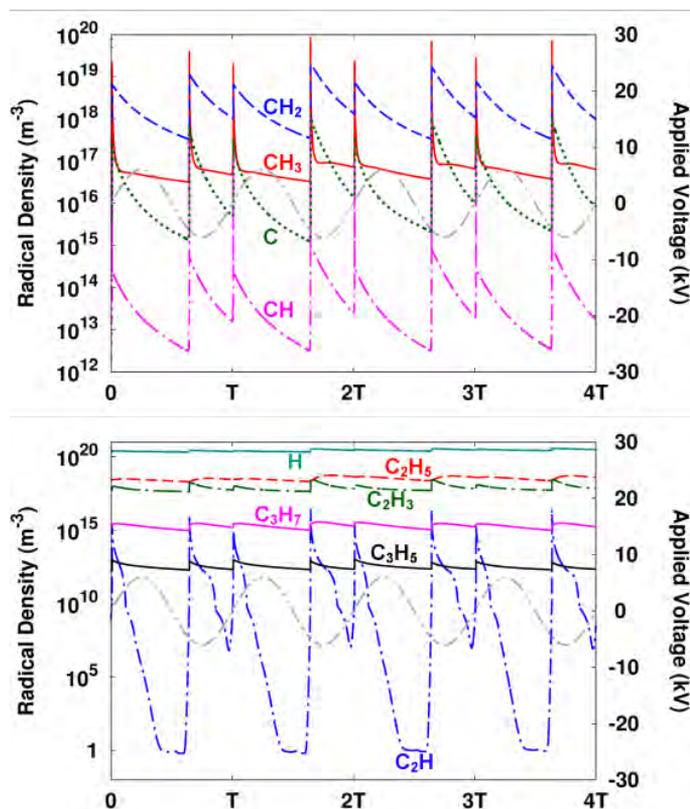


Figure 7. Spatially averaged radical densities as a function of time, as well as the applied voltage for four periods of time.

Recombination of the radicals leads to the formation of higher order hydrocarbons and hydrogen gas. The spatially averaged densities of these molecules do not exhibit this periodic behavior. Indeed, their densities behave more or less independent from the applied voltage, since they are only indirectly correlated with the electron density and electron energy by the

densities of the radicals from which they are formed (see discussion about the reaction pathways in Section 4.5.3.). The net production of these higher hydrocarbon molecules and hydrogen gas is higher than their net consumption, and as result a gradual increase in the densities is observed each half period of the applied voltage. In contrast, the net consumption of CH₄ is higher than its net production, and therefore a gradual decrease in the CH₄ density is observed each half period. Therefore, it is more interesting to look to the variation of the molecule densities on a longer time-scale.

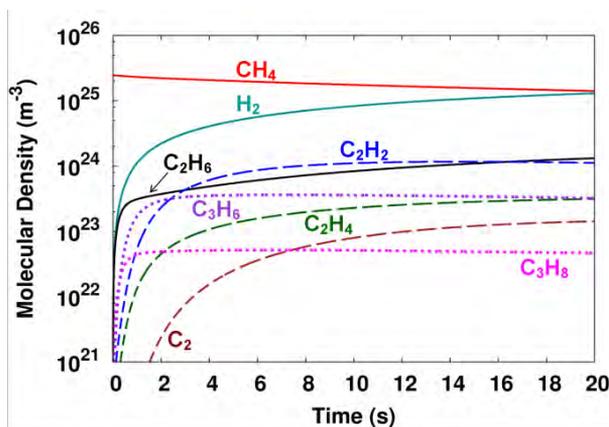


Figure 8. Spatially averaged molecular densities as a function of the residence time.

Figure 8 illustrates the spatially averaged molecule densities as a function of the residence time in the plasma reactor. Note that a residence time of 20 s corresponds to a gas flow rate of 0.05 L·min⁻¹ for the experimental set-up under study. The density of the background gas methane is initially 2.45×10^{25} m⁻³, but is decreasing due to dissociation and ionization reactions governing the conversion process. As a result, H₂, C₂H₆, C₂H₄, C₂H₂, C₂, C₃H₈ and C₃H₆ are formed and are also present in the discharge at high densities, as shown in Figure 8. It appears that the production is most pronounced in the first 1 to 2 s

and that the densities of the higher hydrocarbons and H₂ molecules do not significantly change anymore for a longer residence time. However, the logarithmic scale is a bit misleading and the conversion still continues, as will be illustrated in Section 4.5.2. below. The spatially averaged densities vary between 10^{22} m^{-3} and 10^{25} m^{-3} for the different molecules. H₂ seems to be formed at the highest density, and after 20 s, its density is comparable to the CH₄ density. As far as the higher hydrocarbon species are concerned, it appears from Figure 8 that C₂H₆ and C₂H₂ are formed with the highest density, which is only about one order of magnitude lower than the CH₄ density after 20 s. As a result of the polymerization of C₂H₂, also C₄H₂ is formed with a density of 10^{24} m^{-3} . At first sight, this density seems rather high. This can be explained by the fact that C₄H₂ is considered in the model as the sum of all higher polymerized species. Moreover, in the model no loss mechanism for C₄H₂ is included and the sticking probability of C₄H₂ is defined zero, as for the other molecules (see Section 3.5. above).

4.5.2. Conversion, Yields and Selectivities

Figure 9(a) illustrates the calculated conversion of CH₄ and the yields of the reaction products, i.e., H₂ and the summation over all C₂H_y and C₃H_y hydrocarbons, as a function of residence time in the reactor (solid lines). The measured conversion and yields of these products, for similar operating conditions, are depicted with dashed lines.

As expected, both the conversion and the various yields increase as a function of residence time. After 20 s, only 40% of CH₄ is converted and the H₂ and C₂H_y molecules are formed with the highest yields. Reasonable

agreement is reached between calculated and experimental results, taking into account the complexity of the plasma chemistry. The calculated and measured CH₄ conversion and C₃H_y yield agree within 5 %. However, the differences are significant for the H₂ yield and the C₂H_y yield, although they show at least similar trends between calculated and experimental values. A possible explanation for these significant differences is given below when the selectivities of H₂ and C₂H₂ are discussed. The calculated and measured carbon and hydrogen balances are plotted in Figure 9(b), and show an agreement within 20 %. A possible explanation for the differences between the calculated and the measured balances is the uncertainty of the used sticking coefficients. The carbon balance drops slightly as a function of residence time, due to sticking at the walls in the form of solid carbon. After a residence time of 20 s, roughly 20% of the carbon atoms is left in the reactor.

In Figure 9(c) the calculated (solid lines) and measured (dashed lines) selectivities of the individual reaction products are plotted as a function of the conversion of CH₄. From the higher hydrocarbons, C₂H₆ (dark blue) has the highest selectivity, both in the calculated and the measured results. The selectivity is especially high (100% in the calculations) at very low conversion of CH₄. This is because when the discharge is ignited, electron impact dissociation of CH₄ leads to the formation of H₂ and CH₃. This methyl radical will immediately initiate the recombination reactions towards C₂H₆, which in turn is converted later in new radicals and the other higher hydrocarbons. A more thorough discussion on the dominant reaction pathways can be found in the next section. However, this very low conversion is not interesting from an applications point of view. The typical selectivity, in the range of 10-40% CH₄ conversion, is around 20-30%.

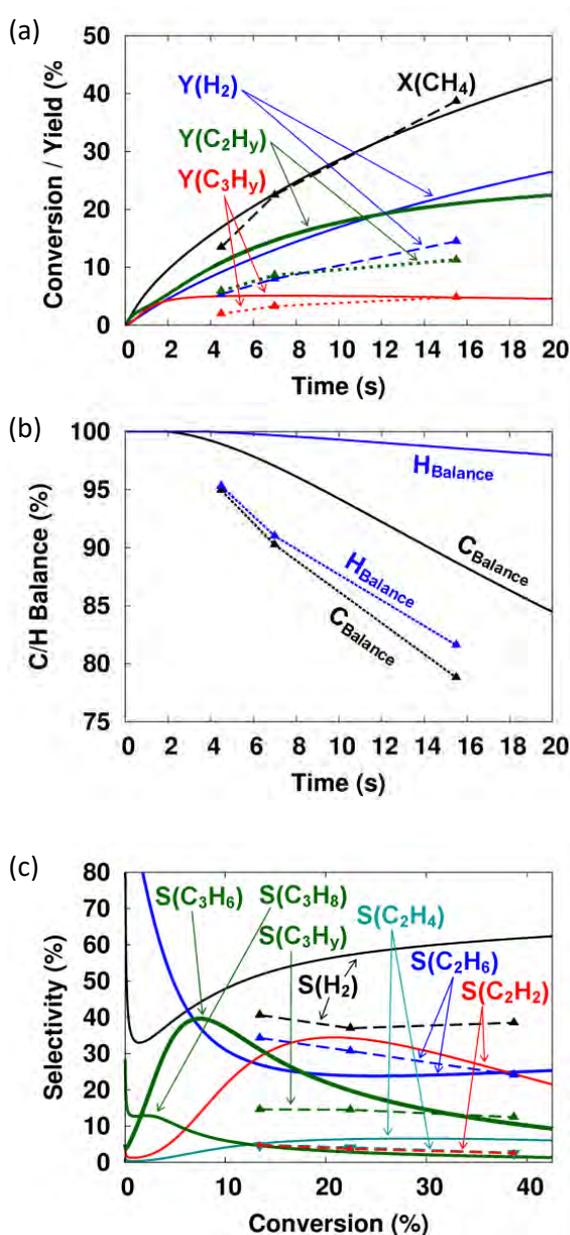


Figure 9. (a) Calculated (solid lines) and experimental (dashed lines) conversion of CH_4 and yields of the reaction products, as a function of residence time in the reactor. In (b) the calculated (solid lines) and measured (dashed lines) carbon-balances and hydrogen-balances are illustrated. In (c) the calculated (solid lines) and experimental (dashed lines) selectivities of the individual hydrocarbon reaction products are plotted as a function of the conversion of CH_4 . Note that the selectivity of C_3H_6 could not be measured.

The experimental results show that C₂H₄ (dark cyan, dashed) and C₂H₂ (red, dashed) have a much lower selectivity than C₂H₆. The calculated selectivity of C₂H₄ (dark cyan, solid) is in good agreement with the experiment (i.e., in the order of 5-10%), but the calculated selectivity of C₂H₂ (red, solid) is too high compared to the experimental results. A possible reason might be that the further polymerization of C₂H₂ molecules into higher molecules is underestimated in the model. Indeed, dust formation appears to be important in acetylene plasmas. In previous models by our group,¹¹⁷⁻¹¹⁹ these polymerization reactions were studied in detail by an extensive chemistry set, including neutral, positive and negative ion pathways. However, in the present model, the polymerization is only treated by one chemical reaction (i.e., C₂H insertion; see Section 4.5.3. below), in order not to further complicate our plasma chemistry set, which is already huge. Therefore, the obvious overestimated C₂H₂ selectivity in our model is probably attributed to the underestimation of C₂H₂ polymerization. Moreover, the overestimated C₂H₂ formation explains why the calculated yield of the overall C₂H_y fraction is higher than the measured values (Figure 9(a)).

The calculated and measured yields of the summation over all C₃H_y molecules are in an almost perfect agreement (Figure 9(a)). The sum of the calculated selectivities of C₃H₈ (dark green, solid) and C₃H₆ (light green, solid) is in reasonable agreement with the total measured selectivity of C₃H_y (green, dashed). However, it is not possible to compare the calculated selectivities of the different compounds, as the measured peaks of the different C₃H_y molecules overlap in the chromatogram.

Besides the higher hydrocarbons, H₂ is also formed as a main end product in the discharge. The calculated yields and selectivities of H₂ are a bit higher than

the measured values. This is probably because the production of H₂ by electron impact dissociation of C₂H₆ and C₃H₈ (see next section for the most important consumption and production pathways of H₂) is assumed a bit too high in the model.

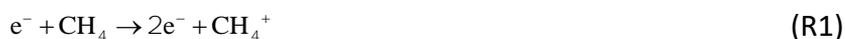
As mentioned above, the formation of C₄H₂ by polymerization reactions of C₂H₂ species is also included in the model. However, as C₄H₂ could not be measured in the experiments, it is treated as a loss of carbon in the model, in order to match the calculated and measured carbon balances. The calculated yield of C₄H₂ after 20s amounts to 13.75 %.

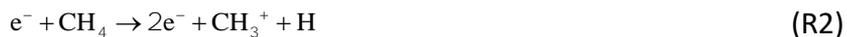
Reported results in literature based on experiments on the conversion of methane into higher hydrocarbons, at similar conditions, show similar trends, namely the end products were mainly H₂ and C₂H_y (mostly C₂H₆) as well as, to a lower extent, some higher hydrocarbons (C₃H_y, C₄H_y, ...).^{13, 78, 80}

4.5.3. Dominant Reaction Pathways

(a) Electron impact reactions with CH₄: the formation of radicals and ions

As soon as the sinusoidal voltage is applied to the reactor and the discharge is ignited, electron impact ionization and dissociation of CH₄ occurs, and this results in the consumption of CH₄ and the creation of new species (electrons, ions, radicals). The formation of new electrons and ions in the plasma is important in order to sustain the discharge. The most important channels for electron impact ionization of CH₄ are:



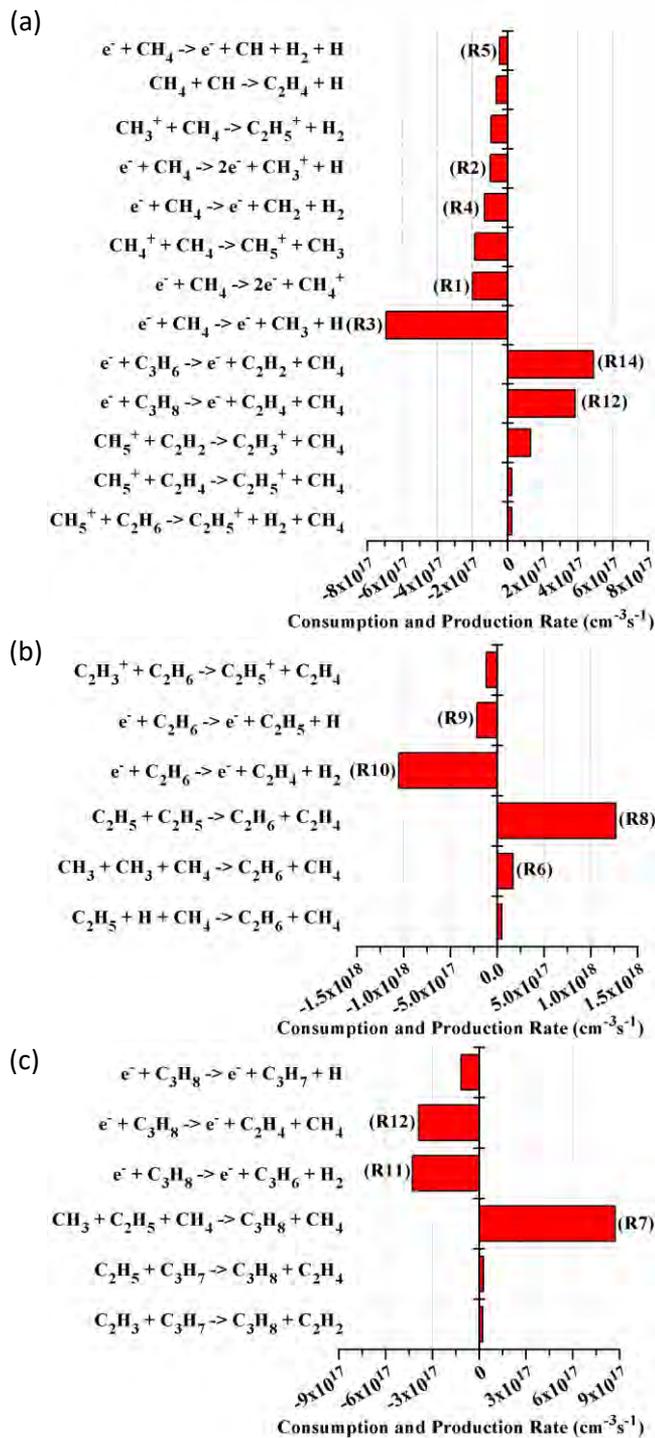


Our calculations point out that reaction (R1) is responsible for 66% of the total electron impact ionization of CH₄, while reaction (R2) is responsible for 33%, which is in good agreement with the results reported by Yang.⁹²

The dissociation of CH₄ leads to the formation of radicals. It is of special interest when studying the gas conversion process, because these radicals are important reagents in the production of higher order hydrocarbons. The most important channels for consumption of CH₄ are electron impact dissociation reactions, more specifically:



Our calculations point out that reaction (R3) is responsible for 79% of the total electron impact dissociation of CH₄, while reactions (R4) and (R5) are responsible for 15% and 5%, respectively. Similar results were reported by Yang.⁹²



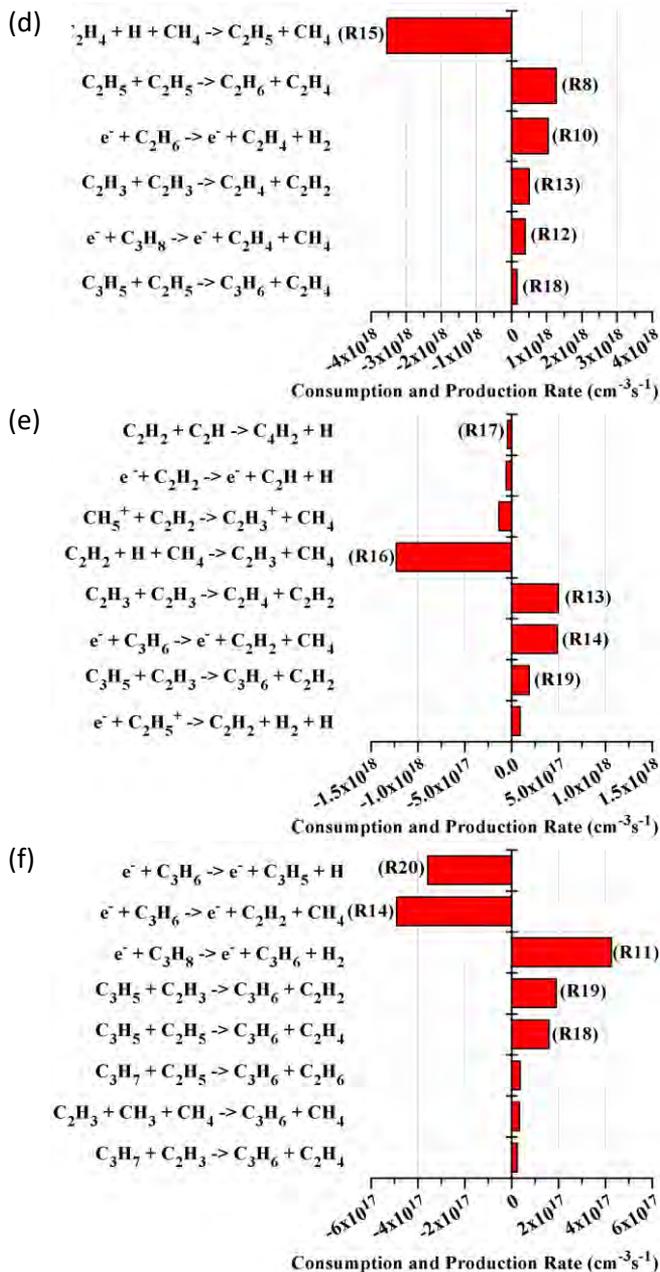


Figure 10. Calculated time-averaged reaction rates of the dominant reaction pathways for the production and consumption of CH₄ (a), C₂H₆ (b), C₃H₈ (c), C₂H₄ (d), C₂H₂ (e) and C₃H₆ (f). The production rates are plotted as positive values (i.e., right-hand side of the figures), whereas the consumption rates are defined as negative values (i.e., left-hand side of the figures). The most important pathways are labeled, and the labels correspond to the reactions given in the text.

The dominant reactions for CH₄ consumption (and production) are depicted in Figure 10(a). It is clear that the electron impact dissociation reaction to CH₃ (i.e., reaction (R3)) is by far the dominant consumption process of CH₄, followed by electron impact ionization to CH₄⁺ (i.e., reaction (R1)). Besides the electron impact ionization and dissociation reactions, also some neutral-neutral and ion-neutral reactions are important for the consumption of CH₄ (see Figure 10(a)).

Note that electron impact vibrational excitation of CH₄ is also an important process. However, in the model these vibrational excitation reactions are only considered as an energy loss for the electrons (i.e., the vibrationally excited species are not taken into account separately) and therefore these reactions are not included in Figure 10(a) since they neither entail consumption or production of CH₄. In literature it is reported that a similar result is obtained whether the vibrationally excited species are taken into account or not, because in that case the electron impact excitation to CH₄^{*} is balanced by the de-excitation of CH₄^{*} on the reactor wall.⁹²

It can also be deduced from Figure 10(a) that the most important pathways for the regeneration of CH₄ are based on electron impact dissociation of higher hydrocarbons, such as C₃H₆ and C₃H₈ (see below).

(b) The recombination of CH₃: the formation and loss of C₂H₆ and C₃H₈

The most important radical produced out of CH₄ is CH₃, which is mainly formed by reaction (R3) above. This radical will initiate the recombination reactions towards higher hydrocarbons such as C₂H₆ and especially C₃H₈:



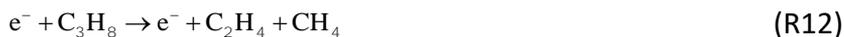
The most important pathways for the production and consumption of ethane (C₂H₆) and propane (C₃H₈) are illustrated in Figures 10(b) and 10(c), respectively. It is clear that reaction (R7) is the dominant production process for C₃H₈ (see Figure 10(c)), but reaction (R6) is only responsible for about 11% of the C₂H₆ production. Indeed, as is apparent from Figure 10(b), C₂H₆ is mainly (83%) formed by the recombination of two C₂H₅ radicals:



This results from the fact that the overall averaged density of C₂H₅ ($7 \times 10^{20} \text{ m}^{-3}$) is three orders of magnitude higher than the CH₃ density, while the rate coefficient of reaction (R6) (i.e., $1.56 \times 10^{-38} \text{ m}^6 \text{ s}^{-1}$, or $3.82 \times 10^{-13} \text{ m}^3 \text{ s}^{-1}$ for a CH₄ gas density of $2.446 \times 10^{25} \text{ m}^{-3}$) is five orders of magnitude higher than the rate coefficient of reaction (R8) (i.e., $2.41 \times 10^{-18} \text{ m}^3 \text{ s}^{-1}$). Taking into account that the rates of both reactions depend on the square of the concentrations of CH₃ and C₂H₅, respectively, it is clear that the rate of reaction (R8) is almost one order of magnitude higher than the rate of reaction (R6).

Electron impact dissociation reactions are the most important loss processes for both C₂H₆ and C₃H₈, leading to the formation of C₂H₄, C₂H₅ and C₃H₆:





Especially reaction (R10) is important as loss process for C₂H₆ (see Figure 10(b)), whereas both reactions (R11) and (R12) contribute nearly equally to the loss of C₃H₈ (see Figure 10(c)).

(c) The formation and loss of higher order unsaturated hydrocarbons: C₂H₄, C₂H₂ and C₃H₆

The most important pathways for the production and consumption of C₂H₄, C₂H₂ and C₃H₆ are plotted in Figures 10(d), 10(e) and 10(f), respectively. The production of C₂H₄ occurs mainly by the recombination of two C₂H₅ radicals (i.e., reaction (R8) above) and by electron impact dissociation of C₂H₆ (i.e., reaction (R10) above). Also electron impact dissociation of C₃H₈ (i.e., reaction (R12) above) and the recombination of two C₂H₃ radicals (reaction (R13)) contribute to some extent:



The latter reaction, as well as the electron impact dissociation of C₃H₆, are mainly responsible for the production of C₂H₂:



Hydrogen attachment reactions are the most important loss processes for both C₂H₄ and C₂H₂, leading to the formation of C₂H₅ and C₂H₃ radicals, respectively:





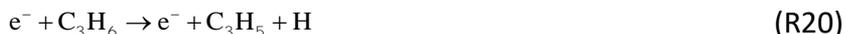
Note in Figure 10(e) also the occurrence of the polymerization reaction of C₂H₂ resulting in the formation of C₄H₂:



Finally, the production of C₃H₆ occurs mainly by electron impact dissociation of C₃H₈ (i.e., reaction (R11) above) and to a lower extent also by the recombination of C₃H₅ radicals with either C₂H₅ or C₂H₃:



The loss of C₃H₆ is mainly attributed to electron impact dissociation reactions, leading to the formation of either C₂H₂ (reaction (R14) above) or C₃H₅:



(d) The role of C₂H₅: an important radical in the conversion process

Our calculations predict that C₂H₅ is present in the discharge at rather high density (see Figure 7), and it plays a significant role in the production and loss of the various hydrocarbon molecules. Therefore, the most important pathways for the production and consumption of this radical are illustrated in Figure 11. C₂H₅ is mainly (94%) formed by hydrogen attachment to C₂H₄ (reaction (R15)) and to a lower extent (6%) also by electron impact dissociation of C₂H₆ (reaction (R9)). The loss of C₂H₅ is mainly attributed to

radical recombination by reactions (R8), (R7) and (R18), which contribute for 51%, 35% and 6%, respectively. As these reactions result in the formation of C₂H₄, C₂H₆, C₃H₆ and C₃H₈, this means that the equilibrium established between C₂H₄, C₂H₅, and C₂H₆, which relies on the accuracy of the rate coefficients considered, plays a crucial role.

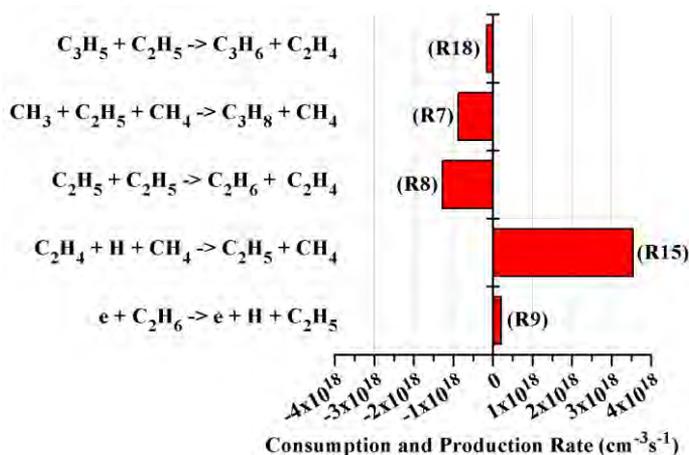


Figure 11. The dominant reaction pathways for the production and consumption of C₂H₅. The time-averaged production rates are plotted as positive values (i.e., right-hand side of the figure), whereas the time-averaged consumption rates are defined as negative values (i.e., left-hand side of the figure). The most important pathways are labeled, and the labels correspond to the reactions given in the text.

(e) The formation and loss of H₂

The most important pathways for the production and consumption of H₂ are illustrated in Figure 12. H₂ is mainly used for the processing of fossil fuels, the production of ammonia and methanol, and as fuel in fuel cells. As appears from Figure 12, H₂ is mainly produced by electron impact dissociation of hydrocarbon molecules. The dissociation reaction of C₂H₆ (reaction (R10)) appears to be the dominant production mechanism, with a contribution of 56%, whereas the dissociation of C₃H₈ (reaction (R11)) and CH₄ (reaction (R4))

contribute for 23% and 7%, respectively. Electron impact dissociation is also the dominant loss process for H₂:

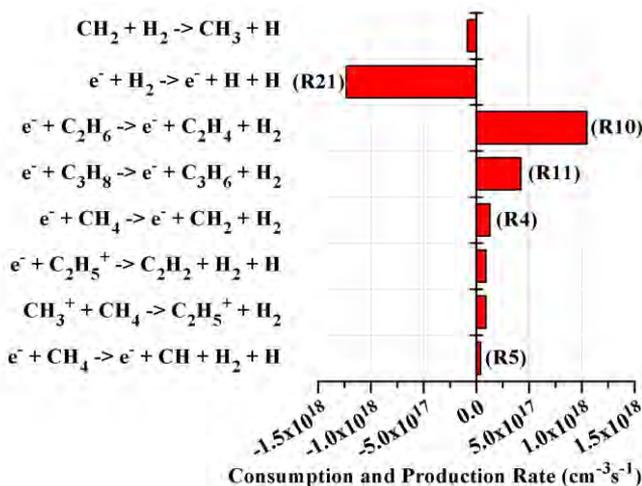


Figure 12. The dominant reaction pathways for the production and consumption of H₂. The time-averaged production rates are plotted as positive values (i.e., right-hand side of the figure), whereas the time-averaged consumption rates are defined as negative values (i.e., left-hand side of the figure). The most important pathways are labeled, and the labels correspond to the reactions given in the text.

(f) Summary of the dominant pathways governing the conversion of CH₄ into C_xH_y and H₂

Finally, Figure 13 gives a schematic overview of the dominant reaction pathways for the conversion of CH₄ into higher hydrocarbons and hydrogen gas. Electron impact dissociation of CH₄ resulting in the formation of the methyl radical (CH₃) starts the conversion process (R3). This methyl radical will initiate recombination reactions towards higher hydrocarbons such as C₂H₆ and C₃H₈ (R6, R7). Subsequently, a play of dissociation and recombination

leads to the conversion towards the other, unsaturated hydrocarbons. Finally, dissociation of CH₄ and the higher hydrocarbons also results in the formation of H₂.

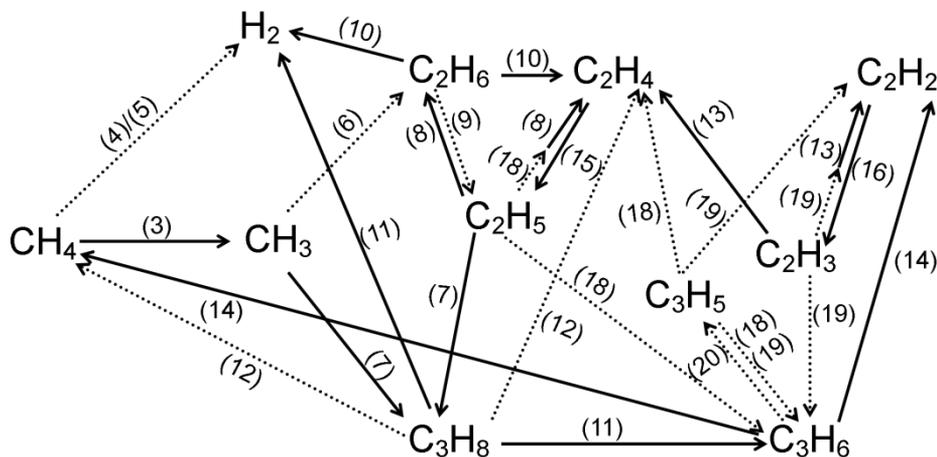


Figure 13. Schematic overview of the dominant reaction pathways for the conversion of CH₄ into higher hydrocarbons and hydrogen gas. The most important pathways are depicted with a solid line, less important channels are represented by a dashed line. The labels correspond to the reactions given in the text. Note that C₄H₂ is not mentioned as it is considered as the sum of all higher polymerized species and also no loss mechanism for it is included in the model.

4.6. Conclusion

In this chapter, a detailed plasma chemistry is presented for the conversion of CH₄ into higher hydrocarbon molecules in a DBD reactor. The densities of the various plasma species have been studied as a function of the residence time. The spatially averaged densities of the electrons, ions and radicals show a periodic behavior as a function of time, following the applied voltage. The spatially averaged densities of the molecules do not exhibit a periodic behavior. Indeed, their densities are characterized by a gradual reduction (CH₄) or increase (higher hydrocarbon molecules and H₂) each half period

following the maximum of the applied voltage, which results in a more notable decreasing or increasing trend over a longer time-scale.

The density of the background gas, methane, is decreasing due to dissociation (and ionization) reactions governing the conversion process. The calculated and measured conversions of CH₄ as a function of the residence time are illustrated. The dissociation of CH₄ leads to the formation of CH₃, which is the most important radical in the gas phase chemistry. This methyl radical will initiate the recombination reactions towards higher hydrocarbons. As a result, these molecules are also present in the discharge at high densities.

The calculated and measured yields and selectivities of these higher hydrocarbons (C₂H₆, C₂H₄, C₂H₂, C₃H₈ and C₃H₆) and of H₂ are depicted and a reasonable agreement between our calculation results and the measurements is established. C₂H₆ and H₂ are the main reaction products of the conversion of CH₄.

Furthermore, the underlying plasma chemistry of the conversion process is analyzed and the dominant reaction pathways for the consumption of CH₄ and for the production and loss of the various end products are pointed out. It is found that electron impact dissociation of CH₄ resulting in the formation of the methyl radical (CH₃) initiates the conversion process. Recombination of CH₃ with either another CH₃ radical or with a C₂H₅ radical will lead to the formation of C₂H₆ and C₃H₈. Dissociation of these higher hydrocarbons leads directly to the formation of other hydrocarbons, but also indirectly by the formation of new radicals, which can subsequently also recombine towards these higher order hydrocarbons. In other words, the conversion of CH₄ is a play of dissociation and recombination reactions leading to a diverse mixture of higher hydrocarbons.

Chapter 5

The Conversion of CH_4/O_2 and CH_4/CO_2 into Oxygenates and Syngas

The fluid model described in Chapter 3 is applied here to describe the gas phase chemistry for partial oxidation and for dry reforming of methane. The spatially averaged densities of the various plasma species are presented as a function of time and initial gas mixing ratio. Besides, the conversion of the inlet gases and the selectivities of the reaction products are calculated. Syngas, higher hydrocarbons and higher oxygenates are typically found to be important reaction products. Furthermore, the main underlying reaction pathways for the formation of syngas, methanol, formaldehyde and other higher oxygenates are determined.

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5.1. Introduction

In order to convert CH₄ into oxygenates and syngas, the presence of a co-reactant is required. This co-reactant has an important influence on the selectivities of the desired end products. Co-reactants reported in literature for the conversion of methane are oxygen^{13, 25, 64-67, 85, 99, 105-106, 120-134}, carbon dioxide^{14, 20-21, 64, 93, 107-109, 135-184}, hydrogen^{67, 185-186}, steam^{165, 168, 187}, nitrogen¹⁸⁸ and others^{104, 189-192}. When focusing on the formation of oxygenates and syngas, most research is performed on the partial oxidation with oxygen^{13, 25, 65-67, 85, 99, 105-106, 120-134} and on dry reforming (CO₂ reforming)^{14, 20-21, 93, 107-109, 135-164, 166-167, 169-184}. In this chapter a modeling study for the conversion of CH₄ in the presence of O₂ or CO₂ into higher oxygenates and syngas will be discussed.

Of course, oxygen is very effective for low temperature plasma activation of methane. However, a possible drawback is an excessive oxidation, resulting in the formation of CO₂ and a wide variety of oxygenates. Therefore, the use of CO₂ as a milder oxidant can sometimes be more preferable, depending on the desired end product(s). Moreover, with CO₂ as a co-reactant the two most important greenhouse gases are converted in the process. Current interests in CO₂ utilization include hydrogenation of CO₂ (see also Chapter 6) and the reforming of CH₄ by CO₂.

Experimental results on the conversion in CH₄/O₂^{13, 25, 65-67, 85, 99, 105-106, 120-134} and CH₄/CO₂^{14, 20-21, 93, 107-108, 135-164, 166-167, 169-170, 173-176, 180, 182-184} plasmas show that the typical end products are C_xH_y, H₂ and CO, and to a lower extent also CH₃OH, CH₂O and other higher oxygenates (acids, alcohols, aldehydes, esters, ketones, ...). The H₂/CO ratio and the yield of higher hydrocarbons and oxygenates seems to be very dependent on the CH₄/O₂ or CH₄/CO₂ feed ratio.

In most papers the focus is largely on the formation of C_xH_y and syngas. Only a few papers explicitly focus on the formation of CH₃OH, CH₂O and other higher oxygenates.^{14, 25, 64-67, 105-107, 121-122, 126-127, 129, 133-134, 137, 143, 147, 158, 162, 173, 175}

Modeling results on the plasma chemistry in CH₄/O₂ and CH₄/CO₂ mixtures reported in literature mostly originate from zero-dimensional simulations, largely based on specific empirical input, which is only valid for the experimental set-up under study.^{20, 25, 85-86, 89, 93, 99, 101, 104-107, 109} Zhou et al. used a semi-empirical kinetic model to simulate the accumulated chemical action of many microdischarges in CH₄/O₂⁸⁵ and CH₄/CO₂²⁰ gas mixtures. Besides the densities of the inlet gases and main products, the pathways for formation of methanol in CH₄/O₂ and syngas in CH₄/CO₂ were briefly discussed. Nair et al.⁹⁹, Matin et al.¹⁰¹, Agiral et al.²⁵, Goujard et al.¹⁰⁵ and Zhou et al.¹⁰⁶ used a semi-empirical kinetic model to simulate the conversion in a CH₄/O₂ non-thermal plasma. Agiral et al.²⁵ briefly discussed the mechanisms of the gas-to-liquid process governing the formation of oxygenates. Goujard et al.¹⁰⁵ performed calculations for two different temperatures and discussed the main underlying pathways for the formation of higher oxygenates at these temperatures. Kraus et al.¹⁰⁴ and Luche et al.⁸⁹ used a semi-empirical kinetic model to simulate the conversion in a CH₄/CO₂ and a CH₄/air non-thermal plasma, respectively. Goujard et al. applied a simplified global kinetic model to study the helium dilution effect on CO₂ reforming of CH₄ in a DBD.¹⁰⁷ Within our group PLASMANT, Snoeckx et al. performed a computational study ranging from the nanoseconds to seconds time-scale for the conversion of CH₄ and CO₂ into value-added chemicals in a DBD.¹⁰⁹ A zero-dimensional chemical kinetics model was applied to study the plasma chemistry in a 1:1 CH₄/CO₂ gas mixture. The calculations were first

performed for one microdischarge pulse and its afterglow. Subsequently, long time-scale simulations were carried out, corresponding to real residence times in the plasma, assuming a large number of consecutive microdischarge pulses. The conversion of CH₄ and CO₂ as well as the selectivity of the formed products were calculated and compared to experiments for a range of different powers and gas flow rates. In a follow-up paper, this model was applied to a wide range of conditions, including gas mixing ratio, gas residence time, power and frequency, to investigate which conditions give rise to the best conversion and energy efficiency.¹⁸¹ Machrafi et al. performed calculations for a 1:1 CH₄/CO₂ gas mixture¹⁰⁸ by means of a so-called 3D “Incompressible Navier-Stokes” model with strongly reduced kinetic mechanism, in order to determine the velocity fields. This model was combined with a convection-diffusion model in order to study the behavior of the inlet gases. Qualitative densities were shown, as it was not possible to have a huge kinetic precision using a 3D model. Wang et al. conducted a density functional theory (DFT) study to investigate the reaction mechanisms for the synthesis of oxygenates and higher hydrocarbons from CH₄ and CO₂ using cold plasmas.⁹⁴ The main dissociation routes of the reactants were analyzed and the formation of various products, including syngas, higher hydrocarbons and oxygenates, was discussed. Istadi et al. developed a hybrid artificial neural network-genetic algorithm to simulate and optimize a catalytic-DBD plasma reactor in a CH₄/CO₂ gas mixture.⁹⁷ The effects of the CH₄/CO₂ feed ratio, total feed flow rate, discharge voltage and reactor wall temperature on the conversion of the inlet gases and the selectivities of the main products were investigated. Recently, Janeco et al.¹⁷⁸ performed a study on the electron kinetics in He/CH₄/CO₂ mixtures, including the contribution of H₂ and CO formed in the discharge, as an initial step to model the reforming

of natural gas for syngas production in a DBD. The electron Boltzmann equation for a swarm in the hydrodynamic regime was solved in mixtures of $\text{He}/\text{CH}_4/\text{CO}_2/\text{CO}/\text{H}_2$. The method used in this work takes into account nonconservative terms and the full angular dependency of the electron velocity distribution function.

In order to achieve our goal, i.e., to describe in detail the plasma chemistry in an atmospheric pressure DBD in different CH_4/O_2 and CH_4/CO_2 gas mixtures, the 1D fluid model used to describe the plasma chemistry for an atmospheric pressure DBD in pure methane (see Chapter 4) was extended. Unlike in most of the above-cited papers, we focus in detail on the main underlying pathways governing the conversion to higher oxygenates, and moreover, we make a comparison of those pathways between a mixture with O_2 and a mixture with CO_2 .

In this chapter we present the most important results on the partial oxidation and the dry reforming of CH_4 into syngas, higher oxygenates and higher hydrocarbons. First, the spatially averaged electron and radical densities as a function of time will be illustrated. Furthermore, the densities of the reaction products for a range of different initial gas mixing ratios, as well as the conversion of the inlet gases, will be discussed. Finally, the main underlying reaction pathways for the formation of syngas, methanol and formaldehyde, which appear to be the main oxygenates produced, will be pointed out.

5.2. Species Included in the Model

The chemistry in a CH₄/O₂ and CH₄/CO₂ gas mixture is described by 75 species (electrons, molecules, ions and radicals). As mentioned above, the model for pure CH₄ (see Chapter 4) is extended. O₂ and CO₂ are included as extra feed gases. Furthermore, CO, H₂O, CH₂O, CH₃OH and some other higher oxygenates are considered in the model, as they might be formed in the plasma. Note that formic acid (HCOOH) and acetic acid (CH₃COOH), which were experimentally found, are not included in the model as the rate constants for the formation and loss processes for these molecules are not well known. Similar to the model for pure CH₄, the radical and ionic species corresponding to the formation products of dissociation, ionization and attachment reactions of the molecules are also taken into account. Although some vibrational and electronic excitation reactions are included in the model, vibrationally and electronically excited species are not taken into account separately, in order to limit the number of species and reactions (see also Chapter 4). Also rotationally excited species are not taken into account in the model. Indeed, the electron energy required for rotational excitations is negligible compared with this for vibrational excitations.^{70, 110} Table 5 presents an overview of the different species taken into account in the model.

Table 5. Overview of the species included in the model, besides the electrons.

Molecules	CH ₄ , C ₂ H ₆ , C ₂ H ₄ , C ₂ H ₂ , C ₂ , C ₃ H ₈ , C ₃ H ₆ , C ₄ H ₂ , H ₂ , O ₃ , O ₂ , CO ₂ , CO, H ₂ O, H ₂ O ₂ , CH ₂ O, CH ₃ OH, C ₂ H ₅ OH, CH ₃ CHO, CH ₂ CO, CH ₃ OOH, C ₂ H ₅ OOH
Ions	CH ₅ ⁺ , CH ₄ ⁺ , CH ₃ ⁺ , CH ₂ ⁺ , CH ⁺ , C ⁺ , C ₂ H ₆ ⁺ , C ₂ H ₅ ⁺ , C ₂ H ₄ ⁺ , C ₂ H ₃ ⁺ , C ₂ H ₂ ⁺ , C ₂ H ⁺ , C ₂ ⁺ , H ₃ ⁺ , H ₂ ⁺ , H ⁺ , O ₄ ⁺ , O ₂ ⁺ , O ⁺ , O ₄ ⁻ , O ₃ ⁻ , O ₂ ⁻ , O ⁻ , CO ₂ ⁺ , CO ⁺ , H ₃ O ⁺ , H ₂ O ⁺ , OH ⁺ , H ⁻ , OH ⁻
Radicals	CH ₃ , CH ₂ , CH, C, C ₂ H ₅ , C ₂ H ₃ , C ₂ H, C ₃ H ₇ , C ₃ H ₅ , H, O, OH, HO ₂ , CHO, CH ₂ OH, CH ₃ O, C ₂ H ₅ O, C ₂ HO, CH ₃ CO, CH ₂ CHO, CH ₃ O ₂ , C ₂ H ₅ O ₂

5.3. Reactions Included in the Model

The 75 species can interact with each other through a large number of reactions. 1019 gas phase reactions, including 157 electron-neutral, 48 electron-ion, 476 neutral-neutral and 338 ion-ion or ion-neutral reactions, are considered. An overview of the reactions is given in the Appendices.

Like in Chapter 4, the rates of the different reactions are calculated from the densities of the colliding species and the corresponding reaction rate coefficients. The electron-neutral and electron-ion reactions are again treated by energy dependent reaction rate coefficients. The rate coefficients of the electron-neutral reactions are obtained from look-up tables calculated with the Boltzmann solver Bolsig+⁷⁴, based on the energy dependent collision cross sections for these reactions. The references for the cross sections can also be found in Table A.1. of the Appendices. The lookup tables for the electron-ion dissociative recombination reactions are built using the functions in combination with the branching ratios for the different channels, of which a detailed overview is given in Table A.2. of the Appendices. The neutral-neutral and ion-neutral reactions are again defined in the model with a constant reaction rate coefficient at a pressure and temperature of 1 atm and 300 K, respectively. These rate coefficients and their corresponding references are summarized in Table A.3. and Table A.4. of the Appendices, respectively.

5.4. Operating Conditions

The calculations are carried out for a gas residence time up to 20s, at a fixed applied voltage of 5 kV and a frequency of 10 kHz. The CH₄/CO₂ molar ratio is

varied in the range of 5-80% CO₂, while the CH₄/O₂ molar ratio is varied from 10 to 30% O₂. The CH₄/CO₂ molar ratio can be varied in a much wider range than the CH₄/O₂ molar ratio, because the latter approaches the upper flammability or explosion limit when the mole fraction of CH₄ in pure O₂ reaches 61 mole%.¹⁹³

5.5. Results and Discussion

5.5.1. Densities of the Plasma Species

Figure 14 illustrates the periodic behavior as a function of time of the spatially averaged electron density for a 70/30 (a) and 90/10 (b) CH₄/O₂ gas mixture and for a 70/30 (c) and 90/10 (d) CH₄/CO₂ gas mixture, on a logarithmic scale, for four periods of the applied voltage. The applied voltage as a function of time is also plotted, for the sake of clarity. In the 70/30 CH₄/O₂ mixture, breakdown in the gas appears once each period following the applied voltage, while in the 90/10 CH₄/O₂ mixture and the 70/30 CH₄/CO₂ mixture, a breakdown appears each half period, and in the 90/10 CH₄/CO₂ mixture, even more breakdowns occur (see below). The electron density behavior is different for the positive and the negative polarity of the applied voltage, which is due to the dissimilarity in surface dimensions and properties of the inner and outer electrode (i.e., only the outer electrode is covered by a dielectric), as was also discussed in Section 4.5.1. above.

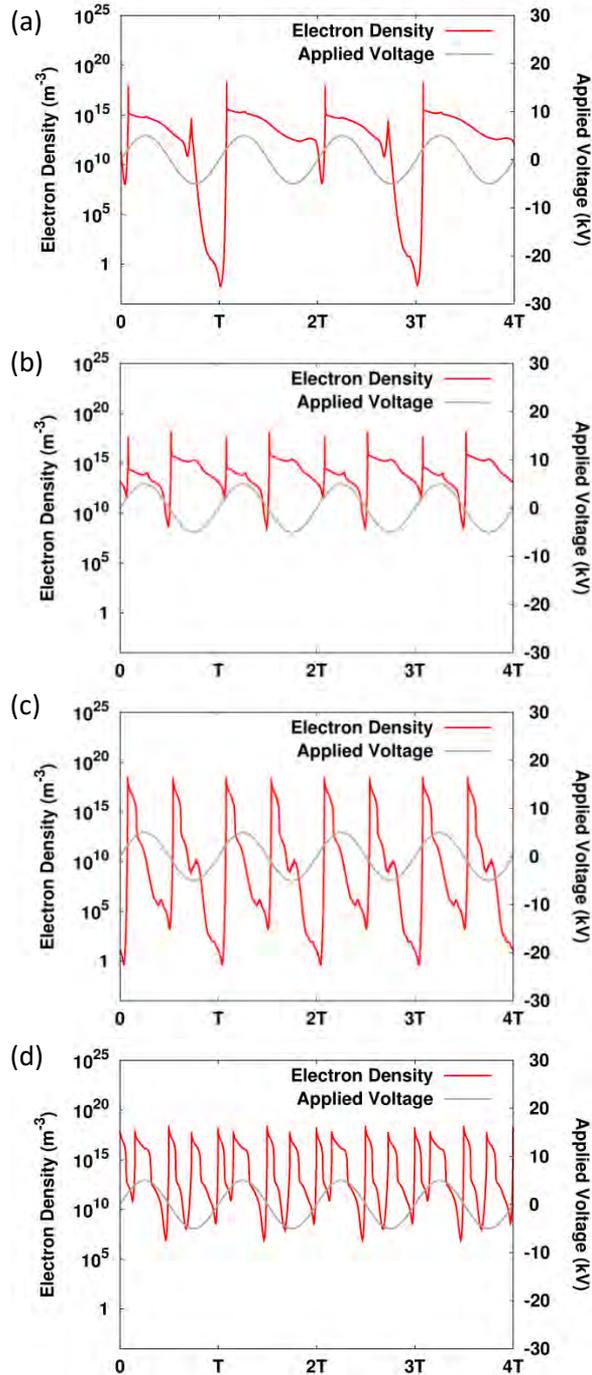


Figure 14. Spatially averaged electron density on a logarithmic scale for a 70/30 (a) and 90/10 (b) CH_4/O_2 gas mixture and for a 70/30 (c) and 90/10 (d) CH_4/CO_2 gas mixture, as a function of time, for four periods of the applied voltage. The applied sinusoidal voltage is also presented, for the sake of clarity.

As mentioned above, in the mixtures with CO₂ twice as many breakdowns appear, compared to the corresponding mixtures with O₂. The figures (a ↔ c, b ↔ d) also illustrate the different periodical behavior. Furthermore, the number of breakdowns is also twice as large for the mixtures with 90 % CH₄ (b and d) compared to the corresponding mixtures with 70 % CH₄ (a and c). The same behavior was also observed for the current profiles and the charging of the electrodes, and can be attributed to the different degree of electronegativity of the various gas mixtures and mixing ratios (see below).

It is also clear from the figures that for the mixtures with 90 % CH₄ (b and d) the minimum electron density is much higher than for the mixtures with 70 % CH₄ (a and c). Nevertheless, the overall spatially and time averaged electron density is almost the same for either 90% or 70% CH₄, and amounts to ca. 10¹⁵ m⁻³ for the CH₄/O₂ mixture and to ca. 10¹⁶ m⁻³ for the CH₄/CO₂ mixture. This is one and two orders of magnitude lower than the calculated value of 10¹⁷ m⁻³ for a pure CH₄ plasma (see Section 4.5.1.), and the reason for this is given below.

The overall spatially and time averaged mean electron energy in the CH₄/O₂ and CH₄/CO₂ gas mixtures was calculated to be about 1.6 eV and 2.1 eV, respectively, compared to about 2 eV in pure CH₄ (see Section 4.5.1.). These differences in electron density and mean electron energy between CH₄/O₂ and CH₄/CO₂ can be attributed to the fact that CH₄/O₂ gives rise to an electronegative plasma in contrast to CH₄/CO₂ and pure CH₄. Indeed, the (positive and negative) ion density is three orders of magnitude higher than the electron density in CH₄/O₂, while in CH₄/CO₂ the electron density is in the same order of magnitude as the positive ion density and one order of magnitude higher than the negative ion density. This can be explained

because in CH₄/O₂ the electrons are more easily trapped by attachment reactions with O₂, and moreover, the higher energy electrons are more frequently consumed in ionization and dissociation reactions, as the threshold energies for these reactions are much lower in CH₄/O₂¹⁹⁴⁻¹⁹⁵ than in CH₄/CO₂¹⁹⁶. Thus, the CH₄/O₂ plasma is most electronegative, containing the highest negative ion density, and this explains the lower (spatially and time averaged) electron density than in the CH₄/CO₂ plasma (which still contains some negative ions), and especially compared to the pure CH₄ plasma (which virtually does not contain negative ions).

The number densities of the radicals and ions, produced by collisions of the electrons with the gas molecules, exhibit the same periodic behavior as the electron density, as is illustrated in Figure 15 for the radicals, for a 70/30 CH₄/O₂ (a, b) gas mixture and a 70/30 CH₄/CO₂ (c, d) gas mixture. However, this periodic trend is superimposed on a rising or declining trend, acting over a longer time-scale until periodic steady state is reached.

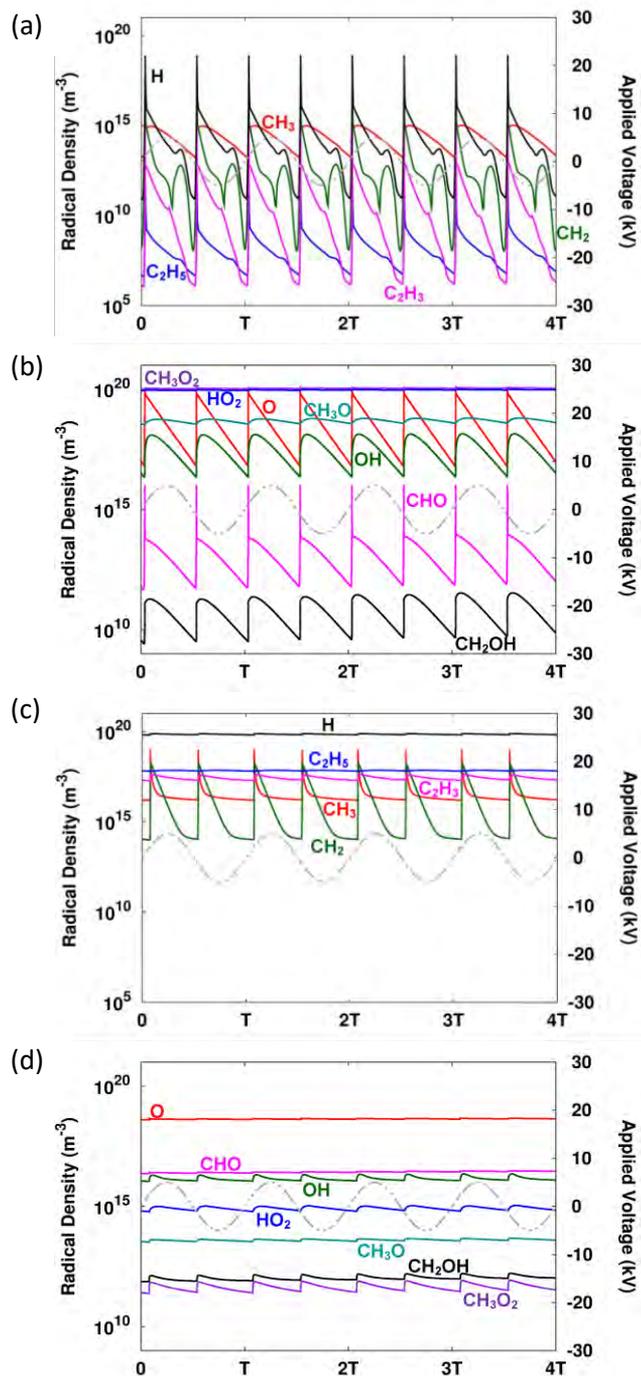


Figure 15. Spatially averaged radical densities (left axis) as a function of time for a 70/30 CH_4/O_2 (a, b) gas mixture and for a 70/30 CH_4/CO_2 (c, d) gas mixture, as well as the applied sinusoidal voltage (gray, right axis) for four periods of the applied voltage.

It is clear from Figure 15 that the densities of some radicals, such as O, OH, CHO, CH₂OH, C₂H₅, C₂H₃ and H in the CH₄/O₂ gas mixture, and CH₃ and CH₂ in both gas mixtures, vary over several orders of magnitude throughout a period. This is because their formation or loss (e.g., H radicals are consumed in reactions with O₂) is strongly dependent on electron impact dissociation of one of the inlet gases. On the other hand, the densities of radicals which are not directly formed by electron impact dissociation of one of the inlet gases, such as C₂H₅, C₂H₃, H, O, OH, CHO, CH₂OH in the CH₄/CO₂ gas mixture, and HO₂, CH₃O and CH₃O₂ in both gas mixtures, vary by less than one order of magnitude throughout a period. The overall spatially and time averaged radical densities vary from about 10⁸ m⁻³ for the less abundant radicals, to about 10¹⁹ m⁻³ for the most abundant radicals. The most abundant radicals in the CH₄/O₂ gas mixture are O, OH, HO₂, CH₃O and CH₃O₂, while H, O, CH₃, CH₂, C₂H₅ and C₂H₃ are mostly abundant in the CH₄/CO₂ gas mixture (see also below). This will determine the different reaction pathways for the formation of the oxygenates in the CH₄/O₂ and CH₄/CO₂ gas mixtures, as will be elaborated in Section 5.5.3. below.

Figure 16 shows the spatially and time averaged radical densities as a function of the initial gas mixing ratio in both the CH₄/O₂ and CH₄/CO₂ gas mixtures. It is clear that the mixtures with CO₂, at an identical initial fraction of CH₄, yield higher densities of C_xH_y, H, CHO and CH₂OH radicals than the mixtures with O₂, while the densities of O, OH, HO₂, CH₃O and CH₃O₂ are higher in the mixtures with O₂ than in the mixtures with CO₂. This can be explained because the net formation of C_xH_y directly or indirectly from CH₄ is higher in the mixtures with CO₂. Furthermore, the formed H, CHO and CH₂OH radicals immediately react with O₂ into HO₂, CO and CH₂O, respectively, and

therefore the net formation of H, CHO and CH₂OH is higher in the mixtures with CO₂. Likewise, the O, OH, HO₂, CH₃O and CH₃O₂ radicals are directly or indirectly formed from O₂ (see Section 5.5.3. below), which explains their higher density in the CH₄/O₂ mixtures. Upon rising initial fraction of CO₂ between 5 and 80 %, the densities of the C_xH_y radicals and of the H atoms drop by half an order to one order of magnitude, due to the fact that these radicals are directly or indirectly formed out of CH₄. A similar trend is observed upon rising fraction of O₂. On the other hand, the densities of O, OH and other O-containing radicals increase by half an order to several orders of magnitude upon rising fraction of CO₂ in the gas mixture, which can be explained by the fact that these radicals are directly or indirectly formed out of CO₂. For the same reason, the densities of the O and OH radicals slightly increase upon rising fraction of O₂ in the gas mixture, while the other O-containing radicals decrease by half an order to several orders of magnitude. The latter can be explained by the fact that a higher inlet fraction of O₂ leads towards full oxidation of CH₄ (see also Figure 17 below).

The ion densities also exhibit a similar periodic behavior as the electrons, which is logical, as they are mostly formed by electron impact ionization or by (dissociative) attachment from the inlet gases, for the positive and negative ions, respectively. The most abundant ions in the CH₄/O₂ gas mixtures are CH₅⁺, C₂H₅⁺, O₄⁺, H₃O⁺, O₂⁻, O₄⁻ and OH⁻, while CH₅⁺, C₂H₅⁺ and OH⁻ are the most abundant ions in the CH₄/CO₂ gas mixtures. Their spatially and time averaged densities are in the order of 10¹⁷ m⁻³ and 10¹⁶ m⁻³ for the CH₄/O₂ and CH₄/CO₂ gas mixtures, respectively. This is typically 2 or 3 orders of magnitude lower than the spatially and time averaged densities of the most abundant radicals in both gas mixtures, indicating that the ions play a minor role in the plasma

chemistry (see Section 5.5.3. below). Therefore, we do not go in further detail on the ion densities.

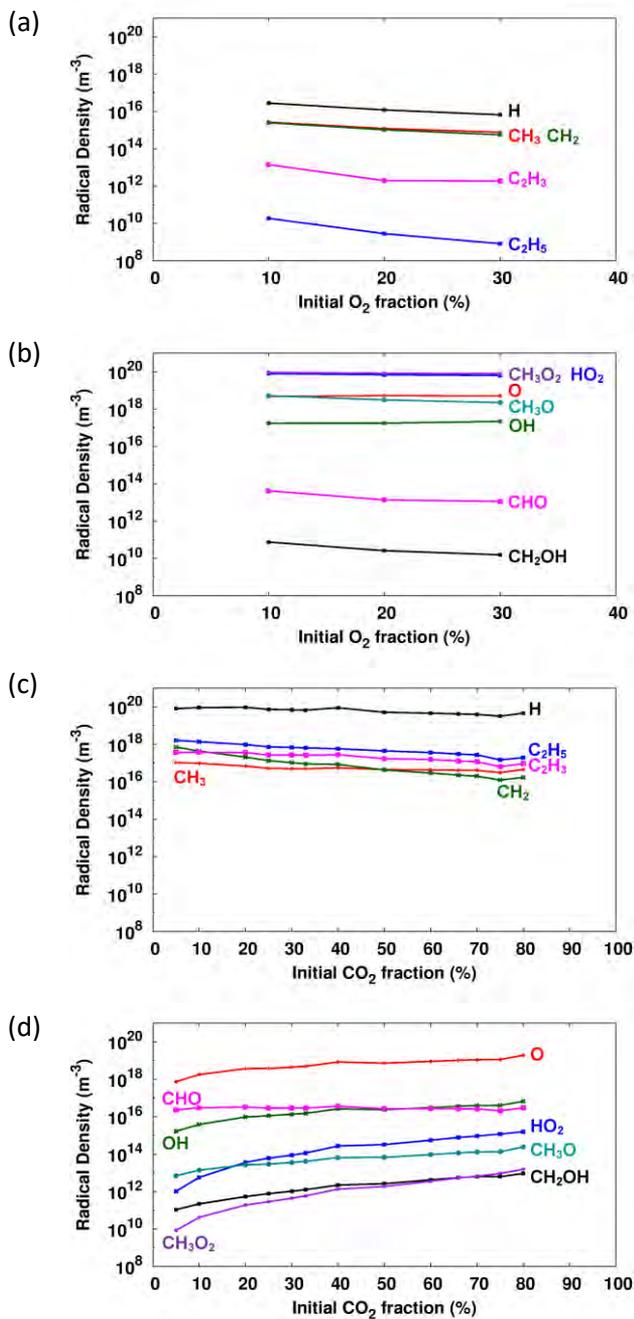
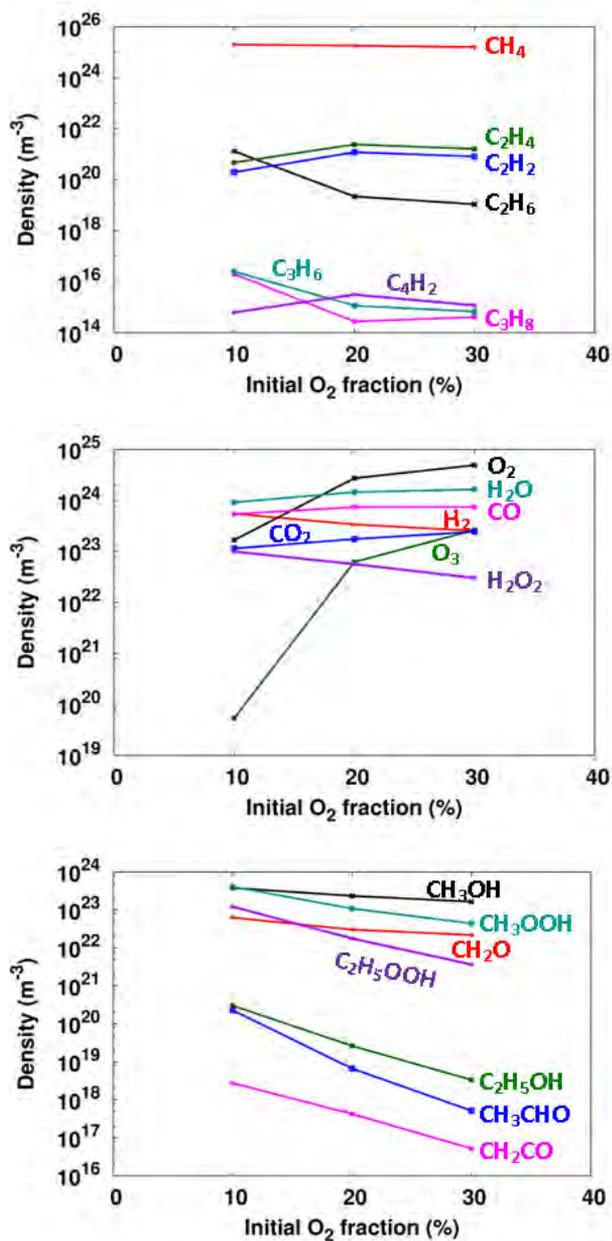


Figure 16. Spatially and time averaged radical densities as a function of the initial gas mixing ratio for the CH_4/O_2 (a, b) and CH_4/CO_2 (c, d) gas mixtures.

CH_4/O_2 

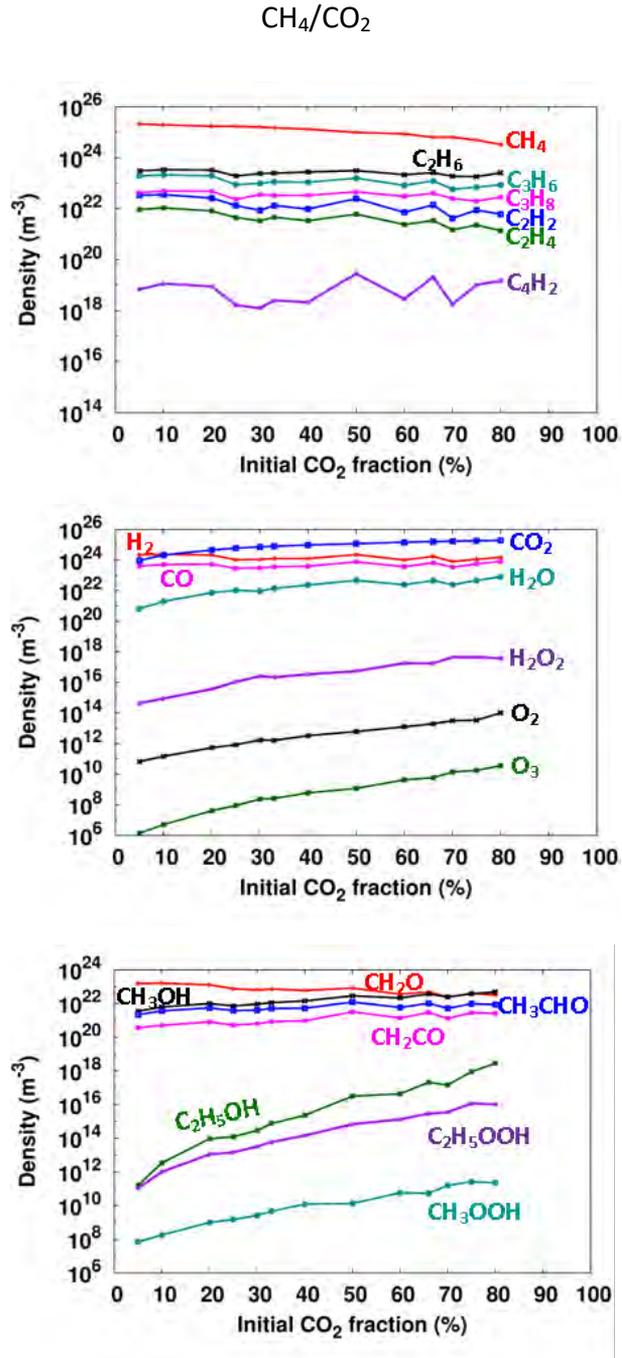


Figure 17. Spatially averaged molecule densities as a function of the initial gas mixing ratio, after a residence time of 5 seconds, for the CH_4/O_2 (left panel) and CH_4/CO_2 (right panel) gas mixtures.

The molecules do not exhibit such a periodic behavior as the electrons, as they are not directly correlated with the electron density and electron energy, because they are typically formed by recombination of the radicals (see Section 5.5.3. below). The densities of the molecules formed from the inlet gases, i.e., H₂, CO, higher order hydrocarbons and oxygenates, exhibit a rising trend as a function of time, during each half period of the applied voltage, because their net production is higher than their net consumption. The inlet gases, on the other hand, have a higher net consumption, so they are characterized by a gradual decrease in their densities during each half period. It appears that the conversion is most pronounced in the first few seconds and that the densities of the molecules do not significantly change anymore for a longer residence time. Below, we present the densities as a function of time, but here we first focus on the densities of the different end products as a function of the initial gas mixing ratio after a certain residence time.

Figure 17 illustrates the densities of the various molecules as a function of the initial gas mixing ratio, after a residence time of 5 seconds, for the CH₄/O₂ (left panel) and CH₄/CO₂ (right panel) gas mixtures. A residence time of 5 s corresponds to a gas flow rate of 0.2 L·min⁻¹ for the plasma reactor under study. It is clear that the densities of the higher hydrocarbons (C_xH_y), as well as H₂, CH₂O (formaldehyde), CH₃CHO (acetaldehyde) and CH₂CO (ketene or ethenone) are higher in the mixtures with CO₂, while the densities of O₃, H₂O, H₂O₂ (hydrogen peroxide), CH₃OH (methanol), C₂H₅OH (ethanol), CH₃OOH (methyl hydroperoxide) and C₂H₅OOH (ethyl hydroperoxide) are higher in the mixtures with O₂. CO is formed at high density in both gas mixtures and therefore the H₂/CO ratio is higher than 1 in the mixtures with CO₂ and lower

than 1 in the mixtures with O₂. Note that in the gas mixtures with O₂ as a co-reactant also a significant amount of undesired CO₂ is formed.

These results are in good agreement with reported results in literature on the formation of oxygenates in CH₄/O₂ and CH₄/CO₂ in discharges at similar conditions. Larkin et al.⁶⁴⁻⁶⁷ discussed the formation of CO, CO₂, CH₃OH, CH₂O, HCOOH (formic acid) and CH₃COOH (acetic acid) in CH₄/O₂ in a plasma reactor surrounded by a water cooling jacket to increase the formation of liquid oxygenates. They also showed that in the presence of enough O₂ the selectivity of C_xH_y will remain low. Okumoto et al.¹²¹⁻¹²² made use of dilution gases to enhance the formation of oxygenates in CH₄/O₂ and reported the formation of C_xH_y, CO, CO₂, H₂, H₂O, CH₃OH, CH₂O and CH₃CHO. Nozaki et al.^{126, 133-134}, Goujard et al.¹⁰⁵ and Agiral et al.²⁵ carried out experiments for CH₄/O₂ gas mixtures in a microplasma reactor, which was immersed into a water bath maintained near room temperature, to enhance the condensation of liquid components on the cooled reactor wall. Furthermore, they intermittently injected distilled water in addition to the inlet gases in order to wash out these liquid components and they collected all condensable components at the end of the reactor by a cold trap. They found that if oxygen was totally consumed, so after a long residence time, or when the inlet oxygen fraction was excessively high, the main products were CO, CO₂ and H₂O. Besides, also the formation of H₂, C_xH_y, HCOOH, H₂O₂, CH₃OOH, CH₃OH and CH₂O were reported, and the concentration of CH₃OH was much higher than that of CH₂O without the cooling, which is in good agreement with our results. However, the selectivity of CH₂O and HCOOH drastically increased when cooling the reactor. Indarto et al.^{127, 129} discussed the formation of H₂, CO, CO₂, H₂O, C_xH_y and CH₃OH in CH₄/O₂ and found that a

proper selection of catalyst can drastically enhance the yield and selectivity of CH₃OH. Our results are also in reasonable agreement with the results reported by Zhou et al.¹⁰⁶ comparing the use of a single and a double dielectric plasma reactor for the direct oxidation of CH₄ to H₂O₂ and oxygenates, where the double dielectric reactor favored the formation of these products.

The conversion of CH₄ in the presence of CO₂ is much less reported. Zou et al.¹⁴ discussed the formation of CO, H₂, C_xH_y, H₂O, CH₂O, CH₃OH, C₂H₅OH, HCOOH, CH₃COOH and other alcohols, acids, aldehydes, ketones and esters in CH₄/CO₂ in the presence of starch. It was shown that the selectivity of C_xH_y was much higher than for the oxygenates, which is in good agreement with our results. Kozlov et al.¹³⁷, Zhang et al.¹⁴⁷ and Scarduelli et al.¹⁶² reported the formation of a variety of hydrocarbons and oxygenates in CH₄/CO₂. Li et al.¹⁴³ found that CH₃COOH and C₂H₅OH were the major oxygenates among other alcohols and acids formed in CH₄/CO₂, but of course their selectivities were much lower than those for C_xH_y and CO. Sentek et al.¹⁵⁸ discussed the formation of H₂, CO, C_xH_y and alcohols in a CH₄/CO₂ plasma in the presence of a catalyst. Finally, Goujard et al.¹⁰⁷ studied the effect of helium dilution on the formation of CO, C_xH_y, CH₂O and CH₃OH in CH₄/CO₂.

The flexible adaptation of the H₂/CO ratio in a DBD by altering the inlet gas mixing ratio is an advantage compared to classical processes, including steam reforming, partial oxidation, and CO₂ reforming, which typically produce syngas with H₂/CO molar ratio greater than 3, less than 2 and less than 1, respectively.²⁰⁻²¹ The H₂/CO molar ratio from steam reforming (>3) is much higher than that required by the stoichiometry for many synthesis processes. A low H₂/CO molar ratio (in the order of 2) is desirable for many industrial

synthesis processes, such as the Fischer Tropsch synthesis or the synthesis of valuable oxygenated chemicals. Methanol can even be produced from syngas with a H₂/CO molar ratio as low as 0.5, when the system can simultaneously carry out methanol synthesis and the water-gas-shift reaction.²⁰⁻²¹

If the initial fraction of O₂ increases from 10 to 30%, the densities of C₂H₆, C₃H₆, C₃H₈, H₂, H₂O₂, CH₂O, CH₃OH and CH₃OOH decrease up to one order of magnitude, and the densities of C₂H₅OH, CH₃CHO, CH₂CO and C₂H₅OOH decrease even with several orders of magnitude. Meanwhile, the densities of C₂H₄, C₂H₂, C₄H₂, CO₂, CO and H₂O increase up to one order of magnitude and the density of O₃ increases with several orders of magnitude, pointing towards full oxidation of CH₄. In other words, if higher oxygenates, such as CH₂O and CH₃OH, are the desired end products of the gas conversion of CH₄, it is appropriate to make use of CH₄/O₂ gas mixtures with a not too high fraction of O₂. These results are in reasonable agreement with reported research on the effect of the initial gas mixing ratio in similar discharges in CH₄/O₂ by Larkin et al.⁶⁵⁻⁶⁶, Okumoto et al.¹²² and Zhou et al.¹⁰⁶.

Likewise, increasing the initial fraction of CO₂ from 5 to 80% results in a drop of the densities of C_xH_y, H₂, and CH₂O up to one order of magnitude, while the densities of CO, CH₃OH, CH₃CHO and CH₂CO increase up to one order of magnitude and the densities of O₂, O₃, H₂O, H₂O₂, C₂H₅OH, CH₃OOH and C₂H₅OOH increase even with several orders of magnitude. In other words, the ideal gas mixing ratio for CH₄/CO₂ gas mixtures depends on the desired higher oxygenate to be formed. Since the H₂ density drops and the CO density increases upon rising initial fractions of O₂ and CO₂, the H₂/CO molar ratio will significantly decrease, which is interesting, in view of the desired stoichiometry for industrial synthesis processes (cf. above). These results are

again in reasonable agreement with literature studies on the effect of the initial gas mixing ratio in similar discharges in CH₄/CO₂ by Zou et al.¹⁴, Li et al.¹⁴³ and Zhang et al.¹⁴⁷.

Note that the trends illustrated in Figure 17 correspond to a residence time of 5 seconds; however, the different molecules might have their maximum densities at a different residence time for the different gas mixtures studied, so the trends depicted in Figure 17 are not necessarily the same at other residence times. Besides, the gas composition in the CH₄/O₂ gas mixtures completely changes at the moment when O₂ is fully consumed, which happens after 5.6s and 15.2s, in the case of 10 and 20% O₂, respectively (see Figure 19 below). To make this more clear, we show in Figure 18 the characteristic density profiles as a function of the residence time, as we have observed for the different molecules, for a 90/10 CH₄/O₂ (a) and a 90/10 CH₄/CO₂ (b) gas mixture.

In the mixture with O₂ we can distinguish six different density profiles:

1. H₂ and CO show a continuously rising trend.
2. The higher hydrocarbons (C_xH_y), ethanol (C₂H₅OH) and ketene (CH₂CO) have negligible values up to 5.6s, followed by a strong increase up to an equilibrium value after 10s.
3. O₃ exhibits a maximum within 1s, and then reacts away within 3 s.
4. CO₂, H₂O and methanol (CH₃OH) show a steady increase to a maximum at around 6-8s, followed by a very slow decrease.
5. Hydrogen peroxide (H₂O₂), methyl hydroperoxide (CH₃OOH) and ethyl hydroperoxide (C₂H₅OOH) go over a maximum at 4-6s and then decrease rapidly.

6. Finally, formaldehyde (CH₂O) and acetaldehyde (CH₃CHO) also reach a maximum at 4-6s, but after a fast drop, their density increases again after 8s.

Except for the profile of O₃ (no. 3), which has already reacted away after 4s, the effect of O₂ being fully consumed after 5.6s can be observed in the changes of the density profiles of all different molecules at this moment of time. Indeed, the densities of the higher hydrocarbons, for instance, start rising at that time, because in the absence of O₂, the CH₄ will mainly be converted into higher hydrocarbons, while the densities of the oxygenates typically show a (sharp) drop in time, when O₂ is fully depleted.

In the mixture with CO₂ four different density profiles can be distinguished:

1. H₂, CO, ethane (C₂H₆) and methanol (CH₃OH) exhibit a steady rise as a function of time.
2. Ethylene (C₂H₄), acetylene (C₂H₂), C₄H₂, H₂O, formaldehyde (CH₂O), acetaldehyde (CH₃CHO) and ketene (CH₂CO) go over a maximum at around 6-8s.
3. Propane (C₃H₈), propene (C₃H₆) and ethanol (C₂H₅OH) rise rapidly, but reach an equilibrium density after 2s.
4. O₂, O₃, hydrogen peroxide (H₂O₂), methyl hydroperoxide (CH₃OOH) and ethyl hydroperoxide (C₂H₅OOH) reach a maximum within 5 ms, and then react rapidly away.

Thus it is clear that the higher hydrocarbons and oxygenates (no. 2 and no. 3) can be formed at rather high density, but they react away again after a longer residence time towards H₂ and CO, respectively, which explains why H₂ and CO show a continuously rising trend. Besides H₂ and CO, also C₂H₆ and CH₃OH exhibit a steady rise (no. 1) as their formation is strongly connected to

the dissociation products of CH_4 , in particular the CH_3 and CH_2 radicals. Finally, O_2 , O_3 and the different peroxides are only present at very low densities, and for a very short time, as they are formed as an intermediate in the direct or indirect formation of CO .

An identical behavior is observed for all these species in the other gas mixing ratios of CH_4 with O_2 and CO_2 .

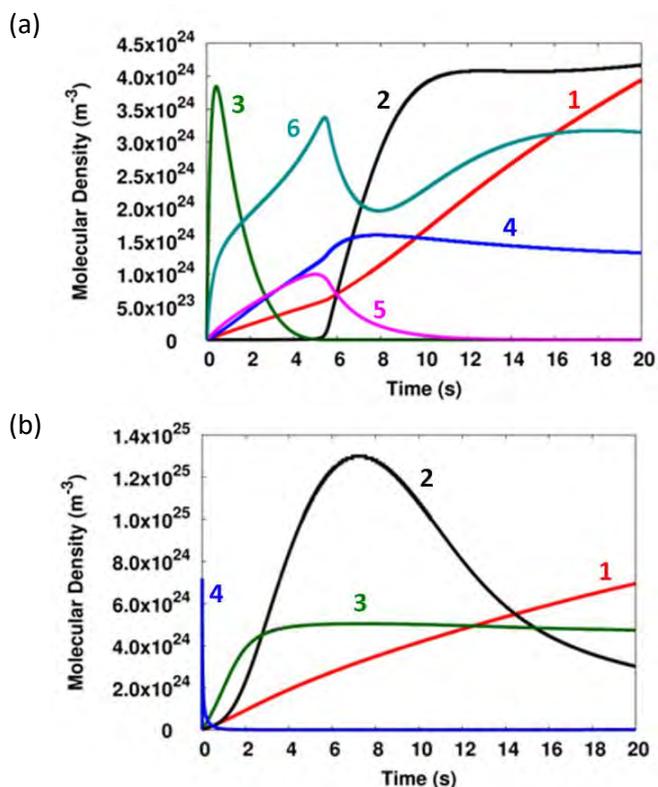


Figure 18. Spatially averaged molecule densities as a function of the residence time, for the 90/10 CH_4/O_2 gas mixture (a) and the 90/10 CH_4/CO_2 gas mixture (b). The labels of the curves characterize some specific molecules (see text). For panel (a): 1 = H_2 (density divided by 10), 2 = C_2H_6 , 3 = O_3 (density multiplied by 10), 4 = CO_2 , 5 = H_2O_2 , 6 = CH_2O (density multiplied by 5). For panel (b): 1 = H_2 , 2 = C_2H_4 (density multiplied by 1000), 3 = C_3H_8 (density multiplied by 100), 4 = O_2 (density multiplied by 10^{10}).

5.5.2. Conversion, Yields and Selectivities

Figure 19 shows the conversion of CH₄ and O₂ (a) and of CH₄ and CO₂ (b) as a function of residence time for different gas mixing ratios. The conversion of CH₄ after 20s is around 20% in all considered mixtures with O₂, while in pure CH₄, a conversion of 40% was calculated after 20s (see Section 4.5.2.). This is logical, because in the CH₄/O₂ mixture a considerable fraction of the energy is also consumed by O₂. O₂ is indeed converted very quickly, and the time for full conversion depends on the initial fraction of O₂, i.e., full conversion is reached faster in the case of a lower O₂ initial fraction (see Figure 19(a)), which is logical.

In the CH₄/CO₂ gas mixture, the conversion of both CH₄ and CO₂ strongly depends on the initial gas mixing ratio. No clear trend can be observed from Figure 19(b), because the initial gas mixing ratio strongly affects the discharge characteristics and therefore the conversion of the inlet gases. The effect of the initial gas mixing ratio on the conversion will be discussed below. Our calculations predict a maximum conversion of 68% for CH₄ and 55% for CO₂ after a residence time of 20s in a 20/80 and a 95/5 CH₄/CO₂ gas mixture, respectively (not shown in Figure 19(b)). It is logical that a higher CH₄ conversion is reached at a lower initial CH₄ fraction in the gas mixture, and vice versa for CO₂, because these conditions yield a higher co-reactant concentration, which contributes to a more efficient conversion.

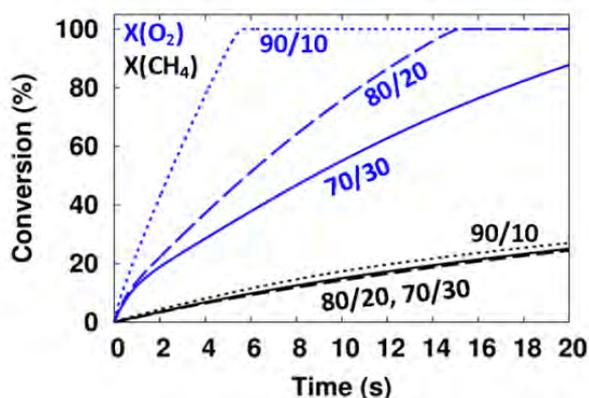
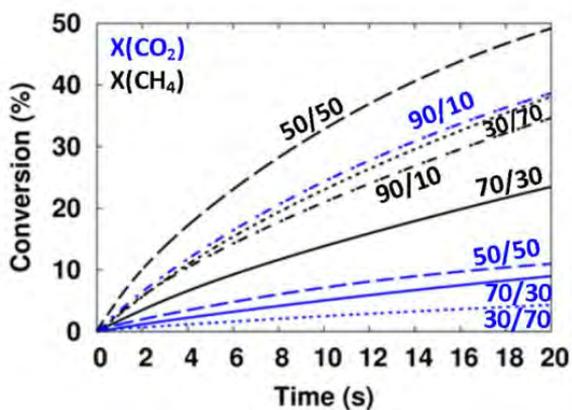
(a) CH_4/O_2 (b) CH_4/CO_2 

Figure 19. Conversion of CH_4 (black) and O_2 (a, blue) or CO_2 (b, blue) as a function of residence time.

When comparing the conversion of CH_4 in both the CH_4/O_2 and the CH_4/CO_2 gas mixtures with the same gas mixing ratios, it is clear that at a 70/30 gas mixing ratio, the CH_4 conversion is equal (i.e., around 20%) in both gas mixtures, while at the 80/20 and 90/10 gas mixing ratios, the CH_4 conversion was found to be slightly higher in the mixtures with CO_2 than in the mixtures with O_2 . This can be explained because the loss (by electron impact dissociation and ionization) of CH_4 is about a factor 2 higher in CH_4/CO_2 than in CH_4/O_2 due to the fact that much more electrons are consumed by electron impact reactions with O_2 than with CO_2 (cf. the electronegative character,

explained in Section 5.5.1. above). However, the lower consumption of CH₄ in the CH₄/O₂ gas mixture is partially compensated by the increasing importance of the reaction with OH when the initial fraction of O₂ in the gas mixture increases. Furthermore, in the CH₄/CO₂ gas mixture, the production (or regeneration) of CH₄ is around 50% of the CH₄ consumption when the initial fraction of CO₂ is in the range of 10-30%, while in the CH₄/O₂ mixture, the CH₄ production is decreasing with increasing O₂ initial fraction, from 30% of the CH₄ consumption in 90/10 CH₄/O₂ to 8% in 70/30 CH₄/O₂ (i.e. one order of magnitude lower than in 70/30 CH₄/CO₂). In other words, the much lower regeneration of CH₄ in the 70/30 CH₄/O₂ mixture than in the 70/30 CH₄/CO₂ mixture compensates enough for the lower consumption of CH₄ in the 70/30 CH₄/O₂ mixture than in the 70/30 CH₄/CO₂ mixture. This effect, together with the increasing importance of the reaction with OH radicals, results in an almost equal net conversion of CH₄ in both gas mixtures at a 70/30 gas mixing ratio (see more details in Section 5.5.3. and Figure 21 below).

Figure 20 shows the conversion of CH₄, O₂ and CO₂ as a function of the initial gas mixing ratio, for both the CH₄/O₂ and CH₄/CO₂ gas mixtures, after a residence time of 5s. The CH₄ conversion is roughly independent from the initial O₂ or CO₂ fraction up to 30-40%, with a value of about 10%, but it increases for higher initial CO₂ fractions, especially above 70%. Indeed, at higher initial CO₂ fractions, the conversion of CH₄ rises due to the increasing importance of the reaction of CH₄ with CO₂⁺, which becomes the most important channel for consumption of CH₄, while at lower initial CO₂ fractions electron impact dissociation of CH₄ is the most important loss channel (see also Section 5.5.3. and Figure 21 below). For the same reason, the conversion of O₂ and CO₂ increases with decreasing initial O₂ or CO₂ fraction, because of

the additional loss reactions with CH₄ molecules (or CH₄-derived species). For instance, in the 70/30 CH₄/O₂ mixture, a three-body reaction with O radicals is the most important loss process for O₂, while in the 90/10 CH₄/O₂ mixture, the most important loss processes for O₂ are three-body reactions with CH₃ or H radicals (see also Section 5.5.3. and Figure 22 below). Likewise, in the CH₄/CO₂ mixtures with high initial CO₂ fractions, electron impact ionization of CO₂ is the most important loss channel, while at lower initial CO₂ fractions, the reaction of CO₂ with CH₂ radicals is the most important loss channel for CO₂ (see again Section 5.5.3. and Figure 22 below).

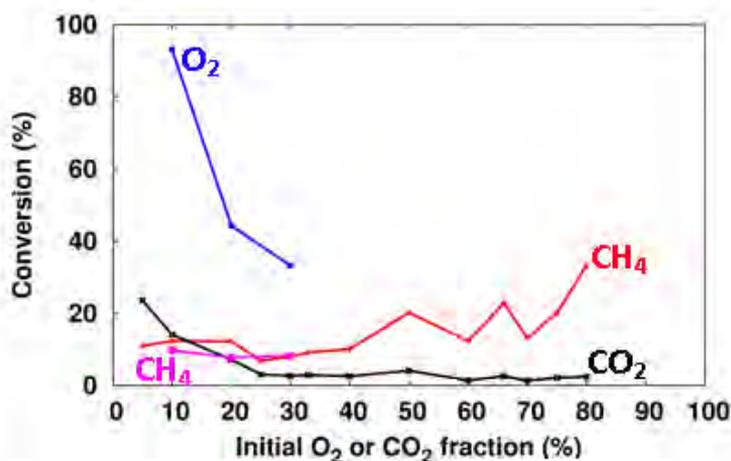


Figure 20. Conversion of CH₄, O₂ and CO₂ as a function of the initial O₂ or CO₂ fraction in the gas mixture, for a residence time of 5 seconds. The CH₄ conversion in the CH₄/CO₂ mixture is depicted in red, while the CH₄ conversion in the CH₄/O₂ mixture is presented in pink.

As was also clear from Figure 19, the O₂ conversion is much higher than the CO₂ conversion, which is only in the order of 20% at low CO₂ fractions, and even below 3% at higher CO₂ fractions. This is because the threshold energies for electron impact ionization and dissociation are much lower for O₂ than for

CO₂. The CH₄ conversion is comparable to the CO₂ conversion at low CO₂ fractions, i.e., around 10%, but it rises to 35% at high CO₂ fractions. Finally, it is worth to mention that Figure 20 illustrates the conversion, relative to the amount of CH₄, CO₂ or O₂ present in the mixture. The absolute (or effective) conversion of CH₄ is of course higher at a higher initial CH₄ fraction, and vice versa for the absolute CO₂ and O₂ conversions, which is logical, as there is more of these gases initially present in the gas mixture.

Besides the conversion of CH₄, CO₂ and O₂, we are especially interested in the yields and selectivities of the formed value-added chemicals. Table 6 shows the maximum yields of H₂, CO, formaldehyde (CH₂O) and methanol (CH₃OH), as well as the gas mixtures and residence times for which these maximum values were obtained. Also the corresponding selectivities are presented. Note that the sum of the selectivities does not have to be equal to 100%, because in the CH₄/CO₂ mixture, the selectivities of CO, CH₂O and CH₃OH are calculated with respect to both the CH₄ and CO₂ conversion, while the H₂ selectivity is only calculated with respect to the CH₄ conversion. Similarly in the case of the CH₄/O₂ mixture, the selectivities of CO, CH₂O and CH₃OH are calculated with respect to the CH₄ conversion, while the H₂ selectivity is calculated with respect to twice the CH₄ conversion, resulting in a difference of a factor 2 (see Section 3.6.).

Table 6. Overview of the maximum yields for some important end products in both the CH₄/O₂ and CH₄/CO₂ gas mixtures, as well as the corresponding gas mixing ratio and residence time at which these maximum yields are obtained. The corresponding selectivities of these end products are also listed.

		H ₂	CO	CH ₂ O	CH ₃ OH
CH ₄ /O ₂	Yield (%)	9	10	0.3	4
	Mixture	90/10	70/30	90/10 and 80/20	80/20
	Residence Time (s)	20	20	5.4 and 14.9	20
	Selectivity (%)	33	39	3 and 2	15
CH ₄ /CO ₂	Yield (%)	34	10	0.9	0.4
	Mixture	20/80	20/80	90/10	25/75
	Residence Time (s)	20	20	10.3	20
	Selectivity (%)	50	52	4	2

It is clear that syngas is the main product in both gas mixtures, but the H₂/CO molar ratio is somewhat different, as was also discussed in Section 5.5.1. above. In the CH₄/O₂ mixture, the H₂ yield reaches a maximum at 10% O₂ fraction, while the CO yield reaches a maximum at 30% O₂ fraction, which is logical. In the CH₄/CO₂ mixture, the maximum H₂ and CO yields are both reached at 80% CO₂. For H₂, this can be explained because, although the absolute formation of H₂ is of course lower at a higher initial CO₂ fraction, its yield becomes higher as the latter is calculated with respect to the initial CH₄ density, which is obviously lower at higher initial CO₂ fraction. For CO, electron impact dissociation of CO₂ is the most important production channel, and the highest density and yield of CO are found at the highest initial CO₂ fraction. Note that at lower initial CO₂ fractions, the most important production channel of CO is the reaction of CH₂ radicals with CO₂, but this

reaction does not lead to a higher CO density (see also Section 5.5.3. and Figure 24 below). The H₂/CO molar ratio in the case of the 20/80 CH₄/CO₂ gas mixture is around 1.5, which is desirable for many industrial synthesis processes (cf. above). At higher CH₄/CO₂ gas mixing ratios, the H₂/CO molar ratio rises to about 5, because the H₂ density increases, while the CO density decreases upon higher CH₄ fraction in the mixture.

The maximum yields of CH₂O and CH₃OH are clearly lower than the maximum H₂ and CO yields. This is especially true in the CH₄/CO₂ mixtures, where both yields are below 1%. In this case, the highest CH₂O yield is obtained at 90% CH₄ fraction, while the highest CH₃OH yield is reached at 25% CH₄. In the CH₄/O₂ mixtures, the highest CH₂O yield is also below 1%, but the maximum CH₃OH yield reaches a value of 4%, which is not negligible. Nevertheless, a really selective production process towards CH₂O or CH₃OH seems not feasible in a DBD plasma, at least not at the conditions under study. For this purpose, a catalyst will need to be integrated into the plasma region.

Finally, it is clear from Table 6 that the highest yields are not necessarily reached at the longest residence time. Indeed, the H₂, CO and CH₃OH yields reach their maximum at 20s residence time, pointing out that their densities are still rising as a function of time (cf. Figure 18 above), while the CH₂O yield clearly reaches its maximum at a shorter residence time (see also Figure 18 above), and the exact value depends on the gas mixture and gas mixing ratio, as appears from Table 6. This indicates that, when the production of formaldehyde is targeted, the optimal residence time should be carefully selected.

Indeed, similar results were reported in literature. Okumoto et al.¹²² stated that CH₃OH and CH₂O are in fact intermediate products in the oxidation of CH₄ and are easily decomposed or converted to CO, CO₂ and H₂O. In other words, the formation of oxygenates is strongly dependent on the initial gas mixing ratio, the residence time and a variety of other parameters. Okumoto et al. found that 15 vol.% of O₂ showed optimum performance for the formation of CH₃OH and CH₂O in CH₄/O₂.¹²² Note that the authors made use of dilution gases to enhance the formation of oxygenates. Also Zou et al.¹⁴ discussed the existence of an optimum feed composition to attain the maximum selectivity of the desired oxygenates. They obtained the highest total selectivity of oxygenates at a CH₄ concentration of 35 vol.% in CH₄/CO₂ in the presence of starch with the highest selectivities of alcohols, such as CH₃OH, and acids when the CO₂ fraction in the feed increases to 74 vol.%, and the highest selectivity of CH₂O at a higher CH₄ concentration of about 50 vol.%. These findings are in reasonable agreement with our results.

5.5.3. Dominant Reaction Pathways

We will now discuss the dominant reaction pathways for the conversion of the inlet gases into syngas, higher order hydrocarbons and oxygenates for a 70/30 CH_4/CO_2 gas mixture and for a 70/30 CH_4/O_2 gas mixture.

(a) Electron impact dissociation of CH_4 , CO_2 and O_2 : initiating the conversion process

As soon as the discharge is ignited, electron impact ionization and dissociation of the inlet gases occurs, resulting in the creation of new species (electrons, ions, radicals), as discussed in Section 5.5.1. above. The formation of new electrons and ions in the plasma enables to sustain the discharge, while the formation of radicals is important for the production of syngas, higher order hydrocarbons and oxygenates.

The dominant reactions for CH_4 consumption (and production) for a 70/30 CH_4/CO_2 gas mixture and a 70/30 CH_4/O_2 gas mixture are depicted in Figure 21(a) and Figure 21(b), respectively. Electron impact dissociation, yielding the formation of CH_3 , CH_2 or CH radicals, are important channels for CH_4 consumption in both gas mixtures, with relative contributions of about 33%, 6% and 2% in CH_4/CO_2 and 34%, 7% and 2% in CH_4/O_2 . In the 70/30 CH_4/O_2 gas mixture, the reaction with OH radicals, forming CH_3 radicals and H_2O , also contributes for about 19% to the loss of CH_4 . This reaction is negligible in the CH_4/CO_2 mixture, due to the much lower OH radical density in that case (see Figure 15 above). Furthermore, also electron impact ionization and reactions with ions or radicals contribute to the loss of CH_4 , accounting in total for about 20%, 31% and 6%, respectively, in CH_4/CO_2 and for about 15%, 21% and 22% (including the 19% of the reaction with OH), respectively, in CH_4/O_2 .

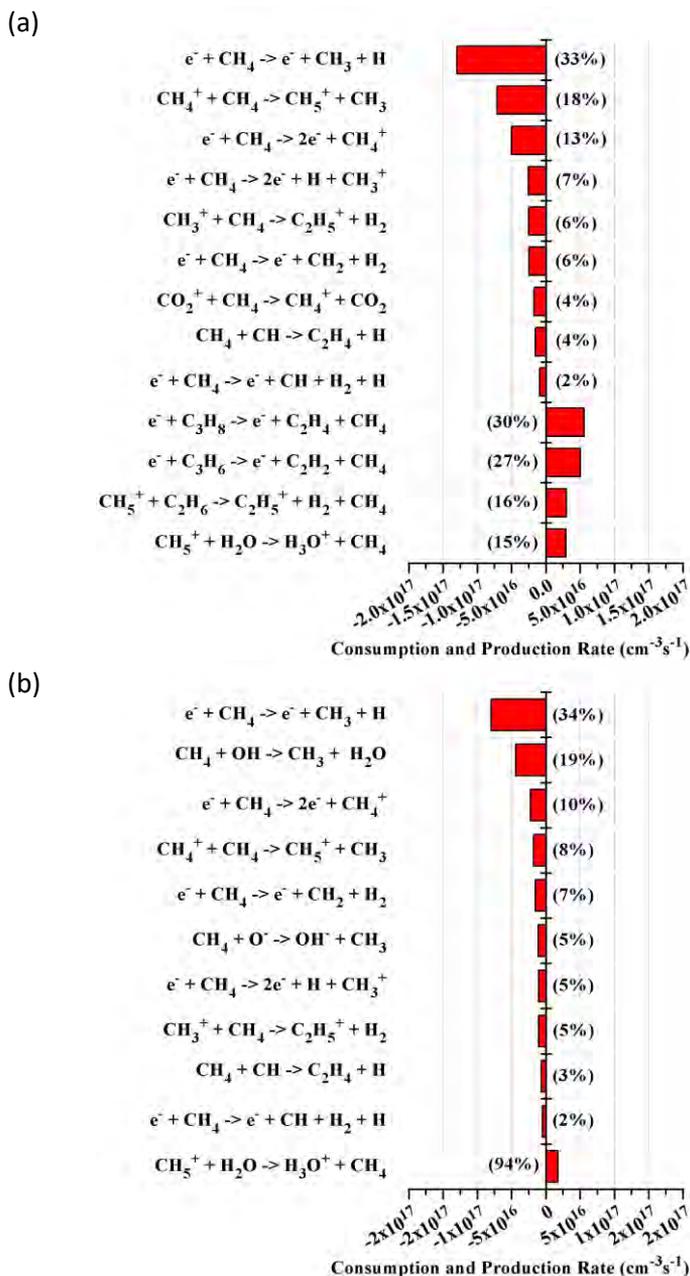


Figure 21. Time-averaged reaction rates of the dominant reaction pathways for the consumption and production of CH₄, for a 70/30 CH₄/CO₂ gas mixture (a) and a 70/30 CH₄/O₂ gas mixture (b). The consumption rates are defined as negative values (i.e., left-hand side of the figures), while the production rates are plotted as positive values (i.e., right-hand side of the figures). The relative contributions of these consumption and production processes to the overall consumption and production of CH₄ are also indicated.

It should be noted that electron impact vibrational excitation of CH₄ is also important, but this process is only considered in our model as an energy loss for the electrons, and not as a chemical loss process for CH₄, because the vibrationally excited species are not taken into account separately in our model (see Section 5.2.).

The most important pathways for the production (or regeneration) of CH₄ in the mixture with CO₂ are based on electron impact dissociation of higher hydrocarbons, such as C₃H₈ and C₃H₆, while in the mixture with O₂ these reactions appear negligible, and a charge transfer process of CH₅⁺ with H₂O is the most important production process.

Finally, it is clear from Figure 21 that the total production (or regeneration) rate of CH₄ in the 70/30 CH₄/CO₂ gas mixture is almost one order of magnitude higher than in the 70/30 CH₄/O₂ gas mixture, while the consumption rate in both gas mixtures is in the same order of magnitude. However, the total loss rate is still a factor 2 higher than the total production rate in the CH₄/CO₂ mixture, and even a factor 12 higher in the CH₄/O₂ mixture, resulting in a clear loss of CH₄.

At a higher initial CO₂ fraction, the reactions of CH₄ with CO₂⁺ and CH₄⁺ become the most important channels for the consumption of CH₄ (see also Section 5.5.2.), accounting both for about 29% in 20/80 CH₄/CO₂, while the electron impact dissociation reaction yielding the formation of CH₃ only contributes for about 15% at these conditions. The most important pathway for the production (or regeneration) of CH₄ then becomes the charge transfer process of CH₅⁺ with H₂O, with a contribution of 32%. A decrease of the initial fraction of CO₂ results in an increase of the contributions of the electron impact dissociation reactions for the consumption of CH₄ and also an increase

of the contributions of the electron impact dissociations of C₃H₈ and C₃H₆ for the regeneration of CH₄. A decrease of the initial fraction of O₂ to 10% results in a drastic decrease of the contribution of the reaction with OH radicals (3%). Electron impact dissociation yielding the formation of CH₃ remains the most important loss channel in this case, with a contribution of 42%. Meanwhile, the contribution of the charge transfer process of CH₅⁺ with H₂O, the most important production process of CH₄, decreases from 94% in 70/30 CH₄/O₂ to 38% in 90/10 CH₄/O₂, as electron impact dissociation of C₃H₈ and C₃H₆ becomes more important, like in the mixtures with CO₂.

The dominant reactions for CO₂ consumption (and production) for a 70/30 CH₄/CO₂ gas mixture and for O₂ consumption (and production) for a 70/30 CH₄/O₂ gas mixture are depicted in Figure 22(a) and Figure 22(b), respectively. The most important channel for consumption of CO₂ at this gas mixing ratio is the reaction with CH₂ radicals, contributing for about 48% to the CO₂ loss, followed by electron impact dissociation and ionization, which contribute for 16% and 30% to the total consumption of CO₂, respectively. At lower CO₂ fractions, the contribution of the first process will even increase to 77% for a 90/10 CH₄/CO₂ gas mixture. On the other hand, at higher CO₂ fractions in the gas mixture, the latter two processes will become gradually more important. For a 20/80 CH₄/CO₂ gas mixture, electron impact ionization and dissociation contribute for 52% and 27%, respectively, while the reaction with CH₂ radicals contributes for 9%. It is worth to mention that the reaction with CH₂ radicals is also the most important pathway for the production of CH₂O and CO in the 70/30 CH₄/CO₂ gas mixture (see below).

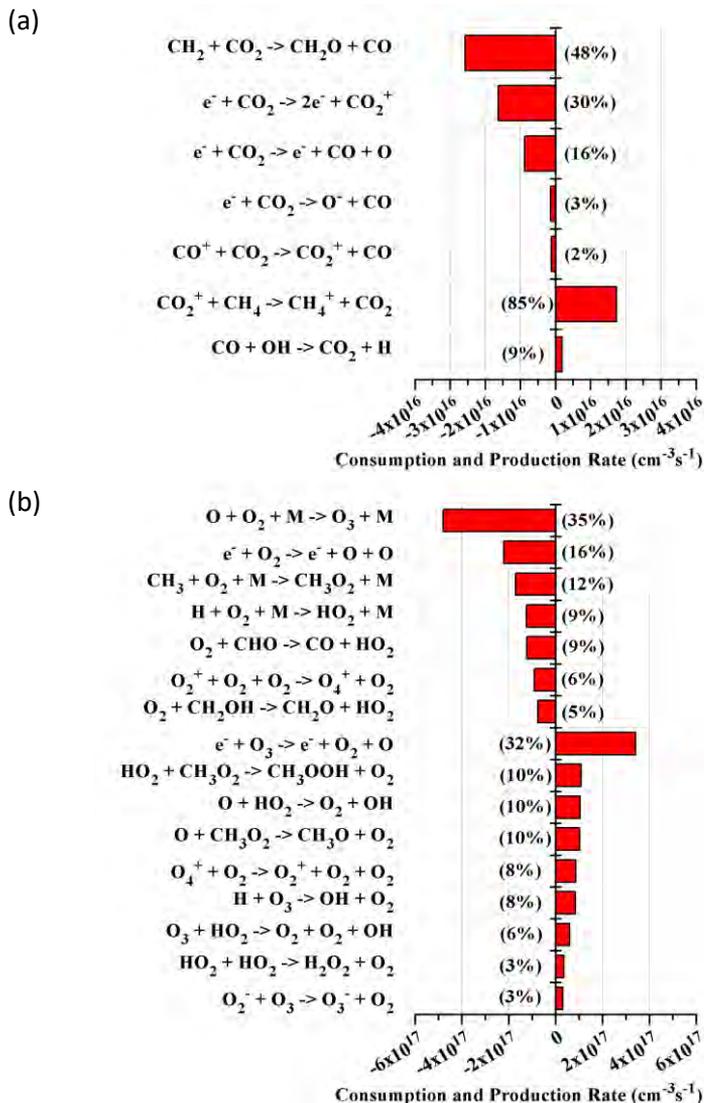


Figure 22. Time-averaged reaction rates of the dominant reaction pathways for the consumption and production of CO₂ for a 70/30 CH₄/CO₂ gas mixture (a) and for the consumption and production of O₂ for a 70/30 CH₄/O₂ gas mixture (b).

The most important channels for consumption of O₂ are three-body collisions with O, CH₃ or H radicals, with either CH₄, O₂, H₂O or CO₂ as third body (denoted as M in Figure 22(b)), as well as electron impact dissociation of O₂ and a chemical reaction with CHO radicals. The three-body reaction with O

radicals, forming O₃, is the most important loss process, with a contribution of 36%. However, almost all the O₃ will be decomposed back to O₂ by electron impact dissociation, so that the net contribution of this reaction will be lower.

Electron impact dissociation of O₂ yields the formation of O radicals, while the reactions with CH₃, H and CHO yield among others the formation of CH₃O₂ and HO₂. The O and HO₂ radicals will react further into OH (see below), which is an important species for the consumption of CH₄ (see above), while CH₃O₂ plays an important role in the formation of CH₃OH and CH₃OOH (see below). When the initial fraction of O₂ decreases to 10%, the three-body collisions with CH₃ and H radicals become more important for the consumption of O₂, with contributions of 29% and 25%, respectively. Meanwhile, the contribution of electron impact dissociation of O₂ decreases to 11% and the three-body collision with O radicals decreases drastically to 10%.

The most important production mechanism for CO₂ in the CH₄/CO₂ gas mixtures is a charge transfer process between CO₂⁺ and CH₄, while electron impact dissociation of O₃ (see above) is the most important production process for O₂ in a 70/30 CH₄/O₂ gas mixture. As a result of the lower production of O₃ (see above) in a 90/10 CH₄/O₂ gas mixture, the reaction of HO₂ radicals with CH₃O₂ radicals towards CH₃OOH is the most important process for regeneration of O₂ in this mixture, with a contribution of 33%. However, the rates for regeneration of CO₂ and O₂ are again a factor 2.6 and 1.3 lower than their corresponding loss rates, so that there is a net consumption of CO₂ and O₂.

(b) Recombination of CH₃ radicals: the formation of C_xH_y vs. the formation of CH₃O₂

The most important species produced from CH₄ are the CH₃ radicals (see above). Figure 23(a) and Figure 23(b) show the dominant reactions for CH₃ consumption and production, again for a 70/30 CH₄/CO₂ gas mixture and a 70/30 CH₄/O₂ gas mixture, respectively. In the 70/30 CH₄/CO₂ mixture, the CH₃ radicals will mainly recombine towards higher hydrocarbons, such as C₂H₆ and C₃H₈, which contribute for 48% and 46% to the consumption of CH₃, respectively. On the other hand, in the 70/30 CH₄/O₂ gas mixture, these reactions are negligible compared to the three-body recombination reaction with O₂ molecules, forming CH₃O₂ radicals (see Figure 23(b)). This is in good agreement with Nozaki et al.¹³⁴ and Goujard et al.¹⁰⁵, who also discussed the importance of the formation of CH₃O₂ in the methane partial oxidation mechanism towards the formation of CH₃OH. Furthermore, this result explains the lower densities for the higher hydrocarbons in the gas mixtures with O₂ as co-reactant (see Figure 17 (a, b) above). The formation and loss mechanisms of the higher hydrocarbon molecules in both gas mixtures are similar to the case of pure CH₄ (see Section 4.5.3.), and will therefore not be discussed here.

At higher initial fraction of CO₂, the recombination of CH₃ towards C₂H₆, C₃H₈ and CH₄ will contribute for 57%, 22% and 19% to the consumption of CH₃, respectively. On the other hand, at a lower initial fraction of CO₂, the recombination towards C₃H₈ will become more important than the recombination to C₂H₆. In a 90/10 CH₄/O₂ gas mixture, thus a lower O₂ content, the recombination towards C₂H₆ and C₃H₈ becomes more important, with contributions of 38% and 30%, respectively, while the three-body

recombination with O₂ molecules, forming CH₃O₂ radicals, contributes for 29% to the consumption of CH₃.

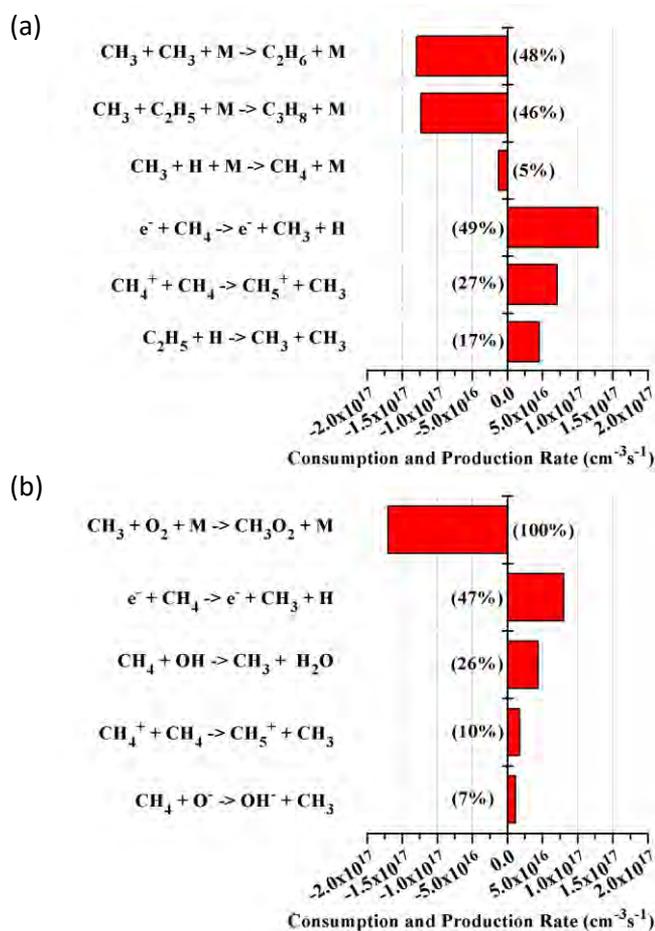


Figure 23. Time-averaged reaction rates of the dominant reaction pathways for the consumption and production of CH₃, for a 70/30 CH₄/CO₂ gas mixture (a) and for a 70/30 CH₄/O₂ gas mixture (b).

(c) Formation of syngas

In Figure 24(a) and Figure 24(b) the most important channels for production and loss of CO in a 70/30 CH_4/CO_2 and a 70/30 CH_4/O_2 gas mixture are illustrated, respectively.

As already mentioned above, the reaction of CO_2 with CH_2 radicals is the most important channel for the production of CO in a 70/30 CH_4/CO_2 gas mixture, with a relative contribution of 37% (see Figure 24(a)). Two other important production mechanisms are the reaction of C_2H_5 with CHO, as well as electron impact dissociation of CO_2 , which contribute for 28% and 13% to the total formation of CO in a 70/30 CH_4/CO_2 gas mixture. In the 70/30 CH_4/O_2 gas mixture, on the other hand, 90% of the CO formation occurs through the reaction of O_2 molecules with CHO radicals. It is thus clear that the chemistry yielding CO formation is completely different in both gas mixtures. Note that in a 20/80 CH_4/CO_2 gas mixture, electron impact dissociation of CO_2 becomes the most important channel for the production of CO.

The same applies to the loss of CO. Indeed, electron impact dissociation and ionization, as well as reactions with H radicals, are the most important loss processes for CO in the CH_4/CO_2 gas mixture, while the reaction with OH radicals is the most important loss process for CO in the CH_4/O_2 gas mixture. However, it is clear from Figure 24 that the total rate for CO formation is a factor 5 and 2.6 higher than the total loss rate, in the CH_4/CO_2 and CH_4/O_2 gas mixtures, respectively.

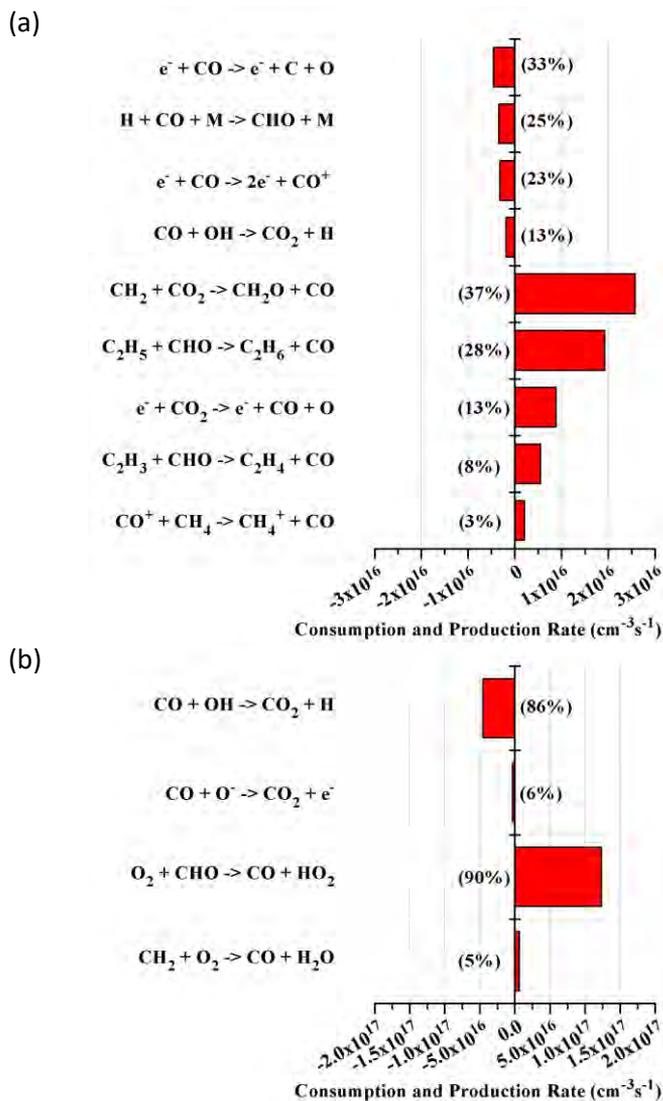


Figure 24. Time-averaged reaction rates of the dominant reaction pathways for the consumption and production of CO, for a 70/30 CH₄/CO₂ gas mixture (a) and a 70/30 CH₄/O₂ gas mixture (b).

Figure 25(a) and Figure 25(b) show the dominant reactions for production and loss of H₂ in a 70/30 CH₄/CO₂ and a 70/30 CH₄/O₂ gas mixture, respectively.

In the 70/30 CH₄/CO₂ gas mixture, electron impact dissociation of C₂H₆ and C₃H₈ are the most important formation channels of H₂, while electron impact dissociation of CH₄ only contributes for 12% (i.e., 8% (towards CH₂ + H₂) + 3% (towards CH + H₂ + H) + 1% (towards C + 2H₂, not shown in Figure 25(a)). In the 70/30 CH₄/O₂ gas mixture, however, electron impact dissociation of CH₄ is clearly most important. Indeed, the higher hydrocarbons are of lower importance in this case (see Figure 17(a, b) above). However, when the initial fraction of O₂ decreases, electron impact dissociation of C₂H₆ and C₃H₈ become the most important formation channels of H₂. Furthermore, electron impact dissociation is the most important loss process for H₂ in both the CH₄/CO₂ and the CH₄/O₂ gas mixture. In the CH₄/CO₂ mixture, the total loss rate is a factor 2 lower than the total production rate, while in the CH₄/O₂ mixture, it is a factor 4 lower. Nevertheless, the overall H₂ production is still much more pronounced in the CH₄/CO₂ mixture than in the CH₄/O₂ mixture (with a total rate of $1.8 \times 10^{17} \text{ cm}^{-3} \text{ s}^{-1}$ vs $4.5 \times 10^{16} \text{ cm}^{-3} \text{ s}^{-1}$; see Figure 25), and this explains the higher H₂ density, as well as the higher H₂/CO molar ratio, in the CH₄/CO₂ mixture. The reason for the higher H₂ production in the CH₄/CO₂ mixture is the higher formation of higher hydrocarbons (see above), which represent additional formation channels for H₂, as is clear from Figure 25(a).

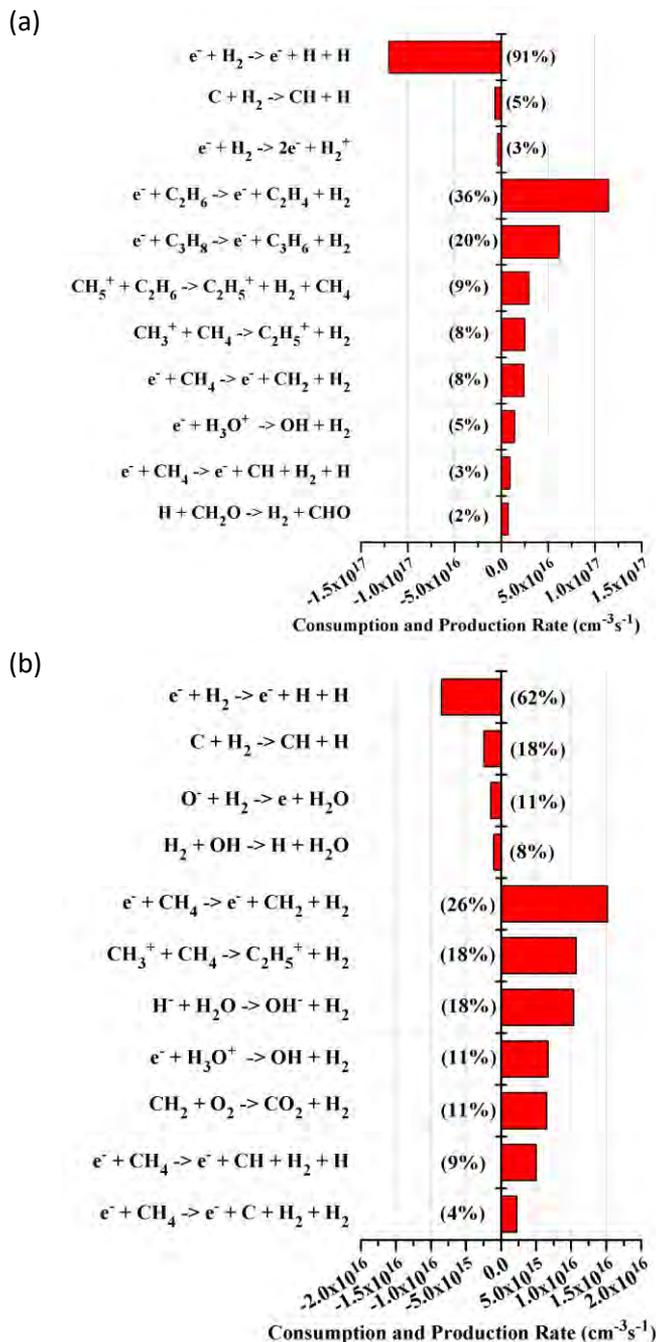


Figure 25. Time-averaged reaction rates of the dominant reaction pathways for the consumption and production of H₂, for a 70/30 CH₄/CO₂ gas mixture (a) and a 70/30 CH₄/O₂ gas mixture (b).

(d) Formation of methanol and formaldehyde

Figure 26(a) and Figure 26(b) illustrate the dominant reactions for production and loss of CH₃OH in a 70/30 CH₄/CO₂ and a 70/30 CH₄/O₂ gas mixture, respectively, while in Figure 27(a) and Figure 27(b) the dominant reactions for production and loss of CH₂O in a 70/30 CH₄/CO₂ and a 70/30 CH₄/O₂ gas mixture are illustrated, respectively.

In the 70/30 CH₄/CO₂ gas mixture, the production of methanol occurs almost entirely through the three-body reaction between the CH₃ and OH radicals, while in the 70/30 CH₄/O₂ gas mixture, methanol is almost entirely formed by the reaction between H₂O and CH₃O radicals. Indeed, the rate of the three-body reaction between the CH₃ and OH radicals is one order of magnitude higher in CH₄/CO₂ than in CH₄/O₂ ($1.1 \times 10^{15} \text{ cm}^{-3} \text{ s}^{-1}$ vs $1.6 \times 10^{14} \text{ cm}^{-3} \text{ s}^{-1}$), but the rate of the reaction between H₂O and CH₃O radicals is four orders of magnitude higher in CH₄/O₂ than in CH₄/CO₂ ($8.5 \times 10^{16} \text{ cm}^{-3} \text{ s}^{-1}$ vs $1.4 \times 10^{12} \text{ cm}^{-3} \text{ s}^{-1}$). When comparing the overall production rates in Figure 26, it is clear that the total CH₃OH production rate is almost two orders of magnitude higher in the CH₄/O₂ mixture than in the CH₄/CO₂ mixture, explaining the higher CH₃OH density and yield in the CH₄/O₂ mixture (see Figure 17 and Table 6 above).

As already mentioned above, the reaction between CO₂ and CH₂ radicals is the most important channel for the production of formaldehyde in the 70/30 CH₄/CO₂ gas mixture, while in the 70/30 CH₄/O₂ gas mixture, formaldehyde is mainly produced by the reactions of O₂ with CH₂OH and CH₃O, with relative contributions of 64% and 23%, respectively. The total production rate of CH₂O is a factor 4 higher in the CH₄/O₂ mixture than in the CH₄/CO₂ mixture, but the total loss rate of CH₂O is a factor 4.6 higher in the CH₄/O₂ mixture than in the

CH₄/CO₂ mixture, explaining the higher CH₂O density and yield in the CH₄/CO₂ mixture (see Figure 17 and Table 6 above).

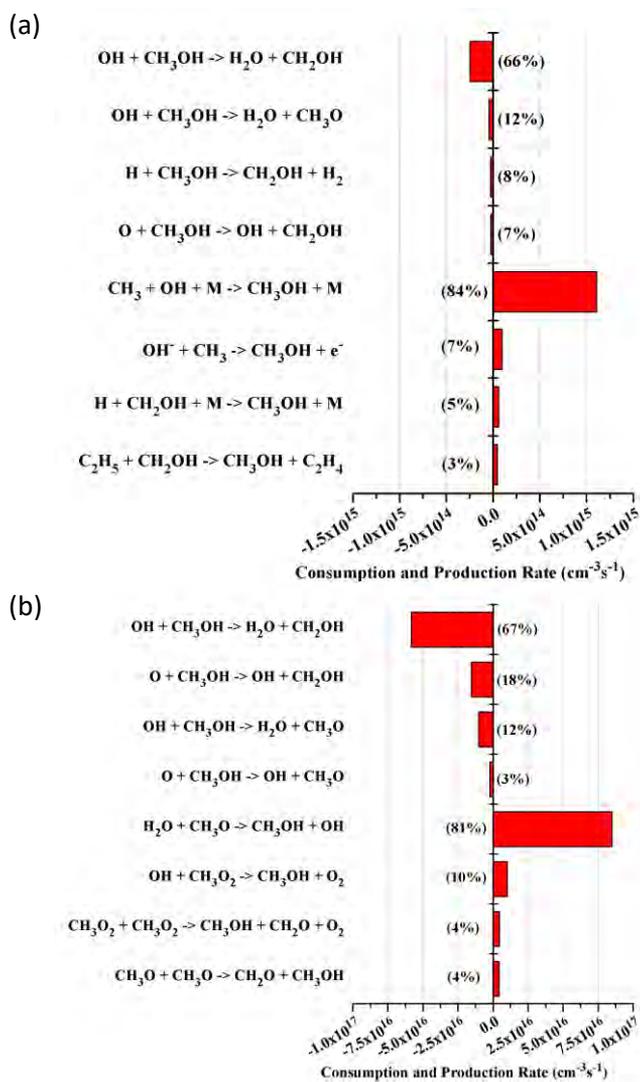


Figure 26. Time-averaged reaction rates of the dominant reaction pathways for the consumption and production of CH₃OH, for a 70/30 CH₄/CO₂ gas mixture (a) and a 70/30 CH₄/O₂ gas mixture (b).

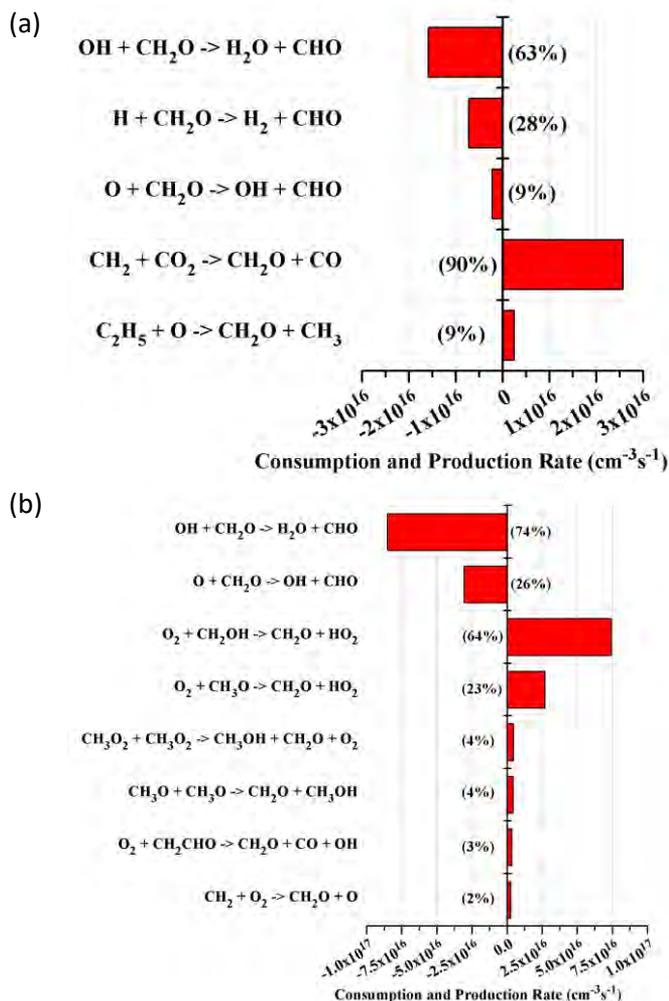


Figure 27. Time-averaged reaction rates of the dominant reaction pathways for the consumption and production of CH_2O , for a 70/30 CH_4/CO_2 gas mixture (a) and a 70/30 CH_4/O_2 gas mixture (b).

The most important loss process in both gas mixtures for both methanol and formaldehyde is the reaction with OH radicals. The overall loss rates are again typically lower than the overall production rates.

Note that for the 70/30 CH_4/O_2 gas mixture the degradation of methanol leads to the formation of CH_2OH (Figure 26(b)), which subsequently reacts to

formaldehyde (Figure 27(b)). The degradation of formaldehyde leads to the formation of CHO, which is subsequently converted to CO (Figure 24(b)). In other words, the formation processes of three of the desired end products (CH₃OH, CH₂O and CO) are dependent on each other in the 70/30 CH₄/O₂ gas mixture, which is in good agreement with the findings of Larkin et al.⁶⁵. The development of a catalyst that activates or inhibits one of the reactions influencing the balance between these molecules should make it possible to favor selectively the formation of one of them.

(e) Summary of the dominant pathways governing the conversion of CH₄ into higher oxygenates

Figure 28 summarizes the dominant reaction pathways for the conversion of CH₄ and CO₂ into higher oxygenates in a 70/30 CH₄/CO₂ gas mixture. The conversion process starts with electron impact dissociation of CH₄, yielding the formation of the CH₃ radicals. The CH₃ radicals will recombine towards higher hydrocarbons, such as C₂H₆ and C₃H₈. Subsequently, a number of dissociation and recombination reactions leads to the conversion towards the other, unsaturated hydrocarbons, and dissociation of CH₄ and the higher hydrocarbons also yields the formation of H₂. The reaction mechanisms towards H₂ and the higher hydrocarbons in the CH₄/CO₂ mixture are exactly the same as in the case of pure CH₄, and thus, more details can be found in Section 4.5.3. above. However, in the CH₄/CO₂ mixture, the CH₃ radicals can also form methanol (CH₃OH) and CH₃O₂ radicals, albeit to a lower extent. Moreover, the CH₂ radicals, which are also formed by electron impact dissociation of CH₄, react with the CO₂ molecules, to form formaldehyde (CH₂O) and CO. Finally, the O atoms, created from electron impact

dissociation of CO_2 , initiate the formation of other oxygenates, like acetaldehyde (CH_3CHO), which also reacts further into CH_3CO radicals, which can subsequently be converted into ketene (CH_2CO). However, this reaction path is not so important, because of the limited formation of O radicals compared to CO and CH_2O out of the CO_2 molecules. H_2 , CO, ethane (C_2H_6), propene (C_3H_6) and CH_2O are the main end products of the conversion of CH_4 and CO_2 in a 70/30 CH_4/CO_2 gas mixture (see also Figure 17 above).

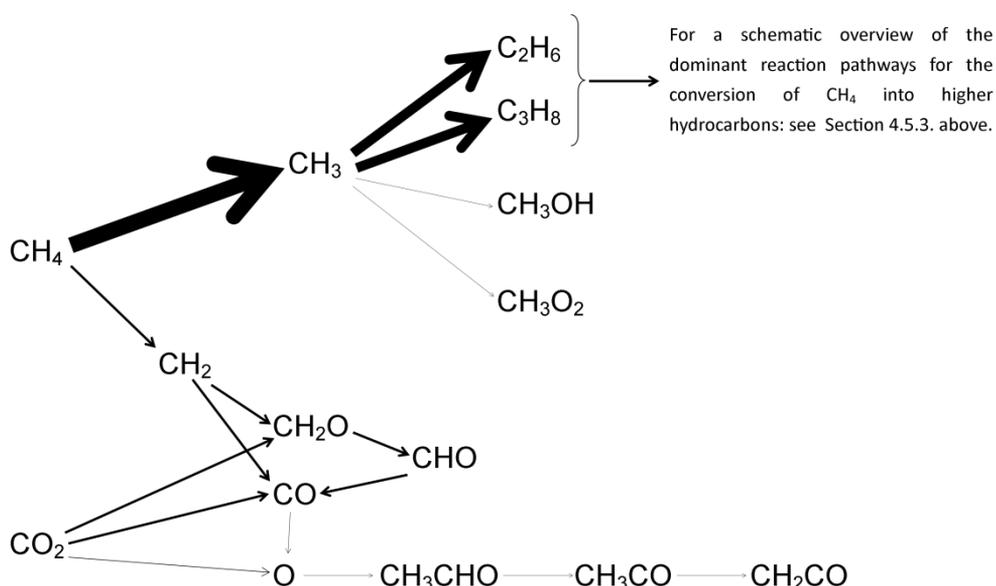


Figure 28. Schematic overview of the dominant reaction pathways for the conversion of CH_4 and CO_2 into higher oxygenates in a 70/30 CH_4/CO_2 gas mixture. The thickness of the arrows is linearly proportional to the rate of the net reaction.

The dominant reaction pathways for the conversion of CH_4 and O_2 into higher oxygenates in a 70/30 CH_4/O_2 gas mixture are schematically illustrated in Figure 29. Again, electron impact dissociation of CH_4 results in the formation of CH_3 radicals. The latter can recombine into methanol or higher hydrocarbons, but more important is the recombination into CH_3O_2 radicals,

which form either CH₃O radicals or methyl hydroperoxide (CH₃OOH). The CH₃O radicals yield the formation of methanol, which can react further into formaldehyde through the CH₂OH radicals, and formaldehyde can further be converted into CO through the CHO radicals (see above). Furthermore, formaldehyde is also partially converted into water. The O₂ molecules are converted into HO₂ radicals, O atoms and CO. They are also converted into O₃ molecules, but the O atoms and O₃ molecules quickly react back into O₂ molecules at a somewhat larger rate, so there is a net formation of O₂ molecules out of O₃ (see the direction of the arrow in Figure 29). This delicate balance between O₂, O and O₃ was also discussed in detail in Aerts et al.¹⁹⁷ CO can be further oxidized into CO₂, which is of course undesired. The O atoms are also converted into CH₃O and OH radicals, which can again form water. The most important products in this CH₄/O₂ mixture are H₂O, CO, CO₂, H₂, O₃, CH₃OH, methyl hydroperoxide (CH₃OOH) and hydrogen peroxide (H₂O₂) (see also Figure 17 above). The reaction scheme revealed by our model for the conversion of CH₄ and O₂ into higher oxygenates is in good agreement with the proposed mechanisms for partial oxidation of CH₄ by Goujard et al.¹⁰⁵ and Zhou et al.¹⁰⁶.

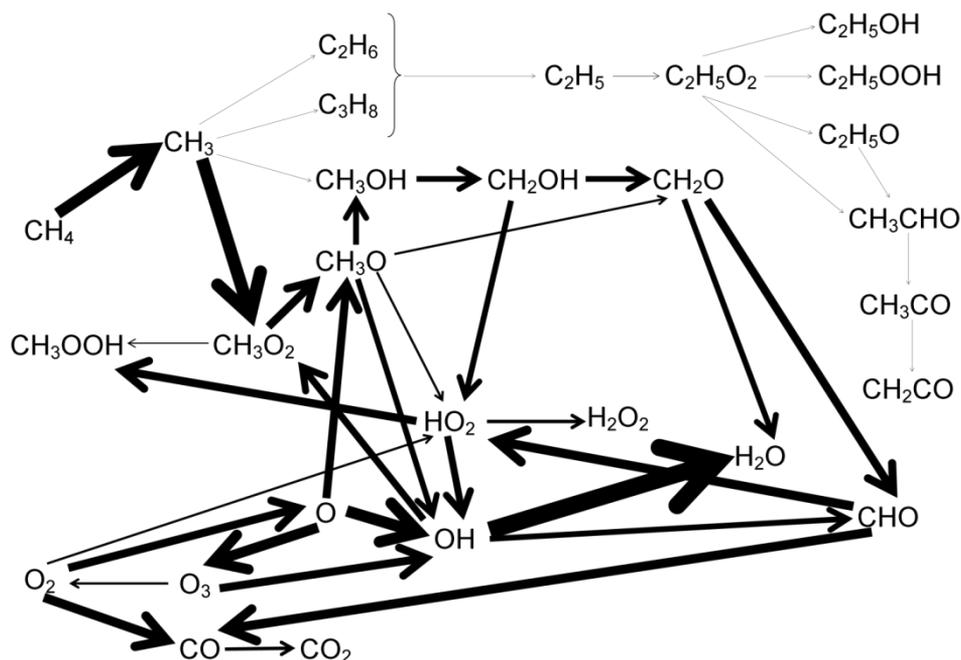


Figure 29. Schematic overview of the dominant reaction pathways for the conversion of CH_4 and O_2 into higher oxygenates in a 70/30 CH_4/O_2 gas mixture. The thickness of the arrows is linearly proportional to the rate of the net reaction.

5.6. Conclusion

In this chapter, we have presented the detailed plasma chemistry in a DBD plasma for the conversion of CH_4 in the presence of O_2 or CO_2 into syngas, higher hydrocarbons and higher oxygenates. We have studied the densities of the various plasma species as a function of residence time and gas mixing ratio. The spatially averaged densities of the electrons, ions and radicals exhibit a periodic behavior as a function of time, following the sinusoidal applied voltage, while the spatially averaged molecule densities do not show a periodic behavior. While the densities of some molecules steadily rise as a function of residence time, the densities of other molecules go over a

maximum, or show a plateau after some time. This is important to realize, as a careful selection of the residence time can entail a higher production of some targeted molecules. We have also presented the densities of all molecules as a function of the initial gas mixing ratio. The mixtures with CO₂ favor the formation of H₂, CH₂O, CH₃CHO and CH₂CO, while the densities of H₂O₂, CH₃OH, C₂H₅OH, CH₃OOH and C₂H₅OOH are higher in the mixtures with O₂. CO is formed at high density in both gas mixtures. Note that in the gas mixtures with O₂ as co-reactant also a significant amount of undesired CO₂ is formed.

The calculated conversions of the inlet gases as a function of residence time and initial gas mixing ratio are also illustrated. The conversion of CH₄ is roughly independent from the initial O₂ or CO₂ fraction (up to 30-40% CO₂), but it increases for higher initial CO₂ fractions, especially above 70%. The conversion of O₂ and CO₂ both decrease with increasing initial O₂ or CO₂ fraction. However, the O₂ conversion is much higher than the CO₂ conversion.

Finally, the underlying plasma chemistry of the conversion process is analyzed in detail, and the dominant reaction pathways for the consumption of CH₄, O₂ and CO₂ and the production and loss of the dominant end products, i.e., CO, H₂, CH₃OH and CH₂O, are discussed. Electron impact dissociation of the inlet gases initiates the conversion process. The recombination of CH₃ radicals plays a crucial role and it was shown that this recombination leads to the formation of higher hydrocarbons in the mixtures with CO₂, while CH₃O₂ radicals are favored in the mixtures with O₂. In the CH₄/CO₂ mixture, also CH₂ radicals play a role, which can be converted into formaldehyde and CO molecules. In the CH₄/O₂ mixture, the CH₃O₂ radicals lead among others to the formation of methanol, which can react further into formaldehyde and the latter can form CO.

Our results are in reasonable agreement with reported results from literature for similar CH_4/O_2 and CH_4/CO_2 discharges. Moreover, our model provides additional information, mainly on the comparison between the formed end products in CH_4/O_2 and CH_4/CO_2 gas mixtures and on the different pathways leading to these products. In this way, the model can help to determine the most suitable feed gas ratio, residence time, co-reactant and other plasma parameters, to obtain the highest yield and/or selectivity of a desired oxygenate. However, as a lot of different products are typically formed in a plasma, the development of a catalyst, which increases the selective formation of some desired oxygenates, will be crucial. Furthermore, besides the conversion, yield and selectivity of specific products, also the energy efficiency of the discharge is critical, to determine whether or not plasma technology can compete with conventional technologies.

Chapter 6

The Hydrogenation of CO₂

The fluid model described in Chapter 3 is applied here to describe the plasma chemistry governing the hydrogenation of carbon dioxide. The spatially averaged densities of the most important end products formed in the CO₂/H₂ mixture are determined as a function of the initial gas mixing ratio. CO and H₂O are found to be present at the highest densities, and to a lower content also CH₄, C₂H₆, CH₂O, CH₃OH, O₂ and some other higher hydrocarbons and oxygenates. The main underlying reaction pathways for the conversion of the inlet gases and the formation of CO, CH₄, CH₂O and CH₃OH are pointed out for various gas mixing ratios. The CO₂ conversion and the production of value-added products is found to be quite low, also in comparison to a CO₂/CH₄ mixture, and this can be explained by the model.

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6.1. Introduction

Current research on the use of plasma for CO₂ conversion includes the splitting of pure CO₂ into CO and O₂^{38, 68, 111, 197-218}, and the direct synthesis of higher hydrocarbons, syngas and oxygenates through the reforming of CH₄ by CO₂^{14, 20-21, 64, 93, 107-109, 135-184} (see Chapter 5) or the hydrogenation of CO₂²¹⁹⁻²²². However, application of the latter is up to now limited because of the high cost of hydrogen.¹³⁶

Recently, the interest in the development of new sustainable industrial processes for the direct hydrogenation of CO₂ into CH₃OH is increasing because of the potential of CH₃OH in a growing hydrogen economy. Moreover, this hydrogenation process is a well-known reaction in catalysis research. In this chapter a modeling study for the hydrogenation of CO₂ in a DBD plasma will be discussed.

Experimental and modeling investigations on the plasma chemistry in CO₂/H₂ mixtures reported in literature are very rare. Eliasson et al.²¹⁹ investigated the hydrogenation of CO₂ to CH₃OH in a DBD with and without the presence of a catalyst. Experimentally the effects of combining a catalyst with a discharge on the yield of CH₃OH were analyzed for different reaction parameters, such as the gas temperature, the pressure, the inlet gas mixing ratio, the electric power and the flow rate of the feed gas. Furthermore, a simplified semi-empirical kinetic model was used to simulate the accumulated chemical action of many microdischarges, in order to calculate the CH₃OH yield in the CO₂/H₂ discharge. A radical reaction mechanism was proposed for the formation of CH₃OH. Liu et al.²²³ discussed in a review paper the use of non-thermal plasmas for CO₂ utilization, including the hydrogenation of CO₂

to form CH₃OH in a DBD, referring thereby to the work of Eliasson et al.²¹⁹. Hayashi et al.²²⁰ discussed the decomposition of CO₂ in the presence of H₂ or water vapor by a non-thermal plasma, produced by a surface discharge at atmospheric pressure. CO, CH₄, dimethyl ether (C₂H₆O), formic acid (HCOOH) and water vapor were detected as end products of a gas mixture of 50% CO₂ and 50% H₂. Kano et al.²²¹ studied the reforming of CO₂ by H₂ to CH₄ and CH₃OH by using a radio frequency impulse low-pressure discharge under different discharge parameters. CH₄, CO, CH₃OH and water vapor were found as end products. Recently Zeng et al.²²² investigated the plasma-catalytic CO₂ hydrogenation in a coaxial packed-bed DBD at low temperatures and atmospheric pressure. The performance of different γ -Al₂O₃ supported metal catalysts on the conversion of CO₂ was studied. The reverse water-gas shift reaction, i.e. the formation of CO and H₂O, as well as carbon dioxide methanation, i.e. the formation of CH₄ and H₂O, have been reported as the dominant reaction processes. The results also show that the H₂/CO₂ molar ratio significantly affects the conversion of CO₂ and the yields of CO and CH₄.

In this chapter we present the most important results on the conversion of CO₂, in the presence of H₂, into CO, higher hydrocarbons and higher oxygenates. The chemistry set is almost the same as used for the CH₄/O₂ and CH₄/CO₂ gas mixtures (see Chapter 5 above and Section 6.2. below). The formation of a variety of higher hydrocarbons and higher oxygenates in CO₂/H₂ for different gas mixing ratios is calculated, as well as the conversion of the inlet gases. These results will be compared with the experimental observations from the papers mentioned above on CO₂/H₂ gas discharges, as well as with earlier calculated results with the same model for a CH₄/CO₂ gas mixture (see Chapter 5). Furthermore, the main underlying pathways

governing the conversion of CO₂ with H₂, into the main reaction products, i.e., CO, CH₄, CH₂O and CH₃OH, are discussed in order to explain the product formation in the different gas mixing ratios and to reveal why some oxygenates are formed while others seem not to be formed.

6.2. Species Included in the Model

As mentioned above, the chemistry set used for the CO₂/H₂ gas mixture is almost identical to the one constructed for the CH₄/O₂ and CH₄/CO₂ gas mixture, except for some adaptations of the third body species in the neutral-neutral three-body collision reactions, where CO₂ and H₂ are now included as third body instead of CH₄, O₂, CO₂ and H₂O, with the same rate coefficients. In total, 75 species (electrons, molecules, ions and radicals) are included in the model, as presented in Table 5 above. Note that dimethyl ether (CH₃OCH₃) and formic acid (HCOOH), which were experimentally found by Hayashi et al.²²⁰, as mentioned above, are not included in the model as the rate constants for the formation and loss processes for these molecules are not well known. As a consequence, our model will not be able to make predictions on the formation of these products. We expect that these species would anyway play a minor role in the chemistry, especially as intermediates. They might be potential end products, but we don't expect their densities to be higher than e.g., CH₄, CH₃OH and CH₂O, and certainly much lower than e.g., CO.

6.3. Reactions Included in the Model

As mentioned in Chapter 5, the 75 species included in the model interact with each other in 963 gas phase reactions, including 157 electron-neutral, 48 electron-ion, 420 neutral-neutral and 338 ion-ion or ion-neutral reactions. Detailed information on the construction of the chemistry set and the transport coefficients and wall interaction coefficients used in the model can be found in Section 5.3. and Section 3.5., respectively.

6.4. Operating Conditions

The calculations are again carried out for a gas residence time up to 20s, at a fixed applied voltage of 5 kV and a frequency of 10 kHz, like in the previous chapter. The CO₂ fraction in the CO₂/H₂ mixture is varied from 10 to 90%.

6.5. Results and Discussion

6.5.1. Densities of the Plasma Species

The spatially averaged electron density and the densities of the radicals and ions produced in the plasma exhibit periodic behavior as a function of time, following the period of the applied sinusoidal voltage. The overall spatially and time averaged electron density for all CO₂/H₂ gas mixtures under study amounts to ca. 10^{15} m^{-3} , while the overall spatially and time averaged mean electron energy varies between 1.9eV and 2.7 eV. These results are similar to the values calculated in pure CH₄ (see Section 4.5.1.) and in the CH₄/O₂ and

CH₄/CO₂ gas mixtures (see Section 5.5.1.). More information on the periodic behavior of the electron density, and of the various ion densities, can thus be found in Section 4.5.1. and in Section 5.5.1. above.

Figure 30 illustrates the periodic behavior of the most important radical densities for a 50/50 CO₂/H₂ gas mixture, on a logarithmic scale, for four periods of the applied voltage. The periodic trend is here superimposed on a rising or declining trend, acting over a longer time-scale until periodic steady state is reached. The most abundant radicals are H, O, OH, HO₂, CHO, CH₃ and CH₂, with overall spatially and time averaged densities up to about 10²⁰ m⁻³. Most of these radicals do not vary a lot as a function of time within one period, except for the CH₂ radicals. This is because the formation of all these radicals proceeds in a quite similar way, i.e. either directly or indirectly related to electron impact dissociation of the inlet gases. However, CH₂ is rapidly destructed in reactions with CO₂, one of the inlet gases, which is thus present at high density, explaining the significant drop in the CH₂ density as a function of time, while H, O, OH, HO₂, CHO and CH₃ react away through collisions with other radicals or molecules at lower densities. The most abundant radicals will determine the different reaction pathways for the formation of different end products (see below). Compared to our previous results for the CO₂/CH₄ mixture (see Section 5.5.1.), the higher order hydrocarbon radicals, such as C₂H₅ and C₂H₃, as well as the oxygenate radicals, such as CH₃O, CH₂OH and CH₃O₂, are formed to a lower extent in CO₂/H₂, which is logical, as there is no hydrocarbon precursor (CH₄) in the inlet gas mixture, resulting in a lower overall carbon fraction than in CO₂/CH₄.

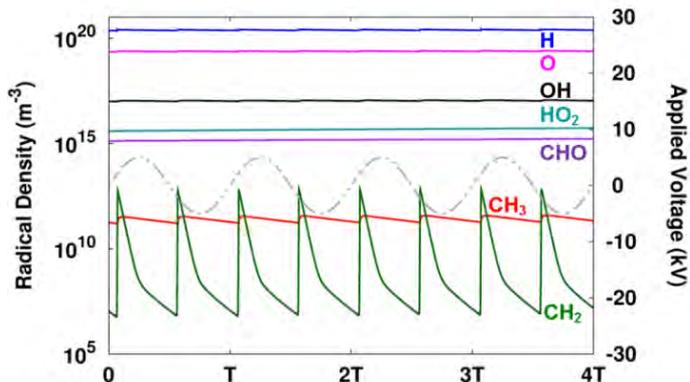


Figure 30. Spatially averaged radical densities (left axis) as a function of time for a 50/50 CO₂/H₂ gas mixture, on a logarithmic scale, as well as the applied sinusoidal voltage (gray, right axis) for four periods of the applied voltage.

The spatially and time averaged densities of the most abundant radicals in CO₂/H₂ are plotted in Figure 31 as a function of the initial CO₂ content in the mixture. Upon rising the initial fraction of CO₂ between 10 and 90 %, the densities of the H, CH₃ and CH₂ radicals drop by one order of magnitude, because these radicals are directly or indirectly formed out of H₂. On the other hand, the densities of O, OH, HO₂ and CHO, as well as the other O-containing radicals (not shown), increase by one order to several orders of magnitude upon rising the inlet fraction of CO₂, as they are directly or indirectly formed out of CO₂.

The most abundant ion in the CO₂/H₂ gas mixture is H₃O⁺, with a spatially and time averaged density in the order of 10¹⁵ m⁻³, hence comparable to the electron density (cf. above). The other ion densities are two or even more orders of magnitude lower, and thus the ion densities are much lower than the spatially and time averaged densities of the most abundant radicals, indicating that the ions play a minor role in the plasma chemistry (see also

Section 6.5.3. below). Therefore, we do not go in further detail on the ion densities.

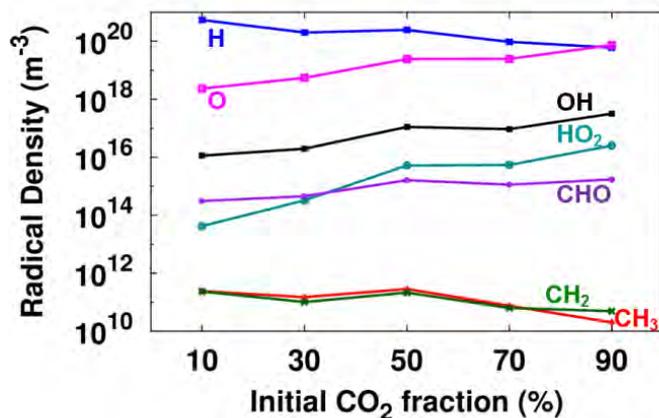


Figure 31. Spatially and time averaged radical densities as a function of the initial CO₂ fraction in the CO₂/H₂ gas mixture.

The densities of the stable molecules do not exhibit a periodic behavior like the electrons and the radicals. The reason is that their formation rates are typically much larger than their loss rates, in contrast to the radicals and ions. The densities of the molecules formed during the hydrogenation of CO₂, i.e., CO, higher order hydrocarbons and oxygenates, exhibit a rising trend as a function of time, because their net production is higher than their net consumption. This will continue until periodic steady state will be reached. Indeed, when the densities of the reaction products rise, the rates of their consumption reactions will rise as well, until a balance is reached between production and consumption. The inlet gases, on the other hand, have a higher net consumption, so their densities show a gradual decrease as a function of time again until periodic steady state will be reached. The

conversion is most pronounced in the first few seconds, and afterwards the densities of the molecules do not significantly change anymore for a longer residence time, as is clear from Figure 32, for both CO₂ and H₂, and the most abundant products.

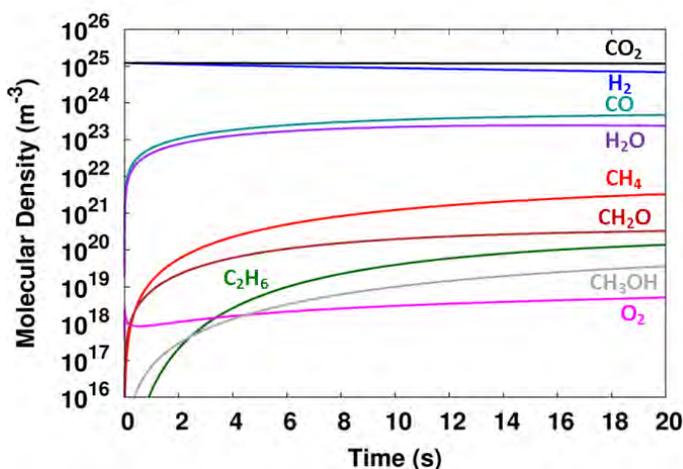


Figure 32. Spatially averaged molecular densities as a function of the residence time for a 50/50 CO₂/H₂ gas mixture.

Figure 33 illustrates the densities of the various molecules in the CO₂/H₂ gas mixture as a function of the initial CO₂ fraction, after a residence time of 5 seconds. The most abundant reaction products are CO, H₂O, CH₄, CH₂O, C₂H₆, O₂ and CH₃OH (more or less in order of decreasing density). This is in good agreement with the end products reported by Eliasson et al.²¹⁹, i.e. CH₄ and CH₃OH, Hayashi et al.²²⁰, i.e. CO and CH₄, Kano et al.²²¹, i.e. CO, CH₄ and CH₃OH, and Zeng et al.²²², i.e. CO and H₂O as major products, a small amount of CH₄ and traces of C₂H₆, for similar CO₂/H₂ discharges. Note that Hayashi et al.²²⁰ also detected the formation of dimethyl ether and formic acid, which are not included in our model as mentioned above. However, our model provides

us more insight in the formation of other higher hydrocarbons and oxygenates. The densities of CO and H₂O, which are by far the most abundant products, are almost not influenced by the inlet fraction of CO₂ (see Figure 33(a)). For H₂O, a maximum is obtained at an initial CO₂ fraction of 50%. This can be explained because H₂O is formed out of the collision of OH and H radicals. From Figure 31 it is clear that the H density decreases while the OH density increases with increasing initial CO₂ fraction, resulting in an optimum ratio at an inlet concentration of 50% CO₂. Furthermore, as will be clear from Section 6.5.2. below, the CO₂ conversion drops upon increasing initial CO₂ fraction in the mixture, and thus, the same applies to the yield of CO. On the other hand, a higher initial CO₂ fraction in the mixture allows for more CO₂ to be converted, and as both effects compensate each other, the effective CO₂ conversion remains constant, explaining why the CO density is constant for all CO₂/H₂ gas mixtures (see Figure 33(a)).

On the other hand, the densities of O₂, H₂O₂ and O₃ increase by several orders of magnitude upon increasing initial fraction of CO₂, which is logical, as they are directly formed out of the CO₂ splitting products (O and O₂). The densities of the higher hydrocarbons (C_xH_y) generally drop upon increasing initial fraction of CO₂, which can be explained by the higher conversion of CO₂ at lower initial fraction of CO₂ (see Section 6.5.2. below) resulting in higher densities of CH₂ and CH₃ radicals, as is clear from Figure 31 above, which are the building blocks for the higher hydrocarbons. However, an optimum seems to be reached for the 50/50 CO₂/H₂ gas mixture (see Figure 33(b)). Indeed, these higher hydrocarbons need the C from CO₂ as their building block, but they also need the H originating from H₂, and therefore an equal presence of both inlet gases seems to be preferable.

The same is true for the densities of CH₂O and CH₃OH and the other oxygenates, as is clear from Figure 33(c), although the hydroperoxides (CH₃OOH and C₂H₅OOH) generally increase with rising initial fraction of CO₂. Compared to our previous results on the formation of higher hydrocarbons and oxygenates in CH₄/O₂ and CH₄/CO₂ mixtures (see Section 5.5.1.), it is clear that except for CO and H₂O, the densities of the most important end products are now several orders of magnitude lower. The reason for this is that the conversion of CO₂ is very low in all gas mixtures (see Section 6.5.2. below), while CH₄ as C building block was more easily converted (see Section 5.5.2. above), and therefore, the crucial radicals in the formation process of higher hydrocarbons and oxygenates, such as CH₂ and CH₃, can be produced at a much higher density in mixtures with CH₄ than in the CO₂/H₂ mixture under study here. Note that the trends illustrated in Figure 33 correspond to a residence time of 5 seconds; however, the different molecules might have their maximum densities at a different residence time for the different gas mixing ratios studied (see also Section 5.5.1.); therefore the trends depicted in Figure 33 are not necessarily the same at other residence times.

Altering the inlet gas mixing ratio also affects the H₂/CO (syngas) ratio. A variable H₂/CO molar ratio is useful, as it allows the mixture to be used for various industrial synthesis processes (see Section 5.5.1.). The H₂/CO ratio, as obtained from our calculations, decreases with increasing initial CO₂ fraction, which is logical. It ranges from 54 (at 10% CO₂), which is not useful for industrial synthesis processes, to 3 (at 90% CO₂), which can be of interest as this is similar to the molar ratio produced by steam reforming (see Section 5.5.1.).

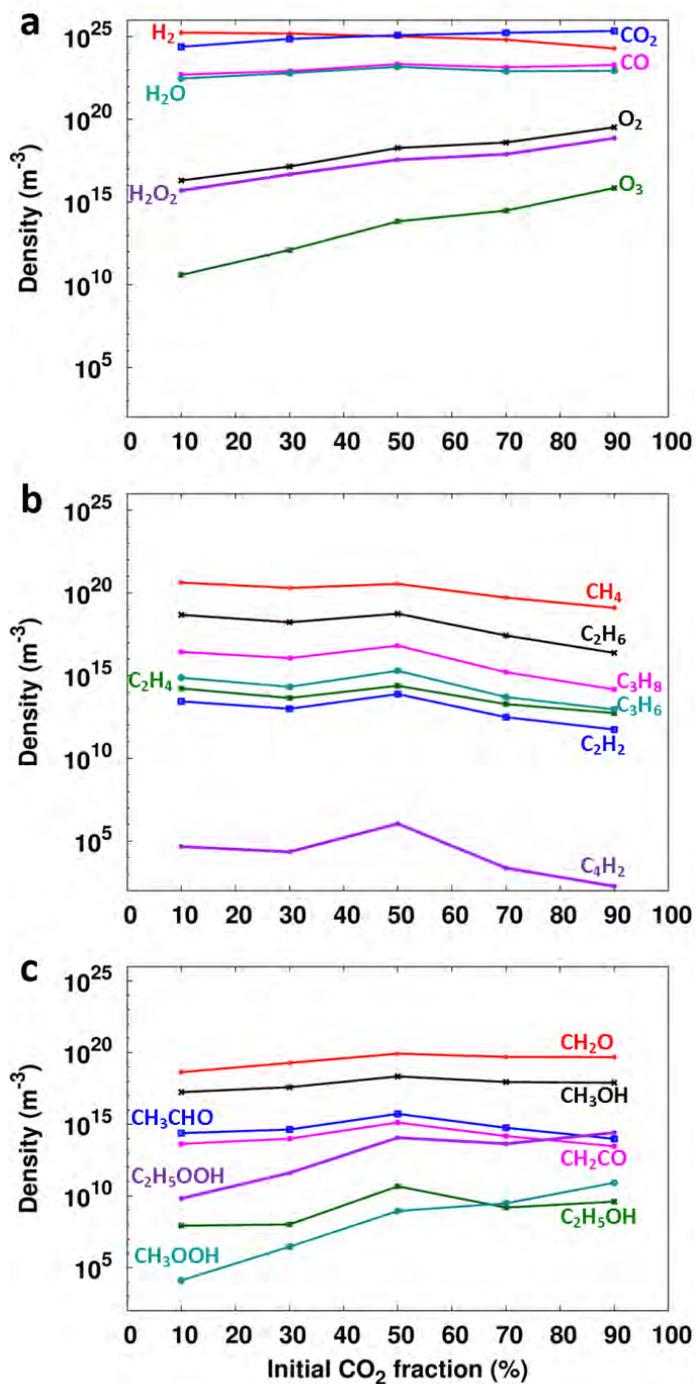


Figure 33. Spatially averaged molecule densities as a function of the initial CO₂ fraction in the CO₂/H₂ gas mixture, after a residence time of 5 seconds.

6.5.2. Conversion, Yields and Selectivities

Table 7 shows the maximum conversions of the inlet gases, i.e. CO₂ and H₂, and the maximum yields and corresponding selectivities of CO and CH₄, for different CO₂/H₂ gas mixtures. These maximum values are in all cases obtained for a residence time of 20s. The conversion of CO₂ clearly decreases with increasing initial CO₂ fraction in the mixture, from 7% at 10% CO₂ in the mixture to roughly 2% at 90% CO₂ in the mixture. This trend is in good agreement with the results of Zeng et al.²²², who reported that the conversion of CO₂ increases almost linearly with the increase of the H₂/CO₂ molar ratio at a fixed flow rate. A similar trend was also observed in CO₂/CH₄ (see Section 5.5.2. above), but the conversion of CO₂ was a factor 3 higher at a high initial CH₄ fraction (i.e., 90%) compared to a high initial H₂ fraction of 90%. This can be explained because CH₂, which is a direct dissociation product of CH₄, is much more abundant in CO₂/CH₄ than in CO₂/H₂, and thus provides an extra and very important loss process for CO₂ in a CO₂/CH₄ mixture (see Section 5.5.). The H₂ conversion is significantly larger, i.e., between 30 and 60 %, but no clear trend can be observed as a function of gas mixing ratio, because the discharge characteristics are strongly affected by the initial gas mixing ratio. As CO is directly produced by electron impact dissociation of CO₂ (see Section 6.5.3. below), the yield of CO shows the same trend as the conversion of CO₂, with values of only 2-6 %. Moreover, CO is the only C containing molecule directly produced out of CO₂ and therefore the selectivity of CO is in all cases around 90%. CH₄ is only formed with a selectivity above 1% at a low initial CO₂ fraction, i.e. a high initial H₂ fraction, which is logical. The yields of C₂H₆, CH₂O and CH₃OH are one or two orders of magnitude lower than the yield of CH₄, while the yields of other higher hydrocarbons and oxygenates are even more

negligible, which is of course the direct result of the rather low conversion of CO₂ in all gas mixing ratios. Note that also some sticking of the C atoms and hydrocarbon species at the walls occurs, which explains why the sum of the selectivities is not equal to 100 %. This formation of a C-containing layer on the electrodes was indeed also experimentally observed in the DBD reactor under study for a pure CO₂ discharge.^{214, 224}

Table 7. Overview of the maximum conversions of the inlet gases, i.e. CO₂ and H₂, and the maximum yields and corresponding selectivities of CO and CH₄ for different CO₂/H₂ gas mixtures. All values are noted as percentage.

Initial CO ₂ fraction	X (CO ₂)	X (H ₂)	Y (CO) - S (CO)	Y (CH ₄) - S (CH ₄)
10	7.0	64	6 - 86	0.2 - 2.2
30	3.6	33	3 - 90	0.03 - 0.9
50	4.4	44	4 - 87	0.03 - 0.6
70	2.1	33	2 - 89	0.003 - 0.2
90	1.9	58	2 - 92	0.0003 - 0.02

6.5.3. Dominant Reaction Pathways

To better explain the above trends, and to find out how the densities of the most important products can be optimized, it is crucial to obtain a better insight in the underlying reaction chemistry. Therefore, we will now discuss the dominant reaction pathways for the conversion of the inlet gases into the most important value-added products, i.e., CO, CH₄, CH₃OH and CH₂O, for the entire range of gas mixing ratios.

(a) Dissociation of CO₂ and H₂

The dominant reactions for CO₂ consumption (and production), as well as the time-averaged total production rate, total loss rate and net loss rate, as a function of the initial CO₂ fraction in the gas mixture are depicted in Figure 34. Although the consumption of CO₂ is mostly relevant in this work, we also show the production processes, because part of the CO₂ dissociation products will again recombine into the formation of CO₂. However, the total loss rate is larger than the total production rate, as is clear from Figure 34, thus leading to a net loss of CO₂ (i.e., conversion into other products). Furthermore, the total formation and loss rate generally increase upon larger initial CO₂ fraction in the mixture, which is logical. The most important channel for consumption of CO₂ is electron impact ionization towards CO₂⁺. However, CO₂⁺ immediately reacts back towards CO₂ upon charge transfer with H₂O molecules. Therefore, the most important reaction for consumption of CO₂ is effectively electron impact dissociation towards CO. This result was also obtained in earlier simulations carried out in our group for pure CO₂ splitting.¹⁹⁷ Furthermore, the relative importance of the various consumption and production processes is more or less independent from the gas mixing ratio, as is clear from Figure 34.

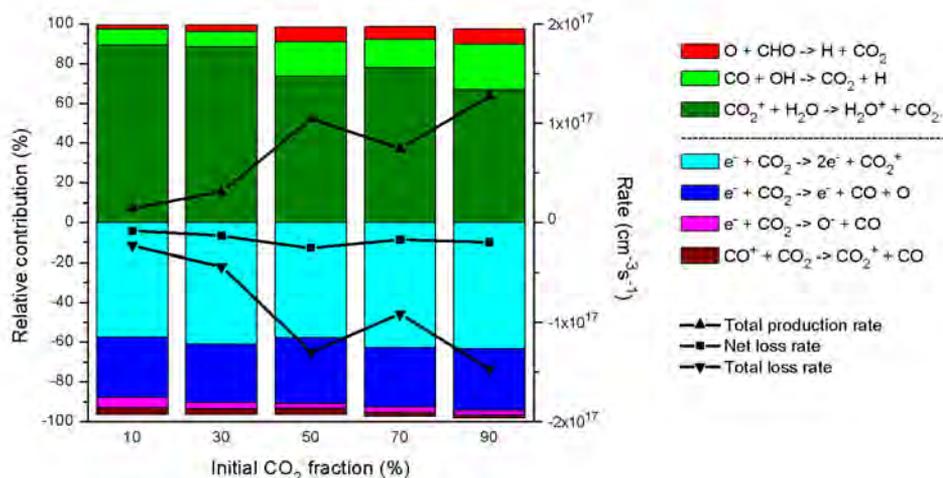


Figure 34. Relative contributions of the various production and consumption processes of CO₂ (left axis), as well as the time-averaged total production rate, total loss rate and net loss rate (right axis), as a function of the initial CO₂ fraction in the CO₂/H₂ gas mixture. The production rates are defined as positive values, while the consumption rates are plotted as negative values.

In Figure 35 the most important reactions for consumption (and production) of H₂ are shown. At an initial CO₂ inlet fraction of 10%, electron impact dissociation is the most important loss process for H₂, but part of the H atoms will recombine back into H₂, or react with CHO radicals into H₂ and CO. At an inlet fraction of 90% CO₂ the reaction of H₂ with H₂O⁺ towards H₃O⁺ becomes the most important loss mechanism. However, the latter is not due to the high absolute rate of this reaction, but rather because the rate of electron impact dissociation drops. Indeed, it is clear from Figure 35 that the total loss rate of H₂ is much lower at 90% than at 10% CO₂ content, because there is of course less H₂ in the mixture. Nevertheless, from comparing Figure 34 and Figure 35 it is clear that the net consumption of H₂ is much higher than the net consumption of CO₂. Indeed, the net loss rate of H₂ drops from

$7 \times 10^{17} \text{ cm}^{-3} \text{ s}^{-1}$ at 10% CO₂ to $7 \times 10^{16} \text{ cm}^{-3} \text{ s}^{-1}$ at 90% CO₂, while the net loss rate of CO₂ is virtually constant around $10^{16} \text{ cm}^{-3} \text{ s}^{-1}$ for all gas mixing ratios. This explains also why the conversion of H₂ is much higher than the conversion of CO₂ (see Section 6.5.2. above).

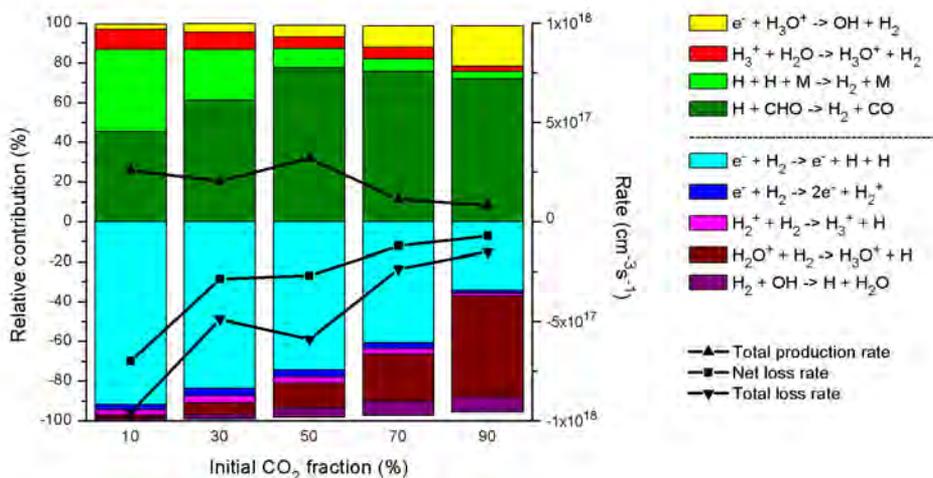


Figure 35. Relative contributions of the production and consumption processes of H₂ (left axis), as well as the time-averaged total production rate, total loss rate and net loss rate (right axis), as a function of the initial CO₂ fraction in the CO₂/H₂ gas mixture.

(b) Formation of CO, CH₄, CH₂O and CH₃OH

In Figure 36 the most important channels for the production (and loss) of CO are illustrated as a function of the initial CO₂ fraction in the gas mixture. The most important production process appears to be the reaction between H atoms and CHO radicals, forming H₂ and CO, but this reaction is counterbalanced by the most important loss process, i.e., the recombination of H with CO into CHO radicals. Therefore the most important effective

reaction for the formation of CO is electron impact dissociation of CO₂. On average there is a net formation of CO, with a rate in the order of $10^{16} \text{ cm}^{-3} \text{ s}^{-1}$, slightly increasing upon higher initial CO₂ fraction in the mixture, which is logical.

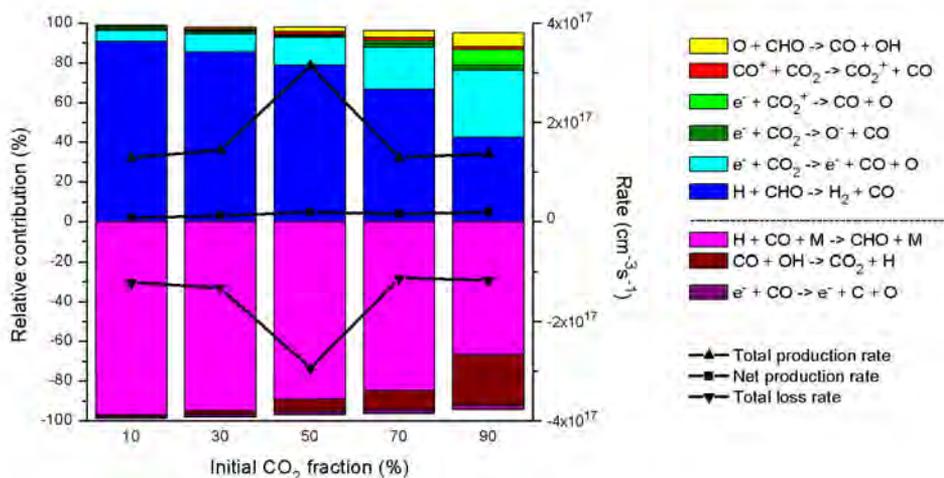


Figure 36. Relative contributions of the production and consumption processes of CO (left axis), as well as the time-averaged total production rate, total loss rate and net production rate (right axis), as a function of the initial CO₂ fraction in the CO₂/H₂ gas mixture.

The most important reactions for production (and loss) of CH₄ are depicted in Figure 37 as a function of the initial CO₂ fraction in the gas mixture. The production of CH₄ seems to be driven by only two reactions, i.e., the three-body recombination reaction between CH₃ and H radicals, and at a lower initial fraction of CO₂ also the charge transfer reaction between CH₅⁺ and H₂O. However, the latter reaction is partially balanced by the loss of CH₄ via a charge transfer reaction with H₃⁺. At a higher initial CO₂ fraction, the charge transfer reaction with CO₂⁺ becomes the most important loss mechanism for

CH₄. A similar trend is observed for the net production rate of CH₄ as a function of the initial CO₂ fraction as for the net loss rate of H₂ (see Figure 35 above). Indeed, the dissociation of H₂ leads to the formation of H radicals which are needed for the formation of CH₄. An optimum is obtained for an initial CO₂ fraction of 10%, as is logical, and can be explained by the maximum densities found for the CH₃ and H radicals, as shown in Figure 31 above.

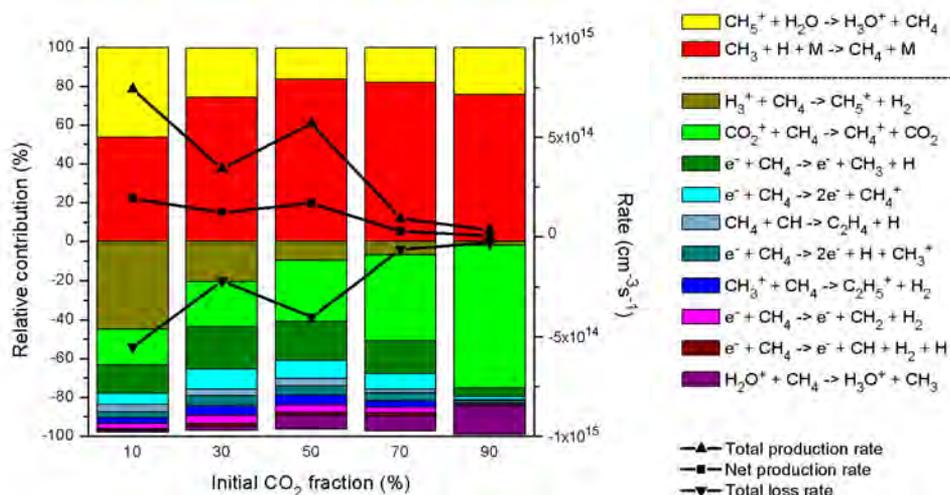


Figure 37. Relative contributions of the production and consumption processes of CH₄ (left axis), as well as the time-averaged total production rate, total loss rate and net production rate (right axis), as a function of the initial CO₂ fraction in the CO₂/H₂ gas mixture.

Figure 38 and Figure 39 show the dominant reactions for production (and loss) of CH₂O and CH₃OH, respectively, as a function of the initial CO₂ fraction in the gas mixture. The reaction between CO₂ and CH₂ radicals appears to be the most important channel for the production of formaldehyde at low initial CO₂ fractions, as was also observed for a CO₂/CH₄ mixture (see Section 5.5.3.). At higher initial CO₂ fractions, CH₂O is also formed to some extent out of two

CHO radicals. Furthermore, CH₂O is mainly lost upon collision with H atoms, yielding CHO and H₂, although the collisions with O atoms or OH radicals, yielding CHO and OH or H₂O, respectively, become gradually more important at higher CO₂ fractions, which is logical.

The total formation and loss rates reach a clear maximum at 50% CO₂ in the mixture, which is explained by the fact that at these conditions an optimum ratio of CH₂ (see maximum in Figure 31 above) and CO₂ is present in the gas mixture. As the total formation and loss rates are more or less equal to each other, the net formation rate of CH₂O is very low, and increases from 10¹¹ to 10¹³ cm⁻³s⁻¹ upon rising CO₂ fraction. This explains why the CH₂O density rises slightly upon increasing CO₂ fraction in the mixture, as illustrated in Figure 33 above.

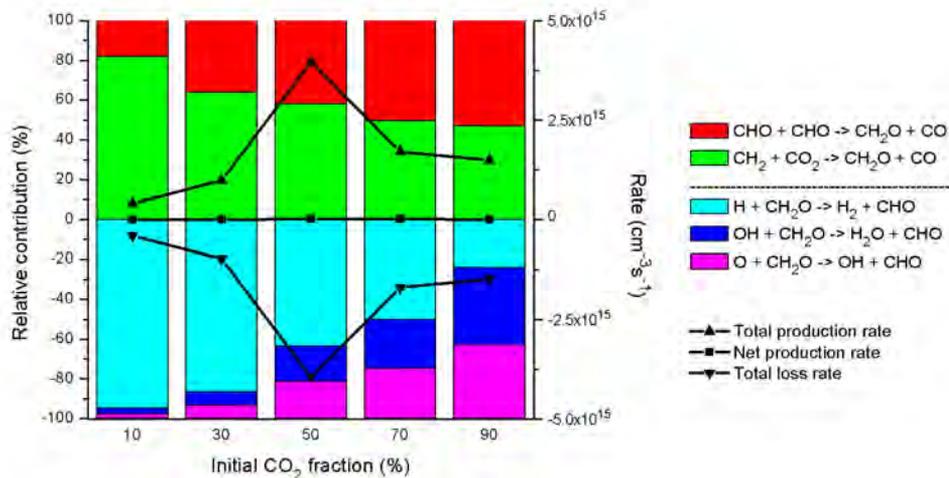


Figure 38. Relative contributions of the production and consumption processes of CH₂O (left axis), as well as the time-averaged total production rate, total loss rate and net production rate (right axis), as a function of the initial CO₂ fraction in the CO₂/H₂ gas mixture.

As is clear from Figure 39, the most important channel for the production of methanol, as predicted by our model, is the three-body reaction between CH₃ and OH radicals, like was also the case in the CO₂/CH₄ mixture studied before (see Section 5.5.3.). However, different from the CO₂/CH₄ mixture, the three-body reaction between CH₂OH and H radicals is now also an important production channel. Most of the CH₃OH produced, is also consumed again upon collision with either H atoms, OH radicals or O atoms, so the net formation rate of CH₃OH varies from 10¹¹ to 10¹² cm⁻³s⁻¹. An optimum production of CH₃OH is again observed at 50/50 CO₂/H₂, because at these conditions an optimum ratio of CH₃ and OH (see Figure 31 above) is present in the gas mixture, and this explains why the CH₃OH density reaches a maximum at this mixing ratio, as shown in Figure 33 above.

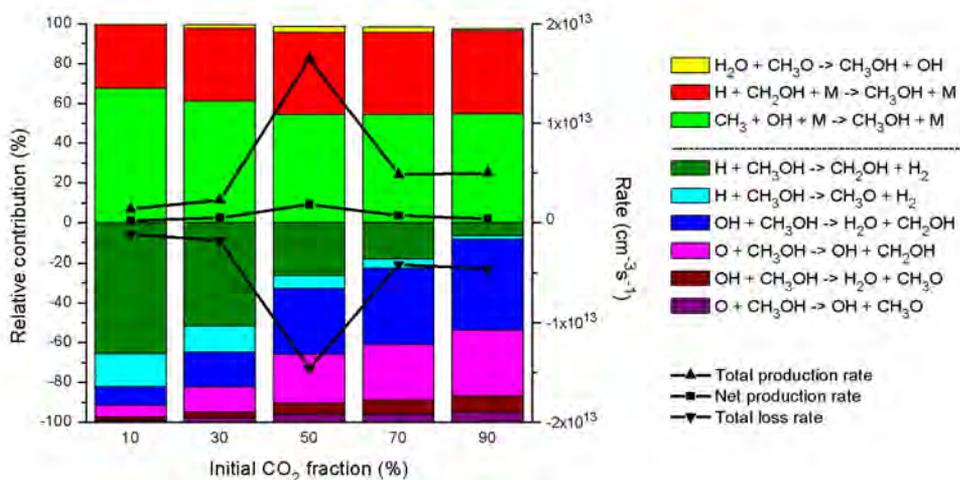


Figure 39. Relative contributions of the production and consumption processes of CH₃OH (left axis), as well as the time-averaged total production rate, total loss rate and net production rate (right axis), as a function of the initial CO₂ fraction in the CO₂/H₂ gas mixture.

(c) Overall reaction mechanism for the hydrogenation of CO₂ into valuable products

Figure 40 summarizes the dominant reaction pathways for the conversion of CO₂ and H₂ in a 50/50 CO₂/H₂ gas mixture. Note that the thickness of the arrow lines is proportional to the rates of the net reactions. The conversion starts with electron impact dissociation of CO₂, yielding CO and O radicals. Simultaneously, and much more pronounced, is the electron impact dissociation of H₂, resulting in the formation of H radicals (cf. the thickness of the arrow line). Radical recombination reactions of the O and H radicals lead to the formation of OH radicals, which recombine further into H₂O, and this explains why H₂O is also formed at relatively high density, as shown in Figure 33 above. However, this is of course of lesser interest than CO as valuable product.

CO will partially react back into CO₂, mainly through the formation of CHO radicals. Note that in this gas mixture, the major reaction from CO back into CO₂ indeed proceeds through CHO, as the rate of the reaction (CO + H + M → CHO + M) is in the order of 10¹⁷ cm⁻³ s⁻¹, and the rate of the subsequent formation of CO₂ through the reaction (CHO + O → CO₂ + H) is about 7x10¹⁵ cm⁻³ s⁻¹, while the rate of the direct reaction (CO + O + M → CO₂ + M) is only in the order of 10¹⁵ cm⁻³ s⁻¹. The H atoms thus contribute significantly to the back reaction of CO into CO₂. It is clear from the thick arrow line from H to CHO in Figure 40 that the formation of CHO out of CO and H indeed occurs at a very high rate. The reason why the arrow line from CO to CHO is much thinner is because CHO also reacts back into CO upon collision with H (CHO + H → CO + H₂), so the net reaction from CO to CHO is smaller than the net reaction from H to CHO. Furthermore, electron impact dissociation of CO

results in the formation of C radicals, which react further into CH, CH₂, C₂HO and CH₃ radicals in several successive radical recombination reactions. The formed CH₂ radicals react with CO₂ into the formation of CH₂O, as was also shown in Figure 38 above. The CH₃ radicals easily form CH₄, which is much more favored (i.e., the rate is one order of magnitude larger) than the formation of CH₃OH out of CH₃. CH₄ partially reacts further into higher hydrocarbons (C_xH_y).

From the reaction scheme, it is clear that a lot of subsequent radical reactions are necessary for the formation of (higher) hydrocarbons and oxygenates, such as CH₄, C₂H₆, CH₂O and CH₃OH, which explains the very low yields and selectivities of these end products (see Section 6.5.2. above). Indeed, the lack of direct formation of CH₂ and CH₃ in CO₂/H₂, which is important in CO₂/CH₄ gas mixtures (see Section 5.5.), combined with the very low conversion of CO₂, which is again due to the absence of CH₂ as important collision partner for the loss of CO₂, makes a CO₂/H₂ mixture under the present conditions less interesting for the formation of higher hydrocarbons and oxygenates than a CO₂/CH₄ mixture. This is especially true because H₂ itself is a useful product, while CH₄, besides being a fuel itself, also greatly contributes to global warming, and thus, the simultaneous conversion of CO₂ and CH₄ will reduce the concentration of two greenhouse gases. Moreover, CO₂/CH₄ mixtures are available from biomass installations, and their simultaneous conversion can be seen as a direct valorization of biogas, instead of the energy intensive biogas upgrading to a CH₄-rich gas by removing CO₂. Another possibly interesting H-source to be added to a CO₂ plasma to produce value-added chemicals, could be water, and the combined CO₂/H₂O conversion could even mimic the natural photosynthesis process.

However, recent investigations have illustrated that this gas mixture is also not able to produce oxygenates above the ppm range in a DBD plasma.²²⁵

Nevertheless, we still believe a CO₂/H₂ mixture can be of interest for producing CO, to obtain gas mixtures with a specific H₂/CO ratio. In order to produce specific oxygenated compounds, however, we believe that a catalyst should be added to the plasma.²²⁶ This was also demonstrated by Eliasson et al.²¹⁹, who reported much higher methanol yields in the presence of a catalyst in the plasma, and by Zeng et al.²²², who found that the combination of a plasma with a catalyst enhances the conversion of CO₂ by 7-36 %, as well as the yield and energy efficient production of CO.

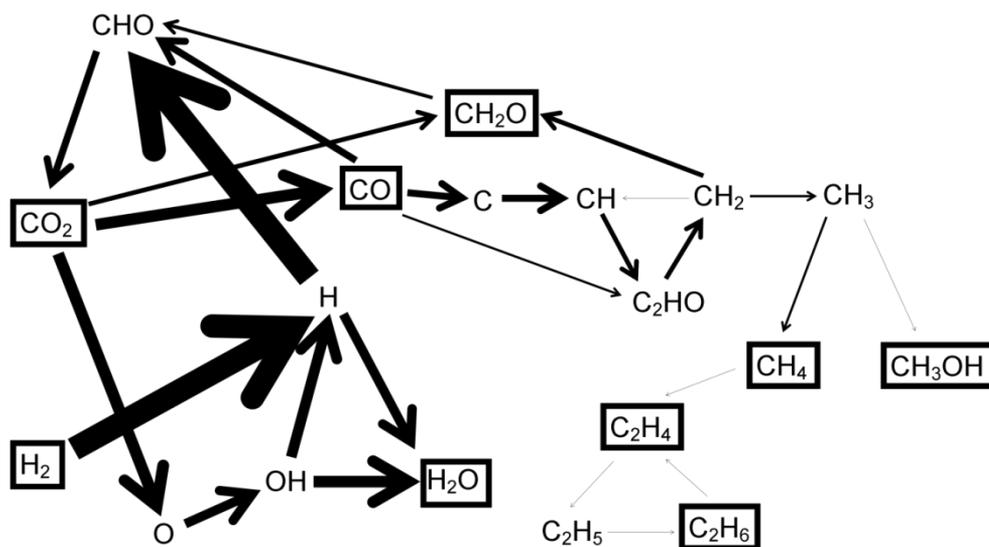


Figure 40. Dominant reaction pathways for the conversion of CO₂ and H₂ into various products, in a 50/50 CO₂/H₂ gas mixture. The thickness of the arrow lines is proportional to the rates of the net reactions. The stable molecules are indicated with black rectangles.

6.6. Conclusion

A 1D fluid modeling study for the hydrogenation of CO₂ in a DBD plasma was carried out for different CO₂/H₂ gas mixing ratios. The densities of the various plasma species as a function of the residence time and the gas mixing ratio were discussed. The spatially averaged densities of the electrons, radicals and ions produced in the plasma exhibit periodic behavior as a function of time, following the period of the sinusoidal applied voltage. The most abundant radicals are H, O, OH, HO₂, CHO, CH₃ and CH₂. The densities of the molecules formed during the hydrogenation of CO₂, i.e., CO, higher order hydrocarbons and oxygenates, exhibit a rising trend as a function of time, because their net production is higher than their net consumption. The most abundant reaction products are CO, H₂O and CH₄, and to a lower extent also CH₂O, C₂H₆, O₂ and CH₃OH. This is in good agreement with reported results from literature for similar CO₂/H₂ discharges. Altering the inlet gas mixing ratio did not drastically affect the densities of the formed higher hydrocarbons and oxygenates, as the conversion of CO₂ was found to be very low in all gas mixing ratios. We have also presented the calculated conversions of the inlet gases and the maximum yields and corresponding selectivities of the main reaction products. It is clear that the conversion of CO₂ is rather low (i.e., in the order of 2-7 %) in all gas mixtures, and much lower than in a CO₂/CH₄ mixture, where typical conversions in the order of 3-20 % are obtained at similar conditions. The reason is the abundance of CH₂ radicals in the latter mixture, which significantly contribute to the loss of CO₂, but their density is very low in the CO₂/H₂ mixture. The H₂ conversion was calculated to be about 30-60 %, depending on the gas mixing ratio. CO was found to be the only value-added end product with a high selectivity. Finally,

the underlying plasma chemistry governing the conversion of CO₂ and H₂ into the various products was analyzed in detail. The dominant reaction pathways for the consumption of CO₂ and H₂ and the production and loss of some interesting end products, i.e., CO, CH₄, CH₂O and CH₃OH, were discussed. It is clear from our results that a higher conversion of CO₂, as well as a higher density of CH₃ and CH₂ radicals, would be necessary in order to obtain higher yields of the desired end products. For the conditions under study, only CO is formed at an acceptable level. Thus, it is clear that a CO₂/H₂ mixture is not very suitable for the production of other value-added chemicals besides CO, and that a CO₂/CH₄ mixture is more appropriate, because of the presence of CH₂ and CH₃ radicals. The use of a catalyst can possibly increase the formation of some desired oxygenates, as is indeed also shown by Eliasson et al.²¹⁹ and Zeng et al.²²².

Chapter 7

General Conclusion and Outlook for the Future

7.1. General Conclusion

We have studied the plasma chemistry for gas conversion in a DBD plasma, in pure CH_4 , as well as in CH_4/O_2 , CH_4/CO_2 and CO_2/H_2 mixtures, which are used for partial oxidation of CH_4 , dry reforming of CH_4 and CO_2 hydrogenation, respectively. More specifically, we have calculated the densities of the various plasma species, created in these gas mixtures, as a function of residence time and gas mixing ratio. C_2H_6 and H_2 are found to be the main reaction products of the conversion of pure CH_4 into higher hydrocarbons in a DBD reactor. Partial oxidation of CH_4 favors the formation of H_2O_2 , CH_3OH , $\text{C}_2\text{H}_5\text{OH}$, CH_3OOH and $\text{C}_2\text{H}_5\text{OOH}$, while the densities of H_2 , CH_2O , CH_3CHO and CH_2CO are higher for the dry reforming of CH_4 . CO is formed at high density in both gas mixtures. Note that in the gas mixtures with O_2 as co-reactant also a significant amount of undesired CO_2 is formed. The most abundant reaction products for the hydrogenation of CO_2 in a DBD plasma are CO , H_2O and CH_4 , and to a lower extent also CH_2O , C_2H_6 , O_2 and CH_3OH . It is illustrated that a careful selection of the residence time and gas mixing ratio can entail a higher production of some targeted molecules.

From the calculated densities, the conversions of the inlet gases and the yields and selectivities of the end products as a function of residence time and initial gas mixing ratio can be obtained. The conversion of CH_4 after 20s is around 20% in all considered mixtures with O_2 , while in pure CH_4 , a conversion of 40% was calculated after 20s. A maximum conversion of 68% for CH_4 and 55% for CO_2 in CH_4/CO_2 is predicted by our calculations. In contrast, the conversion of CO_2 was found to be very low in CO_2/H_2 for all gas mixing ratios (i.e., in the order of 2-7 %). Altering the inlet gas mixing ratio in CO_2/H_2 did not drastically affect the densities of the formed higher

hydrocarbons and oxygenates. Therefore, it is clear that a CO_2/H_2 mixture is not very suitable for the production of other value-added chemicals besides CO.

The dominant reaction pathways for the consumption of the inlet gases and the production and loss of the dominant end products are also discussed. These results explain in detail why the formation of some molecules is favored in one gas mixture, while other molecules are predominantly formed in another gas mixture. They also point out the reason for the rather low conversion in CO_2/H_2 compared to the conversion in CH_4/CO_2 , i.e., the lack of CH_2 radicals in CO_2/H_2 . Schematic overviews at the end of each chapter summarize the dominant reaction pathways for the conversion of the inlet gases into various compounds, in the different gas mixtures.

Reasonable agreement between our calculation results and the measurements for pure CH_4 is established. Furthermore, our results on the partial oxidation and dry reforming of CH_4 and on the hydrogenation of CO_2 are in good agreement with reported results from literature for similar CH_4/O_2 , CH_4/CO_2 and CO_2/H_2 discharges. Moreover, the model can help to obtain more insight into the most suitable feed gas ratio, residence time, co-reactant and other plasma parameters, to obtain the highest yield and/or selectivity of a desired oxygenate.

7.2. Outlook for the Future

In this PhD dissertation, we only focused on the conversion, yields and selectivities, but another crucial parameter to determine whether a sustainable competitive industrial process for gas conversion in a DBD can be established, is the energy efficiency of the conversion process. The latter was not studied in the present PhD dissertation, but it is known that a DBD plasma has a rather low energy efficiency for gas conversion, as studied in other PhD dissertations within our group PLASMANT.^{109, 181, 197, 227-229} To improve the energy efficiency, a (dielectric) packing can be included in the DBD reactor, enhancing the electric field, and thus the electron temperature, thereby increasing the electron impact reaction rates, yielding a higher conversion for the same input power, and thus a higher energy efficiency. The effect of introducing a dielectric packing in a DBD reactor is currently being investigated by fluid modeling in another PhD dissertation within our group PLASMANT,^{212, 230} as well as experimentally,²¹² in collaboration with the group LADCA.

Furthermore, a packed bed DBD reactor is also very suitable to introduce a catalyst in the plasma. Our calculation results indicate that the latter will indeed be crucial to improve the selectivities of the desired end products, by acting on one or more of the underlying gas-phase reactions, which will be needed to make this DBD plasma conversion competitive for industrial applications. Plasma catalysis is also being studied within the group PLASMANT, both by computer modeling and experiments, the latter in collaboration with LADCA.

Finally, our specific modeling results on the plasma chemistry can be further improved by including vibrational excitation levels, so that the model can also be applied to other types of plasma reactors, like a microwave or gliding arc discharge (which are known to have a higher energy efficiency, and which are also being studied within our group PLASMANT), or by including other value-added compounds in the model, such as dimethyl ether and formic acid. However, it will be crucial to find reliable data to describe the formation or loss of these species. On the other hand, a reduction of the chemistry set based on a sensitivity analysis is also worth to perform, to be able to simulate the plasma conversion by 2D fluid models, and account for the specific features of a plasma reactor, such as the occurrence of filaments in a DBD.

Summary

The world primary energy demand is set to grow by one-third to 2040. Globally, fossil fuel resources are still plentiful and will last for decades, but it becomes more difficult to recover them and there can be no guarantee that they will be exploited fast enough to meet the level of demand. The availability of energy resources is, however, of paramount importance to the society. Access to reliable, affordable commercial energy provides the basis for heat, light, mobility, communications and agricultural and industrial capacity in modern society and in this way energy stipulates the degree of civilization. Therefore, socially, environmentally and economically, a growing need is being imposed for a global sustainable energy strategy, based on an improvement of the energy efficiency of the current technologies and a more intensifying diversification of the energy resources, with a huge preference for lower carbon resources. Future energy policy intentions indicate a boost to lower-carbon fuels and technologies worldwide, resulting in an increasing share of non-fossil fuels and natural gas, which is the least-carbon intensive fossil fuel, within the global energy mix up to 2040, while the share of oil and coal is decreasing.

Besides this, climate change due to anthropogenic greenhouse gas emission is a growing concern for the global society. Anthropogenic greenhouse gas emissions have increased since the pre-industrial era and have led to atmospheric concentrations of carbon dioxide (CO₂), methane (CH₄) and nitrous oxide (N₂O) that are unprecedented in at least the last 800,000 years. At the 21st Conference of the Parties to the United Nations Framework Convention on Climate Change (COP21/CMP11; November-December, 2015) a new international agreement, which is strongly endorsed by the chemical

industry, on climate change was made, in order to keep global warming below 2°C.

The conversion of methane, the principal component of natural gas, and carbon dioxide to value-added chemicals and fuels has still a significant growth potential. Currently, both resources are greatly underutilized for the production of chemicals and liquid fuels, mainly because they are very stable molecules. More in particular, the development of a process for the direct synthesis of higher hydrocarbons, syngas and oxygenates, such as methanol and formaldehyde, from methane and/or carbon dioxide in an energy-efficient way would offer significant benefits.

Atmospheric pressure non-thermal plasmas, such as dielectric barrier discharges (DBDs), can offer here a distinct advantage because a DBD has the unique characteristic that it combines an ambient bulk gas temperature and the presence of highly energetic electrons with an electron temperature between 5000 and 20000 K at an electron density of about 10^{14} cm^{-3} , and so it enables gas phase reactions at ambient conditions.

A DBD is an electrical discharge that is generated between two electrodes of which at least one is covered with a dielectric material made of glass, quartz, alumina, etc. The gap between the two electrodes is typically a few millimeters. An ac voltage with an amplitude from 1 kV to 100 kV and a frequency of a few Hz to MHz is usually applied to this kind of discharges. Different plasma activation mechanisms will act, causing vibrational and electronic excitation, as well as ionization and dissociation of species, and in this way gas conversion processes are induced.

These processes always involve a huge underlying plasma chemistry and in order to optimize such a process, it is indispensable to get notion of the play of the different species in the immensity of chemical reactions. Fluid modeling can provide here the necessary information to obtain insight in the gas phase chemistry taking place in the discharge gap.

The aim of this dissertation was to describe in detail the plasma chemistry in an atmospheric pressure cylindrical DBD, used as a chemical reactor for gas conversion in different gas mixtures with CH_4 and/or CO_2 , by means of a 1D fluid model. The model applied in this study is called Plasimo's MD2D. It is based on the continuity and flux equations for each type of species treated, the electron energy equation and the Poisson equation. This set of coupled partial differential equations is solved by the so-called modified strongly implicit method.

More specifically, the goal was to develop a reliable chemistry set for the description of the gas phase chemistry in pure CH_4 , CH_4/O_2 , CH_4/CO_2 and CO_2/H_2 gas discharges. In order to achieve our goal, we started by developing a 1D fluid model for an atmospheric pressure DBD in pure methane, and extended this model in a later stage to describe the plasma chemistry in the other gas mixtures. A large number of different plasma species (i.e., electrons, molecules, radicals, ions) are included in our model, as well as a comprehensive set of chemical reactions, into which these species participate. For the electron-induced reactions, cross sections as a function of the electron energy were defined as input for the Boltzmann solver BOLSIG+, which provides the energy dependent electron transport coefficients and rate coefficients of the electron reactions, whereas the ion-neutral and neutral-

neutral reactions were characterized by a constant reaction rate coefficient for the working pressure and temperature of 1 atm and 300 K, respectively.

In this way, calculation results could be obtained for the densities of the different plasma species, the conversions of the inlet gases, the yields and selectivities of the end products and the dominant reaction pathways for each of the gas mixtures studied. This allows us to determine whether or not a specific gas mixture is suitable for the production of a specific end-product of interest. Our calculation results were validated with reported results in literature, and for pure CH₄ also with some experiments for the reactor set-up under study.

In all gas mixtures, the spatially averaged densities of the electrons, ions and radicals exhibit a periodic behavior as a function of time, following the sinusoidal applied voltage, while the spatially averaged molecule densities do not show a periodic behavior. It is illustrated that a careful selection of the residence time and gas mixing ratio can entail a higher production of some targeted molecules.

Higher hydrocarbons (C₂H_y and C₃H_y) and hydrogen gas are typically found as end products for the conversion of pure CH₄. A reasonable agreement between our calculation results and the measurements is established. It is found that electron impact dissociation of CH₄, resulting in the formation of the methyl radical (CH₃), initiates the conversion process. Recombination of CH₃ with either another CH₃ radical or with a C₂H₅ radical will lead to the formation of C₂H₆ and C₃H₈. Dissociation of these higher hydrocarbons leads directly to the formation of other hydrocarbons, but also indirectly by the formation of new radicals, which can subsequently also recombine towards these higher order hydrocarbons. In other words, the conversion of CH₄ is a

play of dissociation and recombination reactions leading to a diverse mixture of higher hydrocarbons.

Dry reforming of CH_4 in a DBD favors the formation of H_2 , CH_2O , CH_3CHO and CH_2CO , while the densities of H_2O_2 , CH_3OH , $\text{C}_2\text{H}_5\text{OH}$, CH_3OOH and $\text{C}_2\text{H}_5\text{OOH}$ are higher for the partial oxidation of CH_4 in a DBD. CO is formed at high density in both gas mixtures, i.e., CH_4/O_2 and CH_4/CO_2 . In the gas mixtures with O_2 as co-reactant, also a significant amount of undesired CO_2 is formed. Electron impact dissociation of the inlet gases initiates the conversion process. The recombination of CH_3 radicals again plays a crucial role and it was shown that this recombination leads to the formation of higher hydrocarbons in the mixtures with CO_2 , while CH_3O_2 radicals are favored in the mixtures with O_2 . In the CH_4/CO_2 mixture, also CH_2 radicals play a role, which can be converted into formaldehyde and CO molecules. In the CH_4/O_2 mixture, the CH_3O_2 radicals lead among others to the formation of methanol, which can react further into formaldehyde and the latter can form CO . Our results are in reasonable agreement with reported results from literature for similar CH_4/O_2 and CH_4/CO_2 discharges. Moreover, our model provides additional information, mainly on the comparison between the formed end products in CH_4/O_2 and CH_4/CO_2 gas mixtures and on the different pathways leading to these products.

The most abundant reaction products for the hydrogenation of CO_2 in a DBD are CO , H_2O and CH_4 , and to a lower extent also CH_2O , C_2H_6 , O_2 and CH_3OH . This is in good agreement with reported results from literature for similar CO_2/H_2 discharges. Altering the inlet gas mixing ratio did not drastically affect the densities of the formed higher hydrocarbons and oxygenates, as the conversion of CO_2 was found to be very low (i.e., in the order of 2-7 %) in all

gas mixtures, and much lower than in a CO_2/CH_4 mixture, where typical conversions in the order of 3-20 % are obtained at similar conditions. The reason is the abundance of CH_2 radicals in the latter mixture, which significantly contribute to the loss of CO_2 , but their density is very low in the CO_2/H_2 mixture. It is clear that a CO_2/H_2 mixture is not very suitable for the production of other value-added chemicals besides CO, at least in a pure DBD, and that the combination with a catalyst will be needed for the selective production of some value-added compounds, not only in the CO_2/H_2 mixture, but in a DBD plasma in general.

Samenvatting

De wereldwijde vraag naar primaire energie zal naar verwachting met een derde groeien tegen 2040. Hoewel fossiele brandstoffen wereldwijd nog overvloedig aanwezig zijn, wordt het steeds moeilijker om ze te ontginnen en is er geen garantie dat ze snel genoeg gewonnen zullen worden om aan de vraag naar energie tegemoet te komen. De beschikbaarheid van energiebronnen is echter van het grootste belang voor onze maatschappij. De toegang tot betrouwbare, betaalbare commerciële energie vormt de basis voor warmte, licht, mobiliteit, communicatie en agrarische en industriële capaciteit in een moderne maatschappij, en op deze manier bepaalt energie de ontwikkelingsgraad van een maatschappij. Daarom is er vanuit sociaal, ecologisch en economisch oogpunt een groeiende behoefte aan een wereldwijde strategie voor duurzame energie, door middel van een verbetering van de energie-efficiëntie van de huidige technologieën en een toenemende verscheidenheid aan energiebronnen, met een grote voorkeur voor energiebronnen met een lager koolstofgehalte. Beleidsintenties inzake energie wijzen op een algemene verschuiving naar brandstoffen en technologieën met een lager koolstofgehalte. Dit leidt ertoe dat het aandeel aan niet-fossiele brandstoffen en aardgas, de minst koolstofintensieve fossiele brandstof, binnen de wereldwijde energiemix zal blijven groeien in de komende decennia, terwijl olie en steenkool minder belangrijk worden.

Daarnaast is er de toenemende bezorgdheid over de gevolgen van de klimaatverandering voor de samenleving. De antropogene uitstoot van broeikasgassen, welke aan de basis ligt van de klimaatverandering, is gestegen sinds het pre-industriële tijdperk. Daardoor is de atmosferische concentratie van koolstofdioxide (CO₂), methaan (CH₄) en lachgas (N₂O) toegenomen tot

waarden die ongezien zijn in de laatste 800.000 jaar. Tijdens de 21^{ste} Conferentie van Partijen over het Klimaatverdrag (COP21/CMP11, november-december 2015) werd een nieuwe internationale overeenkomst gemaakt over klimaatverandering, welke wordt onderschreven door de chemische industrie. Er werd hierbij afgesproken om de opwarming van de aarde onder de 2 °C te houden.

De omzetting van methaan, het hoofdbestanddeel van aardgas, en koolstofdioxide in chemicaliën en brandstoffen met toegevoegde waarde heeft nog steeds een aanzienlijk groeipotentieel. Momenteel worden beide grondstoffen sterk onderbenut voor de productie van chemicaliën en vloeibare brandstoffen, vooral omdat het beiden zeer stabiele moleculen zijn. Vooral de ontwikkeling van een energie-efficiënt en duurzaam proces voor de directe vorming van hogere koolwaterstoffen, syngas en zuurstofhoudende verbindingen, zoals methanol en formaldehyde uit methaan en/of koolstofdioxide zou perspectieven bieden.

Atmosferische niet-thermische plasma's, zoals diëlektrische barrière ontladingen (DBDs), kunnen hier een duidelijk voordeel bieden, daar in een DBD de temperatuur van het bulkgas relatief laag blijft (tussen kamertemperatuur en 200 °C) terwijl elektronen gevormd worden, die zeer energetisch zijn en een temperatuur hebben variërend tussen 5000 en 20.000 K, bij een elektronendichtheid van circa 10^{14} cm^{-3} . Dit maakt reacties mogelijk die thermodynamisch niet zouden kunnen optreden bij deze lage gastemperaturen. Als dusdanig kunnen plasmaprocessen de nadelen van de hoge temperatuur, die vereist is bij conventionele katalytische processen, vermijden.

Een DBD is een elektrische ontlading die wordt gegenereerd tussen twee elektroden waarvan er ten minste één is bedekt met een diëlektricum, gemaakt van bv. glas, kwarts, aluminiumoxide, enz. De afstand tussen de twee elektroden is typisch enkele millimeters. Doorgaans wordt een wisselspanning met een amplitude van 1 kV tot 100 kV en een frequentie van enkele Hz tot MHz over de elektroden aangelegd, waarna in de ontladingsruimte een plasma gecreëerd zal worden. Verschillende plasma-activatiemechanismen treden op en dit leidt tot vibrationele en elektronische excitatie, ionisatie en dissociatie van de gasdeeltjes en dusdanig tot gasconversie.

Een waaier aan deeltjes en reacties is betrokken in deze gasconversie processen. Het is dan ook cruciaal om een inzicht te krijgen in deze onderliggende plasmachemie, indien men dergelijk proces wenst te optimaliseren. Fluid modellering kan hier de nodige informatie aanreiken om een inzicht te krijgen in de gasfase chemie in zulk een DBD.

Het opzet van dit doctoraat was om in detail de plasmachemie in een cilindrische DBD bij atmosferedruk, gebruikt als een chemische reactor voor gasconversie, te beschrijven aan de hand van een 1D fluid model, voor verschillende gasmengsels met CH₄ en/of CO₂. Het model dat gebruikt werd in dit onderzoek is Plasimo's MD2D. Een fluid model is gebaseerd op de snelheidsmomenten van de Boltzmann transportvergelijking. De nulde, eerste en tweede momenten van deze vergelijking geven namelijk de behoudsvergelijkingen van respectievelijk deeltjesdichtheid, hoeveelheid van beweging en energiedichtheid. De behoudsvergelijking voor hoeveelheid van beweging wordt hier echter benaderd door de eenvoudiger drift-diffusie vergelijking. De behoudsvergelijking van deeltjesdichtheid en de drift-diffusie vergelijking worden opgesteld voor elke deeltjessoort, terwijl de

energiebalansvergelijking enkel opgesteld wordt voor de elektronen. Deze vergelijkingen worden ten slotte gekoppeld aan de Poisson vergelijking om de elektrische potentiaalverdeling zelfconsistent te kunnen berekenen uit de dichtheden van elektronen en ionen. Aangezien deze set van vergelijkingen sterk gekoppeld is, moeten deze vergelijkingen ook simultaan worden opgelost.

Meer bepaald was het het doel om een betrouwbare chemieset op te stellen voor de beschrijving van de gasfase chemie in zuiver CH_4 , CH_4/O_2 , CH_4/CO_2 en CO_2/H_2 gasontladingen. Om ons doel te bereiken, zijn we begonnen met het ontwikkelen van een 1D fluid model voor een DBD bij atmosferedruk in zuiver methaan. In een volgende stap hebben we dit model dan uitgebreid om de plasmachemie in de andere gasmengsels te kunnen beschrijven.

Zulk een reactieset bestaat uit een groot aantal verschillende soorten plasmadeeltjes (elektronen, moleculen, radicalen, ionen) en hun bijhorende reacties. Voor de deeltjes dienen diffusiecoëfficiënten, mobiliteitscoëfficiënten, stickingcoëfficiënten en secundaire elektronen emissiecoëfficiënten gedefinieerd te worden in het model. Voor de reacties met elektronen werden cross secties als functie van de elektronenenergie gedefinieerd als input voor de Boltzmann solver BOLSIG+, die energieafhankelijke elektron transport- en snelheidscoëfficiënten van de elektronreacties bepaalt. De reacties tussen neutrale deeltjes en tussen neutrale deeltjes en ionen werden gedefinieerd met een constante reactiesnelheidscoëfficiënt voor 1 atmosfeer en 300 K.

Op deze manier konden de dichtheden van de verschillende plasmadeeltjes, de omzettingen van de inlaatgassen, de rendementen en de selectiviteiten

van de eindproducten en de belangrijkste reactiepaden berekend worden voor elk van de in dit onderzoek beschouwde gasmengsels. Daardoor konden we bepalen of een bepaald gasmengsel geschikt is voor de productie van een specifiek beoogd eindproduct. Onze resultaten werden gevalideerd aan de hand van gerapporteerde waarden in de literatuur voor gelijkaardige ontladingen, alsook aan de hand van experimenten uitgevoerd in de plasmareactor beschouwd in dit onderzoek, in het geval van zuiver CH_4 .

De ruimtelijk gemiddelde dichtheden van de elektronen, ionen en radicalen vertonen in elk van de gasmengsels periodisch gedrag in functie van de tijd. Dit is in tegenstelling tot de ruimtelijk gemiddelde dichtheden van de moleculen, welke een dalende of stijgende trend vertonen. Een zorgvuldige keuze van de verblijftijd en de gassamenstelling kan leiden tot een hogere productie van bepaalde gewenste eindproducten.

Hogere koolwaterstoffen (C_2H_y en C_3H_y) en waterstofgas zijn de belangrijkste eindproducten voor de conversie van zuiver CH_4 . Een redelijke overeenkomst tussen onze berekeningen en de metingen werd verkregen. Het blijkt verder dat botsingen van elektronen met CH_4 leiden tot de dissociatie van CH_4 in methylradicalen (CH_3) welke het gasconversie proces zullen initiëren. Recombinatie van CH_3 met een ander CH_3 radicaal of een C_2H_5 radicaal leidt tot de vorming van C_2H_6 en C_3H_8 . Dissociatie van deze hogere koolwaterstoffen leidt direct en indirect (via nieuwe recombiniatiereacties) tot de vorming van andere koolwaterstoffen. De omzetting van CH_4 is met andere woorden een spel van dissociatie- en recombiniatiereacties, die leiden tot een divers mengsel van hogere koolwaterstoffen.

‘Dry reforming’ van CH_4 in een DBD leidt tot de vorming van H_2 , CH_2O , CH_3CHO en CH_2CO , terwijl partiële oxidatie van CH_4 resulteert in de vorming

van H_2O_2 , CH_3OH , $\text{C}_2\text{H}_5\text{OH}$, CH_3OOH en $\text{C}_2\text{H}_5\text{OOH}$. De dichtheid van CO is hoog in zowel CH_4/O_2 als CH_4/CO_2 . In de gasmengsels met O_2 als co-reactant wordt ook een aanzienlijke hoeveelheid ongewenst CO_2 gevormd. Elektron impact dissociatie van de gasmoleculen initieert het conversieproces. De recombinatie van CH_3 radicalen speelt wederom een cruciale rol. Er werd aangetoond dat deze recombinatie leidt tot de vorming van hogere koolwaterstoffen in het mengsel met CO_2 , terwijl CH_3O_2 radicalen bij voorkeur gevormd worden in de mengsels met O_2 . In de CH_4/CO_2 gasmengsels spelen ook de CH_2 radicalen een belangrijke rol, waarbij er via botsingen met CO_2 formaldehyde en CO gevormd worden. De CH_3O_2 radicalen in de CH_4/O_2 gasmengsels leiden onder andere tot de vorming van methanol, dat verder kan reageren tot formaldehyde en dit kan dan weer verder reageren tot CO. Er is een redelijke overeenstemming tussen onze resultaten en gerapporteerde resultaten uit de literatuur voor soortgelijke CH_4/O_2 en CH_4/CO_2 ontladingen. Bovendien levert ons model extra informatie, voornamelijk wat betreft de vergelijking van de gevormde eindproducten tussen CH_4/O_2 en CH_4/CO_2 gas gasmengsels en de verschillende reactiepaden verantwoordelijk voor de vorming van deze producten.

De belangrijkste reactieproducten voor de hydrogenatie van CO_2 in een DBD zijn CO, H_2O en CH_4 , en in mindere mate ook CH_2O , C_2H_6 , O_2 en CH_3OH . Dit komt goed overeen met de gerapporteerde resultaten uit de literatuur voor soortgelijke CO_2/H_2 ontladingen. Het veranderen van de initiële gasverhouding heeft geen grote invloed op de dichtheid van de gevormde hogere koolwaterstoffen en zuurstofhoudende verbindingen, daar de omzetting van CO_2 zeer laag bleek (in de orde van 2-7%) in alle gasmengsels, en dus veel lager is dan deze in een CO_2/CH_4 mengsel, waarbij omzettingen in

de orde van 3-20% worden verkregen bij soortgelijke omstandigheden. De reden is de grotere aanwezigheid van CH_2 radicalen in het CO_2/CH_4 gasmengsel, die aanzienlijk bijdragen tot de afbraak van CO_2 . Het is duidelijk dat een CO_2/H_2 mengsel niet erg geschikt is voor de productie van andere chemicaliën met toegevoegde waarde behalve dan CO , tenminste voor een DBD plasma, en dat de combinatie met een katalysator nodig zal zijn voor de selectieve productie van specifieke waardevolle componenten, niet enkel in het CO_2/H_2 mengsel, maar ook meer algemeen in een DBD plasma.

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Appendices - Overview of the Reactions in the Model

Note: This set is applicable for the CH₄/CO₂, CH₄/O₂ and CO₂/H₂ mixtures, as well as for pure CH₄, where of course only the reactions with CH₄ and CH_x species are included. The reactions included in the model for pure CH₄ are indicated with a gray shadow.

Table A.1. Electron impact reactions with the various molecules and radicals, included in the model. These reactions are treated by energy-dependent cross sections (or rate coefficients), and the references where these cross sections (or rate coefficients) were adopted from, are also included. For the vibrational and electronic excitations, several individual excitations are included, as indicated by the number between brackets.

CH ₄					
Momentum Transfer	e ⁻ + CH ₄	→	e ⁻ + CH ₄		231
Vibrational Excitation	e ⁻ + CH ₄	→	e ⁻ + CH ₄ [*]	(2)	231
Ionization	e ⁻ + CH ₄	→	2e ⁻ + CH ₄ ⁺		232
Dissociative Ionization	e ⁻ + CH ₄	→	2e ⁻ + CH ₃ ⁺ + H		232
	e ⁻ + CH ₄	→	2e ⁻ + CH ₂ ⁺ + H ₂		232
Dissociation	e ⁻ + CH ₄	→	e ⁻ + CH ₃ + H		233-234
	e ⁻ + CH ₄	→	e ⁻ + CH ₂ + H ₂		233-234
	e ⁻ + CH ₄	→	e ⁻ + CH + H ₂ + H		233-234
	e ⁻ + CH ₄	→	e ⁻ + C + 2H ₂		233-234
CH ₃					
Ionization	e ⁻ + CH ₃	→	2e ⁻ + CH ₃ ⁺		232

Appendices Table A.1.

Dissociative Ionization	$e^- + CH_3$	$\rightarrow 2e^- + CH_2^+ + H$	232
	$e^- + CH_3$	$\rightarrow 2e^- + CH^+ + H_2$	232
Dissociation	$e^- + CH_3$	$\rightarrow e^- + CH_2 + H$	233-234
	$e^- + CH_3$	$\rightarrow e^- + CH + H_2$	233-234
CH₂			
Ionization	$e^- + CH_2$	$\rightarrow 2e^- + CH_2^+$	232
Dissociative Ionization	$e^- + CH_2$	$\rightarrow 2e^- + CH^+ + H$	232
	$e^- + CH_2$	$\rightarrow 2e^- + C^+ + H_2$	232
Dissociation	$e^- + CH_2$	$\rightarrow e^- + CH + H$	233-234
CH			
Ionization	$e^- + CH$	$\rightarrow 2e^- + CH^+$	232
Dissociative Ionization	$e^- + CH$	$\rightarrow 2e^- + C^+ + H$	232
Dissociation	$e^- + CH$	$\rightarrow e^- + C + H$	233-234
C			
Ionization	$e^- + C$	$\rightarrow 2e^- + C^+$	233-234
C₂H₆			
Momentum Transfer	$e^- + C_2H_6$	$\rightarrow e^- + C_2H_6$	231
Vibrational Excitation	$e^- + C_2H_6$	$\rightarrow e^- + C_2H_6^*$	(3) 231
Ionization	$e^- + C_2H_6$	$\rightarrow 2e^- + C_2H_6^+$	232
Dissociative Ionization	$e^- + C_2H_6$	$\rightarrow 2e^- + C_2H_5^+ + H$	232
	$e^- + C_2H_6$	$\rightarrow 2e^- + C_2H_4^+ + H_2$	232
	$e^- + C_2H_6$	$\rightarrow 2e^- + C_2H_3^+ + H_2 + H$	232
	$e^- + C_2H_6$	$\rightarrow 2e^- + C_2H_2^+ + 2H_2$	232

	$e^- + C_2H_6$	$\rightarrow 2e^- + CH_3^+ + CH_3$	232
Dissociation	$e^- + C_2H_6$	$\rightarrow e^- + C_2H_5 + H$	235-236
	$e^- + C_2H_6$	$\rightarrow e^- + C_2H_4 + H_2$	235-236
C₂H₅			
Ionization	$e^- + C_2H_5$	$\rightarrow 2e^- + C_2H_5^+$	232
Dissociative Ionization	$e^- + C_2H_5$	$\rightarrow 2e^- + C_2H_4^+ + H$	232
	$e^- + C_2H_5$	$\rightarrow 2e^- + C_2H_3^+ + H_2$	232
	$e^- + C_2H_5$	$\rightarrow 2e^- + C_2H_2^+ + H_2 + H$	232
Dissociation	$e^- + C_2H_5$	$\rightarrow e^- + C_2H_4 + H$	235-236
	$e^- + C_2H_5$	$\rightarrow e^- + C_2H_3 + H_2$	235-236
C₂H₄			
Momentum Transfer	$e^- + C_2H_4$	$\rightarrow e^- + C_2H_4$	231
Vibrational Excitation	$e^- + C_2H_4$	$\rightarrow e^- + C_2H_4^*$	(2) 231
Ionization	$e^- + C_2H_4$	$\rightarrow 2e^- + C_2H_4^+$	232
Dissociative Ionization	$e^- + C_2H_4$	$\rightarrow 2e^- + C_2H_3^+ + H$	232
	$e^- + C_2H_4$	$\rightarrow 2e^- + C_2H_2^+ + H_2$	232
Dissociation	$e^- + C_2H_4$	$\rightarrow e^- + C_2H_3 + H$	235-236
	$e^- + C_2H_4$	$\rightarrow e^- + C_2H_2 + H_2$	235-236
C₂H₃			
Ionization	$e^- + C_2H_3$	$\rightarrow 2e^- + C_2H_3^+$	232
Dissociative Ionization	$e^- + C_2H_3$	$\rightarrow 2e^- + C_2H_2^+ + H$	232
	$e^- + C_2H_3$	$\rightarrow 2e^- + C_2H^+ + H_2$	232
Dissociation	$e^- + C_2H_3$	$\rightarrow e^- + C_2H_2 + H$	235-236

Appendices Table A.1.

	$e^- + C_2H_3$	$\rightarrow e^- + C_2H + H_2$	235-236
C₂H₂			
Momentum Transfer	$e^- + C_2H_2$	$\rightarrow e^- + C_2H_2$	231
Vibrational Excitation	$e^- + C_2H_2$	$\rightarrow e^- + C_2H_2^*$	(3) 231
Ionization	$e^- + C_2H_2$	$\rightarrow 2e^- + C_2H_2^+$	232
Dissociation	$e^- + C_2H_2$	$\rightarrow e^- + C_2H + H$	235-236
	$e^- + C_2H_2$	$\rightarrow e^- + C_2 + H_2$	235-236
C₂H			
Ionization	$e^- + C_2H$	$\rightarrow 2e^- + C_2H^+$	232
Dissociation	$e^- + C_2H$	$\rightarrow e^- + C_2 + H$	235-236
	$e^- + C_2H$	$\rightarrow e^- + C + CH$	235-236
C₂			
Ionization	$e^- + C_2$	$\rightarrow 2e^- + C_2^+$	235-236
Dissociation	$e^- + C_2$	$\rightarrow e^- + C + C$	235-236
C₃H₈			
Momentum Transfer	$e^- + C_3H_8$	$\rightarrow e^- + C_3H_8$	231
Vibrational Excitation	$e^- + C_3H_8$	$\rightarrow e^- + C_3H_8^*$	(2) 231
Dissociative Ionization	$e^- + C_3H_8$	$\rightarrow 2e^- + C_2H_5^+ + CH_3$	232
	$e^- + C_3H_8$	$\rightarrow 2e^- + C_2H_4^+ + CH_4$	232
Dissociation	$e^- + C_3H_8$	$\rightarrow e^- + C_3H_7 + H$	235-236
	$e^- + C_3H_8$	$\rightarrow e^- + C_3H_6 + H_2$	235-236
	$e^- + C_3H_8$	$\rightarrow e^- + C_2H_4 + CH_4$	235-236

C ₃ H ₇				
Dissociative Ionization	$e^- + C_3H_7$	\rightarrow	$2e^- + C_2H_5^+ + CH_2$	235-236
	$e^- + C_3H_7$	\rightarrow	$2e^- + C_2H_4^+ + CH_3$	235-236
	$e^- + C_3H_7$	\rightarrow	$2e^- + C_2H_3^+ + CH_4$	235-236
	$e^- + C_3H_7$	\rightarrow	$2e^- + CH_3^+ + C_2H_4$	235-236
Dissociation	$e^- + C_3H_7$	\rightarrow	$e^- + C_3H_6 + H$	235-236
	$e^- + C_3H_7$	\rightarrow	$e^- + C_3H_5 + H_2$	235-236
	$e^- + C_3H_7$	\rightarrow	$e^- + C_2H_4 + CH_3$	235-236
	$e^- + C_3H_7$	\rightarrow	$e^- + C_2H_3 + CH_4$	235-236
C ₃ H ₆				
Dissociative Ionization	$e^- + C_3H_6$	\rightarrow	$2e^- + C_2H_5^+ + CH$	235-236
	$e^- + C_3H_6$	\rightarrow	$2e^- + C_2H_4^+ + CH_2$	235-236
	$e^- + C_3H_6$	\rightarrow	$2e^- + C_2H_3^+ + CH_3$	235-236
	$e^- + C_3H_6$	\rightarrow	$2e^- + C_2H_2^+ + CH_4$	235-236
	$e^- + C_3H_6$	\rightarrow	$2e^- + CH_3^+ + C_2H_3$	235-236
Dissociation	$e^- + C_3H_6$	\rightarrow	$e^- + C_3H_5 + H$	235-236
	$e^- + C_3H_6$	\rightarrow	$e^- + C_2H_2 + CH_4$	235-236
C ₃ H ₅				
Dissociative Ionization	$e^- + C_3H_5$	\rightarrow	$2e^- + C_2H_3^+ + CH_2$	235-236
	$e^- + C_3H_5$	\rightarrow	$2e^- + C_2H_2^+ + CH_3$	235-236
	$e^- + C_3H_5$	\rightarrow	$2e^- + CH_3^+ + C_2H_2$	235-236
Dissociation	$e^- + C_3H_5$	\rightarrow	$e^- + C_2H_2 + CH_3$	235-236
H ₂				
Momentum Transfer	$e^- + H_2$	\rightarrow	$e^- + H_2$	237

Appendices Table A.1.

Vibrational Excitation	$e^- + H_2$	$\rightarrow e^- + H_2^*$	(3)	238
Ionization	$e^- + H_2$	$\rightarrow 2e^- + H_2^+$		239
Dissociation	$e^- + H_2$	$\rightarrow e^- + 2H$		240
H				
Ionization	$e^- + H$	$\rightarrow 2e^- + H^+$		239
O₂				
Momentum Transfer	$e^- + O_2$	$\rightarrow e^- + O_2$		195
Vibrational Excitation	$e^- + O_2$	$\rightarrow e^- + O_2^*$	(4)	195
Electronic Excitation	$e^- + O_2$	$\rightarrow e^- + O_2^*$	(4)	194-195
Ionization	$e^- + O_2$	$\rightarrow 2e^- + O_2^+$		194
Dissociative Ionization	$e^- + O_2$	$\rightarrow 2e^- + O^+ + O$		195
Attachment	$e^- + O_2 + O_2$	$\rightarrow O_2^- + O_2$		Energy dependent rate coefficient 241
Dissociative Attachment	$e^- + O_2$	$\rightarrow O^- + O$		195
Ion-pair formation	$e^- + O_2$	$\rightarrow e^- + O^+ + O^-$		Energy dependent rate coefficient 242
Dissociation	$e^- + O_2$	$\rightarrow e^- + 2O$	(2)	195
O				
Momentum Transfer	$e^- + O$	$\rightarrow e^- + O$		243
Electronic Excitation	$e^- + O$	$\rightarrow e^- + O^*$	(2)	244

Appendices Table A.1.

Ionization	$e^- + O$	$\rightarrow 2e^- + O^+$		244
Attachment	$e^- + O + O_2$	$\rightarrow O^- + O_2$	$1.00 \times 10^{-31} \text{ cm}^6 \text{ s}^{-1}$	195
<hr/>				
O₃				
Dissociative Ionization	$e^- + O_3$	$\rightarrow 2e^- + O_2^+ + O$		195
Attachment	$e^- + O_3 + O_2$	$\rightarrow O_3^- + O_2$	Energy dependent rate coefficient	241
Dissociative Attachment	$e^- + O_3$	$\rightarrow O^- + O_2$		245
	$e^- + O_3$	$\rightarrow O_2^- + O$		245
Ion-pair formation	$e^- + O_3$	$\rightarrow e^- + O^- + O^+ + O$		195
Dissociation	$e^- + O_3$	$\rightarrow e^- + O_2 + O$	Energy dependent rate coefficient	195
<hr/>				
CO₂				
Momentum Transfer	$e^- + CO_2$	$\rightarrow e^- + CO_2$		196
Vibrational Excitation	$e^- + CO_2$	$\rightarrow e^- + CO_2^*$	(3)	196
Electronic Excitation	$e^- + CO_2$	$\rightarrow e^- + CO_2^*$	(2)	246-247
Ionization	$e^- + CO_2$	$\rightarrow 2e^- + CO_2^+$		196
Dissociative Attachment	$e^- + CO_2$	$\rightarrow O^- + CO$		196
Dissociation	$e^- + CO_2$	$\rightarrow e^- + CO + O$		196

Appendices Table A.1.

CO						
Momentum Transfer	$e^- + CO$	\rightarrow	$e^- + CO$			238
Vibrational Excitation	$e^- + CO$	\rightarrow	$e^- + CO^*$	(1)		238
Electronic Excitation	$e^- + CO$	\rightarrow	$e^- + CO^*$	(5)		246-247
Ionization	$e^- + CO$	\rightarrow	$2e^- + CO^+$			248
Dissociative Attachment	$e^- + CO$	\rightarrow	$O^- + C$			249
Dissociation	$e^- + CO$	\rightarrow	$e^- + C + O$			248
H ₂ O						
Momentum Transfer	$e^- + H_2O$	\rightarrow	$e^- + H_2O$			250
Vibrational Excitation	$e^- + H_2O$	\rightarrow	$e^- + H_2O^*$	(2)		250
Ionization	$e^- + H_2O$	\rightarrow	$2e^- + H_2O^+$			250
Dissociative Attachment	$e^- + H_2O$	\rightarrow	$H^- + OH$			250
	$e^- + H_2O$	\rightarrow	$O^- + H_2$			250
	$e^- + H_2O$	\rightarrow	$OH^- + H$			250
Dissociation	$e^- + H_2O$	\rightarrow	$e^- + OH + H$			250
	$e^- + H_2O$	\rightarrow	$e^- + O + H_2$			250
OH						
Ionization	$e^- + OH$	\rightarrow	$2e^- + OH^+$		Energy dependent rate coefficient	251
Dissociation	$e^- + OH$	\rightarrow	$e^- + O + H$		Energy dependent rate coefficient	251

Table A.2. Electron-ion recombination reactions included in the model. These reactions are treated by energy-dependent rate coefficients, and the references where these rate coefficients were adopted from, are also included.

e^-	+	CH_5^+	\rightarrow	CH_3	+	$2H$		233, 252	
e^-	+	CH_5^+	\rightarrow	CH_2	+	H_2	+	H	233, 252
e^-	+	CH_4^+	\rightarrow	CH_3	+	H		233, 252	
e^-	+	CH_4^+	\rightarrow	CH_2	+	$2H$		233, 252	
e^-	+	CH_4^+	\rightarrow	CH	+	H_2	+	H	233, 252
e^-	+	CH_3^+	\rightarrow	CH_2	+	H		233, 252	
e^-	+	CH_3^+	\rightarrow	CH	+	H_2		233, 252	
e^-	+	CH_3^+	\rightarrow	CH	+	$2H$		233, 252	
e^-	+	CH_3^+	\rightarrow	C	+	H_2	+	H	233, 252
e^-	+	CH_2^+	\rightarrow	CH	+	H		233, 252	
e^-	+	CH_2^+	\rightarrow	C	+	H_2		233, 252	
e^-	+	CH_2^+	\rightarrow	C	+	$2H$		233, 252	
e^-	+	CH^+	\rightarrow	C	+	H		233, 252	
e^-	+	$C_2H_6^+$	\rightarrow	C_2H_5	+	H		236	
e^-	+	$C_2H_6^+$	\rightarrow	C_2H_4	+	$2H$		236	
e^-	+	$C_2H_5^+$	\rightarrow	C_2H_4	+	H		236	
e^-	+	$C_2H_5^+$	\rightarrow	C_2H_3	+	$2H$		236	
e^-	+	$C_2H_5^+$	\rightarrow	C_2H_2	+	H_2	+	H	236
e^-	+	$C_2H_5^+$	\rightarrow	C_2H_2	+	$3H$		236	
e^-	+	$C_2H_5^+$	\rightarrow	CH_3	+	CH_2		236	
e^-	+	$C_2H_4^+$	\rightarrow	C_2H_3	+	H		236	
e^-	+	$C_2H_4^+$	\rightarrow	C_2H_2	+	$2H$		236	

Appendices Table A.2.

e^-	+	$C_2H_4^+$		\rightarrow	C_2H	+	H_2	+	H	236
e^-	+	$C_2H_3^+$		\rightarrow	C_2H_2	+	H			236
e^-	+	$C_2H_3^+$		\rightarrow	C_2H	+	$2H$			236
e^-	+	$C_2H_2^+$		\rightarrow	C_2H	+	H			236
e^-	+	$C_2H_2^+$		\rightarrow	C_2	+	$2H$			236
e^-	+	$C_2H_2^+$		\rightarrow	$2CH$					236
e^-	+	C_2H^+		\rightarrow	C_2	+	H			236
e^-	+	C_2H^+		\rightarrow	CH	+	C			236
e^-	+	C_2H^+		\rightarrow	$2C$	+	H			236
e^-	+	C_2^+		\rightarrow	$2C$					236
e^-	+	H_3^+		\rightarrow	$3H$					252
e^-	+	H_3^+		\rightarrow	H_2	+	H			252
e^-	+	H_2^+		\rightarrow	$2H$					252
e^-	+	O^+	+	O_2	\rightarrow	O	+	O_2		241
e^-	+	O_2^+		\rightarrow	O	+	O			241
e^-	+	O_2^+	+	O_2	\rightarrow	O_2	+	O_2		241
e^-	+	O_4^+		\rightarrow	O_2	+	O_2			241
e^-	+	CO_2^+		\rightarrow	CO	+	O			252
e^-	+	CO^+		\rightarrow	C	+	O			252
e^-	+	OH^+		\rightarrow	O	+	H			252
e^-	+	H_2O^+		\rightarrow	OH	+	H			252
e^-	+	H_2O^+		\rightarrow	O	+	H_2			252
e^-	+	H_2O^+		\rightarrow	O	+	$2H$			252
e^-	+	H_3O^+		\rightarrow	H_2O	+	H			252
e^-	+	H_3O^+		\rightarrow	OH	+	H_2			252
e^-	+	H_3O^+		\rightarrow	OH	+	$2H$			252

Table A.3. Neutral-neutral reactions included in the model, as well as the corresponding rate coefficients at 300 K and the references where these data were adopted from. Note a means “estimated value”; b = “adjusted in the model for a three-body collision by dividing by $2.446 \times 10^{19} \text{ cm}^{-3}$, i.e., the density of the inlet gas”. M = CH₄ in pure CH₄, M = CH₄, CO₂, O₂ or H₂O in the CH₄/O₂ and CH₄/CO₂ gas mixtures and M = CO₂ or H₂ in the CO₂/H₂ gas mixtures. The rate coefficients are expressed in $\text{cm}^3 \text{ s}^{-1}$ and $\text{cm}^6 \text{ s}^{-1}$ for two-body and three-body reactions, respectively. Note that the values in Table A.3. and Table A.4. are defined with two decimal digits, as found in literature, however, this precision is not decisive for the output of the model considering the likely uncertainty of these values.

CH ₄	+	CH ₂	→	CH ₃	+	CH ₃	3.01×10^{-19}	253		
CH ₄	+	CH	→	C ₂ H ₄	+	H	9.74×10^{-11}	254		
CH ₄	+	C ₂ H ₅	→	C ₂ H ₆	+	CH ₃	1.83×10^{-24}	253		
CH ₄	+	C ₂ H ₃	→	C ₂ H ₄	+	CH ₃	2.28×10^{-18}	253		
CH ₄	+	C ₂ H	→	C ₂ H ₂	+	CH ₃	1.31×10^{-12}	253		
CH ₄	+	C ₃ H ₇	→	C ₃ H ₈	+	CH ₃	4.38×10^{-24}	255		
CH ₄	+	C ₃ H ₅	→	C ₃ H ₆	+	CH ₃	2.02×10^{-31}	256		
CH ₄	+	H	→	CH ₃	+	H ₂	8.43×10^{-19}	254		
CH ₃	+	CH ₃	→	C ₂ H ₅	+	H	2.71×10^{-19}	257		
CH ₃	+	CH ₃	+	M	→	C ₂ H ₆	+	M	1.56×10^{-26}	254
CH ₃	+	CH ₂	→	C ₂ H ₄	+	H	7.01×10^{-11}	254		
CH ₃	+	C ₂ H ₆	→	C ₂ H ₅	+	CH ₄	7.21×10^{-21}	254		
CH ₃	+	C ₂ H ₅	→	C ₂ H ₄	+	CH ₄	1.91×10^{-12}	254		
CH ₃	+	C ₂ H ₅	+	M	→	C ₃ H ₈	+	M	1.00×10^{-28}	a
CH ₃	+	C ₂ H ₄	→	C ₂ H ₃	+	CH ₄	1.94×10^{-21}	253		

Appendices Table A.3.

CH ₃	+	C ₂ H ₃		→	C ₂ H ₂	+	CH ₄	6.51x10 ⁻¹³	253	
								1.20x10 ⁻¹⁰	258	
CH ₃	+	C ₂ H ₃	+	M	→	C ₃ H ₆	+	M	4.91x10 ⁻³⁰ b	
CH ₃	+	C ₂ H ₂		→	CH ₄	+	C ₂ H	7.65x10 ⁻²⁶	253	
CH ₃	+	C ₃ H ₈		→	C ₃ H ₇	+	CH ₄	1.02x10 ⁻²⁰	255	
CH ₃	+	C ₃ H ₇		→	C ₃ H ₆	+	CH ₄	3.07x10 ⁻¹²	255	
CH ₃	+	C ₃ H ₆		→	C ₃ H ₅	+	CH ₄	1.24x10 ⁻¹⁹	256	
CH ₃	+	H ₂		→	CH ₄	+	H	9.60x10 ⁻²¹	254	
CH ₃	+	H		→	CH ₂	+	H ₂	9.96x10 ⁻²²	254	
CH ₃	+	H	+	M	→	CH ₄	+	M	2.97x10 ⁻²⁸	254
CH ₂	+	CH ₂		→	C ₂ H ₂	+	2H	5.27x10 ⁻¹¹	254	
CH ₂	+	C ₂ H ₅		→	C ₂ H ₄	+	CH ₃	3.01x10 ⁻¹¹	253	
CH ₂	+	C ₂ H ₃		→	C ₂ H ₂	+	CH ₃	3.01x10 ⁻¹¹	253	
CH ₂	+	C ₂ H		→	C ₂ H ₂	+	CH	3.01x10 ⁻¹¹	253	
CH ₂	+	C ₃ H ₈		→	C ₃ H ₇	+	CH ₃	1.02x10 ⁻²⁰	255	
CH ₂	+	C ₃ H ₇		→	C ₂ H ₄	+	C ₂ H ₅	3.01x10 ⁻¹¹	255	
CH ₂	+	C ₃ H ₇		→	C ₃ H ₆	+	CH ₃	3.01x10 ⁻¹²	255	
CH ₂	+	C ₃ H ₆		→	C ₃ H ₅	+	CH ₃	3.65x10 ⁻¹⁷	256	
CH ₂	+	H ₂		→	CH ₃	+	H	5.00x10 ⁻¹⁵	253	
CH ₂	+	H		→	CH	+	H ₂	2.01x10 ⁻¹⁰	254	
								2.78x10 ⁻¹⁰	254	
CH	+	C ₂ H ₆	+	M	→	C ₃ H ₇	+	M	1.14x10 ⁻²⁹ b	
CH	+	H ₂		→	CH ₂	+	H	6.80x10 ⁻¹³	254	
CH	+	H		→	C	+	H ₂	1.00x10 ⁻¹⁰	259	
C	+	H ₂		→	CH	+	H	1.50x10 ⁻¹⁰	260	
C ₂ H ₆	+	C ₂ H ₃		→	C ₂ H ₅	+	C ₂ H ₄	3.39x10 ⁻²¹	253	

C_2H_6	+	C_2H	\rightarrow	C_2H_2	+	C_2H_5	5.99×10^{-12}	253
C_2H_6	+	C_3H_7	\rightarrow	C_3H_8	+	C_2H_5	3.16×10^{-22}	255
C_2H_6	+	C_3H_5	\rightarrow	C_3H_6	+	C_2H_5	2.02×10^{-28}	256
C_2H_6	+	H	\rightarrow	C_2H_5	+	H_2	4.96×10^{-17}	254
C_2H_5	+	C_2H_5	\rightarrow	C_2H_6	+	C_2H_4	2.41×10^{-12}	254
C_2H_5	+	C_2H_4	\rightarrow	C_2H_6	+	C_2H_3	4.56×10^{-27}	253
C_2H_5	+	C_2H_2	\rightarrow	C_2H_6	+	C_2H	3.72×10^{-30}	253
C_2H_5	+	C_2H	\rightarrow	C_2H_4	+	C_2H_2	3.01×10^{-12}	253
C_2H_5	+	C_3H_8	\rightarrow	C_2H_6	+	C_3H_7	3.62×10^{-22}	255
C_2H_5	+	C_3H_7	\rightarrow	C_3H_8	+	C_2H_4	1.91×10^{-12}	255
C_2H_5	+	C_3H_7	\rightarrow	C_3H_6	+	C_2H_6	2.41×10^{-12}	255
C_2H_5	+	C_3H_6	\rightarrow	C_3H_5	+	C_2H_6	2.53×10^{-20}	256
C_2H_5	+	C_3H_5	\rightarrow	C_3H_6	+	C_2H_4	5.36×10^{-12}	256
C_2H_5	+	H_2	\rightarrow	C_2H_6	+	H	2.97×10^{-21}	253
C_2H_5	+	H	\rightarrow	CH_3	+	CH_3	5.99×10^{-11}	254
C_2H_5	+	H	\rightarrow	C_2H_4	+	H_2	3.01×10^{-12}	253
C_2H_5	+	H					2.25×10^{-10}	261
C_2H_5	+	H	+	M	\rightarrow	C_2H_6	+	M
							9.20×10^{-30}	b
C_2H_4	+	C_2H	\rightarrow	C_2H_2	+	C_2H_3	1.40×10^{-10}	258
C_2H_4	+	H	\rightarrow	C_2H_3	+	H_2	4.92×10^{-21}	253
C_2H_4	+	H	+	M	\rightarrow	C_2H_5	+	M
							3.66×10^{-30}	254
C_2H_3	+	C_2H_3	\rightarrow	C_2H_4	+	C_2H_2	1.60×10^{-12}	253
C_2H_3	+	C_2H	\rightarrow	C_2H_2	+	C_2H_2	1.60×10^{-12}	253
C_2H_3	+	C_3H_8	\rightarrow	C_2H_4	+	C_3H_7	3.40×10^{-21}	255
C_2H_3	+	C_3H_7	\rightarrow	C_3H_8	+	C_2H_2	2.01×10^{-12}	255
C_2H_3	+	C_3H_7	\rightarrow	C_3H_6	+	C_2H_4	2.01×10^{-12}	255

Appendices Table A.3.

C_2H_3	+	C_3H_6		\rightarrow	C_3H_5	+	C_2H_4		6.58×10^{-19}	256
C_2H_3	+	C_3H_5		\rightarrow	C_3H_6	+	C_2H_2		8.00×10^{-12}	256
C_2H_3	+	H_2		\rightarrow	C_2H_4	+	H		9.78×10^{-20}	253
C_2H_3	+	H		\rightarrow	C_2H_2	+	H_2		2.01×10^{-11}	254
C_2H_3	+	H							2.02×10^{-10}	261
C_2H_3	+	H	+	M	\rightarrow	C_2H_4	+	M	8.26×10^{-30}	b
C_2H_2	+	C_2H		\rightarrow	C_4H_2	+	H		1.50×10^{-10}	114
C_2H_2	+	H		\rightarrow	C_2H	+	H_2		6.12×10^{-27}	253
C_2H_2	+	H	+	M	\rightarrow	C_2H_3	+	M	2.81×10^{-31}	254
C_2H	+	C_2H		\rightarrow	C_2H_2	+	C_2		3.01×10^{-12}	253
C_2H	+	C_3H_8		\rightarrow	C_2H_2	+	C_3H_7		5.99×10^{-12}	255
C_2H	+	C_3H_7		\rightarrow	C_3H_6	+	C_2H_2		1.00×10^{-11}	255
C_2H	+	C_3H_6		\rightarrow	C_3H_5	+	C_2H_2		5.99×10^{-12}	256
C_2H	+	H_2		\rightarrow	C_2H_2	+	H		1.52×10^{-13}	253
C_2H	+	H		\rightarrow	C_2	+	H_2		1.66×10^{-31}	253
C_2H	+	H							2.31×10^{-10}	261
C_2H	+	H	+	M	\rightarrow	C_2H_2	+	M	9.44×10^{-30}	b
C_3H_8	+	C_3H_5		\rightarrow	C_3H_6	+	C_3H_7		2.02×10^{-28}	256
C_3H_8	+	H		\rightarrow	C_3H_7	+	H_2		5.15×10^{-17}	255
C_3H_7	+	C_3H_7		\rightarrow	C_3H_6	+	C_3H_8		2.81×10^{-12}	255
C_3H_7	+	C_3H_6		\rightarrow	C_3H_5	+	C_3H_8		2.53×10^{-20}	256
C_3H_7	+	C_3H_5		\rightarrow	C_3H_6	+	C_3H_6		3.00×10^{-12}	256
C_3H_7	+	H_2		\rightarrow	C_3H_8	+	H		7.12×10^{-21}	255
C_3H_7	+	H		\rightarrow	C_3H_6	+	H_2		3.01×10^{-12}	255
C_3H_7	+	H							9.68×10^{-11}	261
C_3H_7	+	H	+	M	\rightarrow	C_3H_8	+	M	3.96×10^{-30}	b

C_3H_6	+	H		\rightarrow	C_3H_5	+	H_2		6.94×10^{-15}	256		
C_3H_6	+	H	+	M	\rightarrow	C_3H_7	+	M	9.26×10^{-14}	256		
C_3H_5	+	H_2			\rightarrow	C_3H_6	+	H	3.79×10^{-33}	b		
C_3H_5	+	H	+	M	\rightarrow	C_3H_6	+	M	2.05×10^{-27}	256		
C_3H_5	+	H	+	M	\rightarrow	C_3H_6	+	M	3.26×10^{-10}	262		
H	+	H	+	M	\rightarrow	H_2	+	M	1.33×10^{-29}	b		
H	+	H	+	M	\rightarrow	H_2	+	M	6.00×10^{-33}	254		
O_3	+	O			\rightarrow	O_2	+	O_2	8.43×10^{-15}	263		
O_3	+	O_2			\rightarrow	O	+	O_2	+	O_2	2.29×10^{-26}	263
O	+	O_2	+	M	\rightarrow	O_3	+	M	6.90×10^{-34}	263		
O_3	+	O_3			\rightarrow	O	+	O_2	+	O_3	5.18×10^{-26}	263
O	+	O	+	O	\rightarrow	O_2	+	O	5.09×10^{-33}	263		
O	+	O	+	M	\rightarrow	O_2	+	M	7.19×10^{-33}	263		
O	+	O_2	+	O	\rightarrow	O_3	+	O	6.32×10^{-34}	263		
O	+	O_2	+	O_3	\rightarrow	O_3	+	O_3	1.52×10^{-33}	263		
O_3	+	O			\rightarrow	O	+	O_2	+	O	3.14×10^{-27}	263
CH ₄	+	O			\rightarrow	CH ₃	+	OH	5.54×10^{-18}	254		
CH ₃	+	O			\rightarrow	CH ₂ O	+	H	1.12×10^{-10}	264		
CH ₃	+	O			\rightarrow	CO	+	H_2	+	H	2.80×10^{-11}	264
CH ₃	+	O_2	+	M	\rightarrow	CH ₃ O ₂	+	M	9.79×10^{-31}	265		
CH ₃	+	O_3			\rightarrow	CH ₃ O	+	O_2	2.33×10^{-12}	265		
CH ₂	+	O			\rightarrow	CO	+	H_2	5.53×10^{-11}	264		
CH ₂	+	O			\rightarrow	CO	+	2H	8.29×10^{-11}	264		
CH ₂	+	O_2			\rightarrow	CO ₂	+	H_2	1.42×10^{-12}	254, 266		
CH ₂	+	O_2			\rightarrow	CO	+	H ₂ O	1.42×10^{-12}	254, 266		

Appendices Table A.3.

CH ₂	+	O ₂	→	CH ₂ O	+	O	5.39x10 ⁻¹³	254, 266	
CH	+	O	→	CO	+	H	6.60x10 ⁻¹¹	254	
CH	+	O ₂	→	CO ₂	+	H	1.20x10 ⁻¹¹	264	
CH	+	O ₂	→	CO	+	OH	8.00x10 ⁻¹²	264	
CH	+	O ₂	→	CHO	+	O	8.00x10 ⁻¹²	264	
CH	+	O ₂	→	CO	+	H	+ O	1.20x10 ⁻¹¹	264
C	+	O ₂	→	CO	+	O	2.45x10 ⁻¹³	267	
C ₂ H ₆	+	O	→	C ₂ H ₅	+	OH	5.11x10 ⁻¹⁶	254	
C ₂ H ₅	+	O	→	CH ₃ CHO	+	H	8.80x10 ⁻¹¹	264	
C ₂ H ₅	+	O	→	CH ₂ O	+	CH ₃	6.60x10 ⁻¹¹	264	
C ₂ H ₅	+	O	→	C ₂ H ₄	+	OH	4.40x10 ⁻¹¹	264	
C ₂ H ₅	+	O ₂	→	C ₂ H ₄	+	HO ₂	3.80x10 ⁻¹⁵	265	
C ₂ H ₅	+	O ₂	+ M	→	C ₂ H ₅ O ₂	+	M	5.75x10 ⁻²⁹	265
C ₂ H ₄	+	O	→	CH ₂ CHO	+	H	2.63x10 ⁻¹³	264	
C ₂ H ₄	+	O	→	CHO	+	CH ₃	4.51x10 ⁻¹³	264	
C ₂ H ₄	+	O ₃	→	CH ₂ O	+	CO ₂	+ H ₂	7.06x10 ⁻¹⁹	265- 266
C ₂ H ₄	+	O ₃	→	CH ₂ O	+	CO	+ H ₂ O	7.06x10 ⁻¹⁹	265- 266
C ₂ H ₄	+	O ₃	→	2CH ₂ O	+	O	2.69x10 ⁻¹⁹	265- 266	
C ₂ H ₃	+	O	→	C ₂ H ₂	+	OH	1.25x10 ⁻¹¹	264	
C ₂ H ₃	+	O	→	CO	+	CH ₃	1.25x10 ⁻¹¹	264	
C ₂ H ₃	+	O	→	CHO	+	CH ₂	1.25x10 ⁻¹¹	264	
C ₂ H ₃	+	O	→	CH ₂ CO	+	H	1.25x10 ⁻¹¹	264	
C ₂ H ₃	+	O ₂	→	CH ₂ O	+	CHO	9.00x10 ⁻¹²	254	
C ₂ H ₂	+	O	→	CH ₂	+	CO	6.75x10 ⁻¹⁴	254	

C_2H_2	+	O		\rightarrow	C_2HO	+	H		6.75×10^{-14}	254
C_2H	+	O		\rightarrow	CH	+	CO		1.70×10^{-11}	254
C_2H	+	O_2		\rightarrow	CHO	+	CO		3.00×10^{-11}	254
C_2H	+	O_2		\rightarrow	C_2HO	+	O		1.00×10^{-12}	253
C_3H_8	+	O		\rightarrow	C_3H_7	+	OH		2.73×10^{-15}	255
H_2	+	O		\rightarrow	OH	+	H		9.32×10^{-18}	254
H	+	O	+	M	\rightarrow	OH	+	M	4.33×10^{-32}	253
H	+	O_2		\rightarrow	OH	+	O		1.87×10^{-22}	254
H	+	O_2	+	M	\rightarrow	HO_2	+	M	5.40×10^{-32}	268
H	+	O_3		\rightarrow	OH	+	O_2		2.83×10^{-11}	269
CH_4	+	OH		\rightarrow	CH_3	+	H_2O		6.62×10^{-15}	265
CH_4	+	HO_2		\rightarrow	CH_3	+	H_2O_2		8.76×10^{-27}	253
CH_4	+	CHO		\rightarrow	CH_3	+	CH_2O		6.07×10^{-30}	253
CH_4	+	CH_3O		\rightarrow	CH_3OH	+	CH_3		9.42×10^{-20}	253
CH_4	+	CH_3O_2		\rightarrow	CH_3	+	CH_3OOH		1.03×10^{-26}	253
CH_3	+	CO	+	M	\rightarrow	CH_3CO	+	M	4.19×10^{-36}	114
CH_3	+	H_2O		\rightarrow	CH_4	+	OH		1.82×10^{-25}	253
CH_3	+	OH		\rightarrow	CH_2	+	H_2O		1.13×10^{-12}	114
CH_3	+	OH		\rightarrow	CH_2OH	+	H		1.31×10^{-11}	270
CH_3	+	OH		\rightarrow	CH_3O	+	H		1.60×10^{-10}	270
CH_3	+	OH	+	M	\rightarrow	CH_3OH	+	M	2.30×10^{-27}	114
CH_3	+	HO_2		\rightarrow	CH_3O	+	OH		3.00×10^{-11}	254
CH_3	+	HO_2		\rightarrow	CH_4	+	O_2		5.99×10^{-12}	253
CH_3	+	CH_2O		\rightarrow	CH_4	+	CHO		6.14×10^{-18}	114
CH_3	+	CHO		\rightarrow	CH_4	+	CO		2.00×10^{-10}	253
CH_3	+	CH_3O		\rightarrow	CH_4	+	CH_2O		4.00×10^{-11}	253

Appendices Table A.3.

CH ₃	+	CH ₃ CHO	→	CH ₄	+	CH ₃ CO	4.95x10 ⁻¹⁸	254	
CH ₃	+	CH ₃ O ₂	→	CH ₃ O	+	CH ₃ O	4.00x10 ⁻¹¹	253	
CH ₂	+	CO ₂	→	CH ₂ O	+	CO	3.90x10 ⁻¹⁴	253	
CH ₂	+	H ₂ O	→	CH ₃	+	OH	1.60x10 ⁻¹⁶	253	
CH ₂	+	OH	→	CH ₂ O	+	H	3.00x10 ⁻¹¹	253	
CH ₂	+	HO ₂	→	CH ₂ O	+	OH	3.00x10 ⁻¹¹	253	
CH ₂	+	CH ₂ O	→	CH ₃	+	CHO	1.00x10 ⁻¹⁴	253	
CH ₂	+	CHO	→	CH ₃	+	CO	3.00x10 ⁻¹¹	253	
CH ₂	+	CH ₃ O	→	CH ₃	+	CH ₂ O	3.00x10 ⁻¹¹	253	
CH ₂	+	CH ₃ O ₂	→	CH ₂ O	+	CH ₃ O	3.00x10 ⁻¹¹	253	
CH	+	CO ₂	→	CHO	+	CO	9.68x10 ⁻¹³	264	
CH	+	CO ₂	→	2CO	+	H	9.68x10 ⁻¹³	264	
CH	+	CO	+ M	→	C ₂ H ₂ O	+	M	4.04x10 ⁻³⁰	264
C ₂ H ₆	+	OH	→	C ₂ H ₅	+	H ₂ O	2.46x10 ⁻¹³	265	
C ₂ H ₆	+	HO ₂	→	C ₂ H ₅	+	H ₂ O ₂	6.36x10 ⁻²⁴	253	
C ₂ H ₆	+	CHO	→	C ₂ H ₅	+	CH ₂ O	2.19x10 ⁻²⁶	253	
C ₂ H ₆	+	CH ₃ O	→	C ₂ H ₅	+	CH ₃ OH	2.72x10 ⁻¹⁸	253	
C ₂ H ₆	+	CH ₃ O ₂	→	C ₂ H ₅	+	CH ₃ OOH	6.36x10 ⁻²⁴	253	
C ₂ H ₆	+	C ₂ H ₅ O ₂	→	C ₂ H ₅	+	C ₂ H ₅ OOH	8.69x10 ⁻²⁷	271	
C ₂ H ₅	+	H ₂ O	→	C ₂ H ₆	+	OH	3.56x10 ⁻²⁹	253	
C ₂ H ₅	+	OH	→	C ₂ H ₄	+	H ₂ O	4.00x10 ⁻¹¹	253	
C ₂ H ₅	+	HO ₂	→	C ₂ H ₆	+	O ₂	5.00x10 ⁻¹³	253	
C ₂ H ₅	+	HO ₂	→	C ₂ H ₄	+	H ₂ O ₂	5.00x10 ⁻¹³	253	
C ₂ H ₅	+	CH ₂ O	→	C ₂ H ₆	+	CHO	4.47x10 ⁻¹⁸	253	
C ₂ H ₅	+	CHO	→	C ₂ H ₆	+	CO	2.00x10 ⁻¹⁰	253	
C ₂ H ₅	+	CH ₃ O	→	C ₂ H ₆	+	CH ₂ O	4.00x10 ⁻¹¹	253	

C_2H_5	+	CH_3O_2	\rightarrow	CH_3O	+	C_2H_5O	4.00×10^{-11}	253		
C_2H_4	+	OH	\rightarrow	C_2H_3	+	H_2O	1.54×10^{-16}	253		
C_2H_4	+	HO_2	\rightarrow	CH_3CHO	+	OH	1.62×10^{-20}	253		
C_2H_3	+	H_2O	\rightarrow	C_2H_4	+	OH	1.82×10^{-25}	253		
C_2H_3	+	OH	\rightarrow	C_2H_2	+	H_2O	5.00×10^{-11}	253		
C_2H_3	+	CH_2O	\rightarrow	C_2H_4	+	CHO	4.41×10^{-18}	253		
C_2H_3	+	CHO	\rightarrow	C_2H_4	+	CO	1.50×10^{-10}	253		
C_2H_3	+	CH_3O	\rightarrow	C_2H_4	+	CH_2O	4.00×10^{-11}	253		
C_2H_2	+	OH	\rightarrow	C_2H	+	H_2O	1.77×10^{-22}	253		
C_2H_2	+	HO_2	\rightarrow	CH_2CO	+	OH	1.62×10^{-20}	253		
C_2H	+	OH	\rightarrow	CH_2	+	CO	3.00×10^{-11}	253		
C_2H	+	OH	\rightarrow	C_2H_2	+	O	3.00×10^{-11}	253		
C_2H	+	HO_2	\rightarrow	C_2H_2	+	O_2	3.00×10^{-11}	253		
C_2H	+	HO_2	\rightarrow	C_2HO	+	OH	3.00×10^{-11}	253		
C_2H	+	CHO	\rightarrow	C_2H_2	+	CO	1.00×10^{-10}	253		
C_2H	+	CH_3O	\rightarrow	C_2H_2	+	CH_2O	4.00×10^{-11}	253		
C_2H	+	CH_3O_2	\rightarrow	CH_3O	+	C_2HO	4.00×10^{-11}	253		
C_3H_8	+	OH	\rightarrow	C_3H_7	+	H_2O	3.76×10^{-15}	255		
C_3H_8	+	HO_2	\rightarrow	C_3H_7	+	H_2O_2	1.58×10^{-25}	255		
C_3H_8	+	CHO	\rightarrow	C_3H_7	+	CH_2O	1.95×10^{-26}	255		
C_3H_8	+	CH_3O	\rightarrow	C_3H_7	+	CH_3OH	1.42×10^{-17}	255		
C_3H_8	+	CH_3O_2	\rightarrow	C_3H_7	+	CH_3OOH	7.69×10^{-26}	255		
C_3H_7	+	CH_2O	\rightarrow	C_3H_8	+	CHO	4.10×10^{-18}	255		
C_3H_7	+	CHO	\rightarrow	C_3H_8	+	CO	1.00×10^{-10}	255		
C_3H_7	+	CH_3O	\rightarrow	C_3H_8	+	CH_2O	4.00×10^{-11}	255		
C_3H_7	+	CH_3O_2	\rightarrow	C_2H_5	+	CH_2O	+	CH_3O	5.99×10^{-11}	255

Appendices Table A.3.

H ₂	+	OH	→	H	+	H ₂ O	7.02x10 ⁻¹⁵	268
H ₂	+	HO ₂	→	H	+	H ₂ O ₂	5.43x10 ⁻³⁰	253
H ₂	+	CHO	→	H	+	CH ₂ O	2.78x10 ⁻²⁶	253
H ₂	+	CH ₃ O ₂	→	H	+	CH ₃ OOH	5.43x10 ⁻³⁰	253
H	+	CO ₂	→	CO	+	OH	1.40x10 ⁻²⁹	253
H	+	CO	+ M →	CHO	+	M	1.54x10 ⁻³⁴	114
H	+	H ₂ O	→	H ₂	+	OH	5.86x10 ⁻²⁶	254
H	+	OH	→	H ₂	+	O	1.05x10 ⁻¹⁶	253
H	+	OH	+ M →	H ₂ O	+	M	4.33x10 ⁻³⁰	254
H	+	HO ₂	→	H ₂	+	O ₂	5.60x10 ⁻¹²	268
H	+	HO ₂	→	H ₂ O	+	O	2.40x10 ⁻¹²	268
H	+	HO ₂	→	OH	+	OH	7.20x10 ⁻¹¹	268
H	+	CH ₂ O	→	H ₂	+	CHO	5.72x10 ⁻¹⁴	114
H	+	CHO	→	H ₂	+	CO	1.50x10 ⁻¹⁰	254
H	+	CH ₃ O	→	H ₂	+	CH ₂ O	2.32x10 ⁻¹¹	264
H	+	CH ₃ O	→	CH ₃	+	OH	9.93x10 ⁻¹²	264
H	+	CH ₃ CHO	→	H ₂	+	CH ₃ CO	8.98x10 ⁻¹⁴	254
H	+	CH ₂ CO	→	CH ₃	+	CO	1.04x10 ⁻¹³	254
H	+	C ₂ HO	→	CH ₂	+	CO	2.50x10 ⁻¹⁰	254
H	+	CH ₃ O ₂	→	OH	+	CH ₃ O	1.60x10 ⁻¹⁰	253
O	+	CO	+ M →	CO ₂	+	M	1.11x10 ⁻³⁵	253
O	+	H ₂ O	→	OH	+	OH	4.48x10 ⁻²⁴	253
O	+	OH	→	H	+	O ₂	3.46x10 ⁻¹¹	268
O	+	HO ₂	→	O ₂	+	OH	5.70x10 ⁻¹¹	268
O	+	CH ₂ O	→	OH	+	CHO	1.73x10 ⁻¹³	254
O	+	CHO	→	CO	+	OH	5.00x10 ⁻¹¹	254

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O	+ CHO	→ H	+ CO ₂		5.00x10 ⁻¹¹	254
O	+ CH ₃ O	→ CH ₃	+ O ₂		2.20x10 ⁻¹¹	254
O	+ CH ₃ O	→ OH	+ CH ₂ O		3.00x10 ⁻¹²	254
O	+ CH ₃ CHO	→ OH	+ CH ₃ CO		4.68x10 ⁻¹³	254
O	+ CH ₂ CO	→ CH ₂	+ CO ₂		2.29x10 ⁻¹³	254, 272
O	+ CH ₂ CO	→ CH ₂ O	+ CO		7.88x10 ⁻¹⁴	254, 272
O	+ CH ₂ CO	→ CHO	+ CO	+ H	4.33x10 ⁻¹⁴	254, 272
O	+ CH ₂ CO	→ CHO	+ CHO		4.33x10 ⁻¹⁴	254, 272
O	+ C ₂ HO	→ CO	+ CO	+ H	1.60x10 ⁻¹⁰	254
O	+ CH ₃ O ₂	→ CH ₃ O	+ O ₂		5.99x10 ⁻¹¹	253
O	+ CH ₃ OOH	→ CH ₃ O ₂	+ OH		5.63x10 ⁻¹⁵	264
O ₂	+ CHO	→ CO	+ HO ₂		5.10x10 ⁻¹²	265
O ₂	+ CH ₃ O	→ CH ₂ O	+ HO ₂		1.97x10 ⁻¹⁵	265
O ₂	+ CH ₂ CHO	→ CH ₂ O	+ CO	+ OH	3.00x10 ⁻¹⁴	254, 273- 274
O ₂	+ C ₂ HO	→ CO	+ CO	+ OH	6.46x10 ⁻¹³	254
O ₃	+ OH	→ O ₂	+ HO ₂		7.41x10 ⁻¹⁴	268
O ₃	+ HO ₂	→ O ₂	+ O ₂	+ OH	2.05x10 ⁻¹⁵	268
O ₃	+ CH ₃ O ₂	→ CH ₃ O	+ O ₂	+ O ₂	1.00x10 ⁻¹⁷	275
CO	+ OH	→ CO ₂	+ H		1.25x10 ⁻¹³	254
CO	+ HO ₂	→ CO ₂	+ OH		1.49x10 ⁻²⁷	254
CO	+ CH ₃ O	→ CO ₂	+ CH ₃		6.56x10 ⁻²⁰	253
H ₂ O	+ CHO	→ CH ₂ O	+ OH		9.35x10 ⁻³²	253
H ₂ O	+ CH ₃ O	→ CH ₃ OH	+ OH		1.67x10 ⁻¹⁴	276

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OH	+	OH		→	H ₂ O	+	O		1.47x10 ⁻¹²	268
OH	+	OH	+	M	→	H ₂ O ₂	+	M	6.86x10 ⁻³¹	268
OH	+	HO ₂		→	O ₂	+	H ₂ O		1.10x10 ⁻¹⁰	268
OH	+	CH ₂ O		→	H ₂ O	+	CHO		8.47x10 ⁻¹²	265
OH	+	CHO		→	CO	+	H ₂ O		1.70x10 ⁻¹⁰	254
OH	+	CH ₃ O		→	CH ₂ O	+	H ₂ O		3.00x10 ⁻¹¹	253
OH	+	CH ₃ CHO		→	CH ₃ CO	+	H ₂ O		1.49x10 ⁻¹¹	265
OH	+	CH ₂ CO		→	CO	+	CH ₂ OH		1.14x10 ⁻¹¹	254, 277
OH	+	CH ₃ O ₂		→	CH ₃ OH	+	O ₂		1.00x10 ⁻¹⁰	253
HO ₂	+	HO ₂		→	H ₂ O ₂	+	O ₂		1.63x10 ⁻¹²	268
HO ₂	+	CH ₂ O		→	CHO	+	H ₂ O ₂		1.05x10 ⁻²⁰	253
HO ₂	+	CHO		→	OH	+	H	+	CO ₂	5.00x10 ⁻¹¹ 253
HO ₂	+	CH ₃ O		→	CH ₂ O	+	H ₂ O ₂		5.00x10 ⁻¹³	253
HO ₂	+	CH ₃ O ₂		→	CH ₃ OOH	+	O ₂		5.12x10 ⁻¹²	265
HO ₂	+	C ₂ H ₅ O ₂		→	C ₂ H ₅ OOH	+	O ₂		7.63x10 ⁻¹²	265
CH ₂ O	+	CH ₃ O		→	CH ₃ OH	+	CHO		1.14x10 ⁻¹⁵	253
CH ₂ O	+	CH ₃ O ₂		→	CHO	+	CH ₃ OOH		1.05x10 ⁻²⁰	253
CHO	+	CHO		→	CH ₂ O	+	CO		5.00x10 ⁻¹¹	254
CHO	+	CH ₃ O		→	CH ₃ OH	+	CO		1.50x10 ⁻¹⁰	253
CHO	+	CH ₃ O ₂		→	CH ₃ O	+	H	+	CO ₂	5.00x10 ⁻¹¹ 253
CH ₃ O	+	CH ₃ O		→	CH ₂ O	+	CH ₃ OH		1.00x10 ⁻¹⁰	253
CH ₃ O	+	CH ₃ O ₂		→	CH ₂ O	+	CH ₃ OOH		5.00x10 ⁻¹³	253
CH ₃ O ₂	+	CH ₃ O ₂		→	CH ₃ OH	+	CH ₂ O	+	O ₂	2.19x10 ⁻¹³ 265
CH ₃ O ₂	+	CH ₃ O ₂		→	CH ₃ O	+	CH ₃ O	+	O ₂	1.29x10 ⁻¹³ 265
C ₂ H ₅ O ₂	+	C ₂ H ₅ O ₂		→	C ₂ H ₅ OH	+	CH ₃ CHO	+	O ₂	2.43x10 ⁻¹⁴ 265
C ₂ H ₅ O ₂	+	C ₂ H ₅ O ₂		→	C ₂ H ₅ O	+	C ₂ H ₅ O	+	O ₂	3.97x10 ⁻¹⁴ 265

CH ₄	+	CH ₃ CO	→	CH ₃ CHO	+	CH ₃	1.14x10 ⁻²⁹	253
CH ₄	+	CH ₂ OH	→	CH ₃ OH	+	CH ₃	2.55x10 ⁻²⁷	278
CH ₃	+	H ₂ O ₂	→	CH ₄	+	HO ₂	5.46x10 ⁻¹⁴	253
CH ₃	+	CH ₃ OH	→	CH ₄	+	CH ₃ O	1.01x10 ⁻²⁰	278
CH ₃	+	CH ₃ OH	→	CH ₄	+	CH ₂ OH	2.66x10 ⁻²⁰	278
CH ₃	+	CH ₂ OH	→	CH ₄	+	CH ₂ O	4.00x10 ⁻¹²	278
CH ₃	+	C ₂ H ₅ OH	→	CH ₄	+	C ₂ H ₅ O	3.11x10 ⁻¹⁹	279
CH ₂	+	H ₂ O ₂	→	CH ₃	+	HO ₂	1.00x10 ⁻¹⁴	253
CH ₂	+	CH ₃ CO	→	CH ₂ CO	+	CH ₃	3.00x10 ⁻¹¹	253
CH ₂	+	CH ₃ OH	→	CH ₃ O	+	CH ₃	1.01x10 ⁻²⁰	278
CH ₂	+	CH ₃ OH	→	CH ₂ OH	+	CH ₃	2.66x10 ⁻²⁰	278
CH ₂	+	CH ₂ OH	→	CH ₂ O	+	CH ₃	2.00x10 ⁻¹²	278
CH ₂	+	CH ₂ OH	→	C ₂ H ₄	+	OH	4.00x10 ⁻¹¹	278
C ₂ H ₆	+	CH ₃ CO	→	CH ₃ CHO	+	C ₂ H ₅	3.32x10 ⁻²⁶	253
C ₂ H ₆	+	CH ₂ OH	→	CH ₃ OH	+	C ₂ H ₅	5.93x10 ⁻²⁵	278
C ₂ H ₅	+	H ₂ O ₂	→	C ₂ H ₆	+	HO ₂	2.83x10 ⁻¹⁵	253
C ₂ H ₅	+	CH ₃ OH	→	C ₂ H ₆	+	CH ₃ O	3.50x10 ⁻²²	278
C ₂ H ₅	+	CH ₃ OH	→	C ₂ H ₆	+	CH ₂ OH	9.49x10 ⁻²²	278
C ₂ H ₅	+	CH ₂ OH	→	C ₂ H ₆	+	CH ₂ O	4.00x10 ⁻¹²	278
C ₂ H ₅	+	CH ₂ OH	→	CH ₃ OH	+	C ₂ H ₄	4.00x10 ⁻¹²	278
C ₂ H ₃	+	H ₂ O ₂	→	C ₂ H ₄	+	HO ₂	5.46x10 ⁻¹⁴	253
C ₂ H ₃	+	CH ₃ OH	→	C ₂ H ₄	+	CH ₃ O	1.01x10 ⁻²⁰	278
C ₂ H ₃	+	CH ₃ OH	→	C ₂ H ₄	+	CH ₂ OH	2.66x10 ⁻²⁰	278
C ₂ H ₃	+	CH ₂ OH	→	C ₂ H ₄	+	CH ₂ O	5.00x10 ⁻¹¹	278
C ₂ H ₃	+	CH ₂ OH	→	C ₃ H ₅	+	OH	2.00x10 ⁻¹¹	278
C ₂ H ₂	+	CH ₂ OH	→	C ₂ H ₃	+	CH ₂ O	3.32x10 ⁻¹⁹	278

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C_2H	+	CH_3OH	\rightarrow	C_2H_2	+	CH_3O	2.00×10^{-12}	278
C_2H	+	CH_3OH	\rightarrow	C_2H_2	+	CH_2OH	1.00×10^{-11}	278
C_2H	+	CH_2OH	\rightarrow	C_2H_2	+	CH_2O	5.99×10^{-11}	278
C_3H_8	+	CH_3CO	\rightarrow	CH_3CHO	+	C_3H_7	2.60×10^{-26}	255
C_3H_8	+	CH_2OH	\rightarrow	CH_3OH	+	C_3H_7	4.45×10^{-25}	255
C_3H_7	+	OH	\rightarrow	C_3H_6	+	H_2O	4.00×10^{-11}	255
C_3H_7	+	H_2O_2	\rightarrow	C_3H_8	+	HO_2	7.08×10^{-17}	255
C_3H_7	+	CH_3OH	\rightarrow	C_3H_8	+	CH_3O	3.51×10^{-22}	255
C_3H_7	+	CH_3OH	\rightarrow	C_3H_8	+	CH_2OH	8.45×10^{-22}	255
C_3H_7	+	CH_2OH	\rightarrow	C_3H_8	+	CH_2O	1.60×10^{-12}	255
C_3H_7	+	CH_2OH	\rightarrow	C_3H_6	+	CH_3OH	8.00×10^{-13}	255
C_3H_6	+	O	\rightarrow	C_3H_5	+	OH	8.15×10^{-16}	256
C_3H_6	+	OH	\rightarrow	C_3H_5	+	H_2O	7.69×10^{-13}	256
C_3H_6	+	HO_2	\rightarrow	C_3H_5	+	H_2O_2	3.24×10^{-24}	256
C_3H_6	+	CHO	\rightarrow	C_3H_5	+	CH_2O	3.72×10^{-25}	256
C_3H_6	+	CH_3O	\rightarrow	C_3H_5	+	CH_3OH	5.65×10^{-24}	256
C_3H_6	+	CH_3O_2	\rightarrow	C_3H_5	+	CH_3OOH	1.25×10^{-24}	256
C_3H_6	+	CH_3CO	\rightarrow	C_3H_5	+	CH_3CHO	1.18×10^{-24}	256
C_3H_6	+	CH_2OH	\rightarrow	C_3H_5	+	CH_3OH	3.79×10^{-24}	256
C_3H_5	+	HO_2	\rightarrow	C_3H_6	+	O_2	4.40×10^{-12}	264
C_3H_5	+	H_2O_2	\rightarrow	C_3H_6	+	HO_2	1.00×10^{-23}	256
C_3H_5	+	CH_2O	\rightarrow	C_3H_6	+	CHO	6.06×10^{-25}	256
C_3H_5	+	CHO	\rightarrow	C_3H_6	+	CO	1.00×10^{-10}	256
C_3H_5	+	CH_3O	\rightarrow	C_3H_6	+	CH_2O	5.00×10^{-11}	256
C_3H_5	+	CH_3OH	\rightarrow	C_3H_6	+	CH_2OH	5.43×10^{-29}	256
C_3H_5	+	CH_2OH	\rightarrow	C_3H_6	+	CH_2O	3.00×10^{-11}	256

H ₂	+	CH ₃ CO	→	CH ₃ CHO	+	H	3.29x10 ⁻²⁶	253		
H ₂	+	CH ₂ OH	→	CH ₃ OH	+	H	1.89x10 ⁻²³	278		
H	+	H ₂ O ₂	→	H ₂ O	+	OH	4.20x10 ⁻¹⁴	254		
H	+	H ₂ O ₂	→	H ₂	+	HO ₂	5.15x10 ⁻¹⁵	254		
H	+	CH ₃ OH	→	CH ₂ OH	+	H ₂	1.27x10 ⁻¹⁵	278		
H	+	CH ₃ OH	→	CH ₃ O	+	H ₂	3.18x10 ⁻¹⁶	278		
H	+	CH ₂ OH	→	CH ₂ O	+	H ₂	1.00x10 ⁻¹¹	278		
H	+	CH ₂ OH	→	CH ₃	+	OH	1.60x10 ⁻¹⁰	278		
H	+	CH ₂ OH	+	M	→	CH ₃ OH	+	M	2.89x10 ⁻¹⁰	280
H	+	CH ₂ OH	+	M	→	CH ₃ OH	+	M	1.18x10 ⁻²⁹	b
H	+	C ₂ H ₅ OH	→	H ₂	+	C ₂ H ₅ O	2.52x10 ⁻¹⁷	281		
H	+	CH ₃ OOH	→	H ₂ O	+	CH ₃ O	5.88x10 ⁻¹⁵	282		
H	+	CH ₃ OOH	→	H ₂	+	CH ₃ O ₂	7.11x10 ⁻¹⁵	282		
O	+	H ₂ O ₂	→	HO ₂	+	OH	8.91x10 ⁻¹⁶	264		
O	+	H ₂ O ₂	→	O ₂	+	H ₂ O	8.91x10 ⁻¹⁶	264		
O	+	CH ₃ CO	→	OH	+	CH ₂ CO	8.75x10 ⁻¹¹	264		
O	+	CH ₃ CO	→	CO ₂	+	CH ₃	2.63x10 ⁻¹⁰	264		
O	+	CH ₃ OH	→	OH	+	CH ₂ OH	1.12x10 ⁻¹⁴	283		
O	+	CH ₃ OH	→	OH	+	CH ₃ O	1.68x10 ⁻¹⁵	283		
O	+	CH ₂ OH	→	CH ₂ O	+	OH	7.00x10 ⁻¹¹	278		
O	+	C ₂ H ₅ OOH	→	C ₂ H ₅ O ₂	+	OH	5.19x10 ⁻¹⁴	264		
O ₂	+	CH ₂ OH	→	CH ₂ O	+	HO ₂	9.70x10 ⁻¹²	265		
O ₂	+	C ₂ H ₅ O	→	CH ₃ CHO	+	HO ₂	8.12x10 ⁻¹⁵	265		
OH	+	H ₂ O ₂	→	HO ₂	+	H ₂ O	1.70x10 ⁻¹²	268		
OH	+	CH ₃ CO	→	CH ₂ CO	+	H ₂ O	2.00x10 ⁻¹¹	253		
OH	+	CH ₃ CO	→	CH ₃	+	CO	+	OH	5.00x10 ⁻¹¹	253

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OH	+	CH ₃ OH	→	H ₂ O	+	CH ₂ OH	7.67x10 ⁻¹³	265	
OH	+	CH ₃ OH	→	H ₂ O	+	CH ₃ O	1.35x10 ⁻¹³	265	
OH	+	CH ₂ OH	→	CH ₂ O	+	H ₂ O	4.00x10 ⁻¹¹	278	
OH	+	C ₂ H ₅ OH	→	H ₂ O	+	C ₂ H ₅ O	1.60x10 ⁻¹³	265	
OH	+	CH ₃ OOH	→	H ₂ O	+	CH ₃ O ₂	3.55x10 ⁻¹²	265	
OH	+	C ₂ H ₅ OOH	→	H ₂ O	+	C ₂ H ₅ O ₂	2.83x10 ⁻¹²	254	
HO ₂	+	CH ₃ CO	→	CH ₃	+	CO ₂	+ OH	5.00x10 ⁻¹¹	253
HO ₂	+	CH ₃ OH	→	CH ₂ OH	+	H ₂ O ₂	1.10x10 ⁻²²	278	
HO ₂	+	CH ₂ OH	→	CH ₂ O	+	H ₂ O ₂	2.00x10 ⁻¹¹	278	
CH ₂ O	+	CH ₃ CO	→	CH ₃ CHO	+	CHO	1.17x10 ⁻²²	253	
CH ₂ O	+	CH ₂ OH	→	CH ₃ OH	+	CHO	4.22x10 ⁻¹⁸	278	
CHO	+	H ₂ O ₂	→	CH ₂ O	+	HO ₂	1.50x10 ⁻¹⁸	253	
CHO	+	CH ₃ CO	→	CH ₃ CHO	+	CO	1.50x10 ⁻¹¹	253	
CHO	+	CH ₃ OH	→	CH ₂ O	+	CH ₂ OH	6.85x10 ⁻²³	278	
CHO	+	CH ₂ OH	→	CH ₂ O	+	CH ₂ O	3.00x10 ⁻¹⁰	278	
CHO	+	CH ₂ OH	→	CH ₃ OH	+	CO	2.00x10 ⁻¹⁰	278	
CH ₃ O	+	CH ₃ CO	→	CH ₃ OH	+	CH ₂ CO	1.00x10 ⁻¹¹	253	
CH ₃ O	+	CH ₃ OH	→	CH ₃ OH	+	CH ₂ OH	5.38x10 ⁻¹⁶	278	
CH ₃ O	+	CH ₂ OH	→	CH ₂ O	+	CH ₃ OH	4.00x10 ⁻¹¹	278	
CH ₃ O ₂	+	H ₂ O ₂	→	CH ₃ OOH	+	HO ₂	2.31x10 ⁻¹⁹	253	
CH ₃ O ₂	+	CH ₃ CO	→	CH ₃	+	CO ₂	+ CH ₃ O	4.00x10 ⁻¹¹	253
CH ₃ O ₂	+	CH ₃ OH	→	CH ₂ OH	+	CH ₃ OOH	3.08x10 ⁻²²	278	
CH ₃ O ₂	+	CH ₂ OH	→	CH ₃ O	+	OH	+ CH ₂ O	2.00x10 ⁻¹¹	278
H ₂ O ₂	+	CH ₃ CO	→	CH ₃ CHO	+	HO ₂	3.05x10 ⁻¹⁹	253	
H ₂ O ₂	+	CH ₂ OH	→	CH ₃ OH	+	HO ₂	6.56x10 ⁻¹⁷	278	
CH ₃ CO	+	CH ₃ OH	→	CH ₃ CHO	+	CH ₂ OH	2.22x10 ⁻²²	278	

CH_3OH	+	CH_2OH	\rightarrow	CH_3OH	+	CH_3O	2.12×10^{-23}	²⁷⁸
CH_2OH	+	CH_2OH	\rightarrow	CH_2O	+	CH_3OH	8.00×10^{-12}	²⁷⁸

Table A.4. Ion-neutral and ion-ion reactions included in the model, as well as the corresponding rate coefficients and the references where these data were adopted from. The rate coefficients are expressed in $\text{cm}^3 \text{s}^{-1}$ and $\text{cm}^6 \text{s}^{-1}$ for two-body and three-body reactions, respectively.

CH_5^+	+	CH_2	\rightarrow	CH_3^+	+	CH_4	9.60×10^{-10}	²⁸⁴
CH_5^+	+	CH	\rightarrow	CH_2^+	+	CH_4	6.90×10^{-10}	²⁸⁴
CH_5^+	+	C	\rightarrow	CH^+	+	CH_4	1.20×10^{-09}	²⁸⁴
CH_5^+	+	C_2H_6	\rightarrow	C_2H_5^+	+	$\text{H}_2 + \text{CH}_4$	2.25×10^{-10}	²⁸⁵
CH_5^+	+	C_2H_4	\rightarrow	C_2H_5^+	+	CH_4	1.50×10^{-09}	²⁸⁴
CH_5^+	+	C_2H_2	\rightarrow	C_2H_3^+	+	CH_4	1.60×10^{-09}	²⁸⁴
CH_5^+	+	C_2H	\rightarrow	C_2H_2^+	+	CH_4	9.00×10^{-10}	²⁸⁴
CH_5^+	+	C_2	\rightarrow	C_2H^+	+	CH_4	9.50×10^{-10}	²⁸⁴
CH_5^+	+	H	\rightarrow	CH_4^+	+	H_2	1.50×10^{-10}	²⁸⁴
CH_5^+	+	O	\rightarrow	H_3O^+	+	CH_2	2.20×10^{-10}	²⁸⁴
CH_5^+	+	H_2O	\rightarrow	H_3O^+	+	CH_4	3.70×10^{-09}	²⁸⁴
CH_5^+	+	OH	\rightarrow	H_2O^+	+	CH_4	7.00×10^{-10}	²⁸⁴
CH_4^+	+	CH_4	\rightarrow	CH_5^+	+	CH_3	1.50×10^{-09}	²⁸⁴
CH_4^+	+	C_2H_6	\rightarrow	C_2H_4^+	+	$\text{CH}_4 + \text{H}_2$	1.91×10^{-09}	²⁸⁵
CH_4^+	+	C_2H_4	\rightarrow	C_2H_5^+	+	CH_3	4.23×10^{-10}	²⁸⁴
CH_4^+	+	C_2H_4	\rightarrow	C_2H_4^+	+	CH_4	1.38×10^{-09}	²⁸⁴
CH_4^+	+	C_2H_2	\rightarrow	C_2H_3^+	+	CH_3	1.23×10^{-09}	²⁸⁴
CH_4^+	+	C_2H_2	\rightarrow	C_2H_2^+	+	CH_4	1.13×10^{-09}	²⁸⁴
CH_4^+	+	H_2	\rightarrow	CH_5^+	+	H	3.30×10^{-11}	²⁸⁴
CH_4^+	+	H	\rightarrow	CH_3^+	+	H_2	1.00×10^{-11}	²⁸⁴
CH_4^+	+	O	\rightarrow	CH_3^+	+	OH	1.00×10^{-09}	²⁸⁴
CH_4^+	+	O_2	\rightarrow	O_2^+	+	CH_4	3.90×10^{-10}	²⁸⁴

Appendices Table A.4.

CH_4^+	+	H_2O	\rightarrow	H_3O^+	+	CH_3	2.60×10^{-09}	284
CH_3^+	+	CH_4	\rightarrow	CH_4^+	+	CH_3	1.36×10^{-10}	286
CH_3^+	+	CH_4	\rightarrow	C_2H_5^+	+	H_2	1.20×10^{-09}	284
CH_3^+	+	CH_2	\rightarrow	C_2H_3^+	+	H_2	9.90×10^{-10}	284
CH_3^+	+	CH	\rightarrow	C_2H_2^+	+	H_2	7.10×10^{-10}	284
CH_3^+	+	C	\rightarrow	C_2H^+	+	H_2	1.20×10^{-09}	284
CH_3^+	+	C_2H_6	\rightarrow	C_2H_5^+	+	CH_4	1.48×10^{-09}	284
CH_3^+	+	C_2H_4	\rightarrow	C_2H_3^+	+	CH_4	3.50×10^{-10}	284
CH_3^+	+	C_2H_3	\rightarrow	C_2H_3^+	+	CH_3	3.00×10^{-10}	284
CH_2^+	+	CH_4	\rightarrow	CH_3^+	+	CH_3	1.38×10^{-10}	81
CH_2^+	+	CH_4	\rightarrow	C_2H_5^+	+	H	3.60×10^{-10}	284
CH_2^+	+	CH_4	\rightarrow	C_2H_4^+	+	H_2	8.40×10^{-10}	284
CH_2^+	+	CH_4	\rightarrow	C_2H_3^+	+	$\text{H}_2 + \text{H}$	2.31×10^{-10}	81
CH_2^+	+	CH_4	\rightarrow	C_2H_2^+	+	2H_2	3.97×10^{-10}	81
CH_2^+	+	C	\rightarrow	C_2H^+	+	H	1.20×10^{-09}	284
CH_2^+	+	H_2	\rightarrow	CH_3^+	+	H	1.60×10^{-09}	284
CH^+	+	CH_4	\rightarrow	C_2H_4^+	+	H	6.50×10^{-11}	284
CH^+	+	CH_4	\rightarrow	C_2H_3^+	+	H_2	1.09×10^{-09}	284
CH^+	+	CH_4	\rightarrow	C_2H_2^+	+	$\text{H}_2 + \text{H}$	1.43×10^{-10}	284
CH^+	+	CH_2	\rightarrow	C_2H^+	+	H_2	1.00×10^{-09}	284
CH^+	+	CH	\rightarrow	C_2^+	+	H_2	7.40×10^{-10}	284
CH^+	+	C	\rightarrow	C_2^+	+	H	1.20×10^{-09}	284
CH^+	+	H_2	\rightarrow	CH_2^+	+	H	1.20×10^{-09}	284
CH^+	+	H	\rightarrow	C^+	+	H_2	7.50×10^{-10}	284
CH^+	+	O	\rightarrow	CO^+	+	H	3.50×10^{-10}	284
CH^+	+	O_2	\rightarrow	CO^+	+	OH	1.00×10^{-11}	284

CH^+	+	O_2	\rightarrow	O^+	+	CHO	1.00×10^{-11}	284
CH^+	+	H_2O	\rightarrow	H_3O^+	+	C	5.80×10^{-10}	284
CH^+	+	OH	\rightarrow	CO^+	+	H_2	7.50×10^{-10}	284
C^+	+	CH_4	\rightarrow	C_2H_3^+	+	H	1.10×10^{-09}	284
C^+	+	CH_4	\rightarrow	C_2H_2^+	+	H_2	4.00×10^{-10}	284
C^+	+	CH_3	\rightarrow	C_2H_2^+	+	H	1.30×10^{-09}	284
C^+	+	CH_3	\rightarrow	C_2H^+	+	H_2	1.00×10^{-09}	284
C^+	+	CH_2	\rightarrow	CH_2^+	+	C	5.20×10^{-10}	284
C^+	+	CH_2	\rightarrow	C_2H^+	+	H	5.20×10^{-10}	284
C^+	+	CH	\rightarrow	CH^+	+	C	3.80×10^{-10}	284
C^+	+	CH	\rightarrow	C_2^+	+	H	3.80×10^{-10}	284
C^+	+	C_2H_6	\rightarrow	C_2H_5^+	+	CH	2.31×10^{-10}	284
C^+	+	C_2H_6	\rightarrow	C_2H_4^+	+	CH_2	1.16×10^{-10}	284
C^+	+	C_2H_6	\rightarrow	C_2H_3^+	+	CH_3	4.95×10^{-10}	284
C^+	+	C_2H_6	\rightarrow	C_2H_2^+	+	CH_4	8.25×10^{-11}	284
C^+	+	C_2H_5	\rightarrow	C_2H_5^+	+	C	5.00×10^{-10}	284
C^+	+	C_2H_4	\rightarrow	C_2H_4^+	+	C	1.70×10^{-11}	284
C^+	+	C_2H_4	\rightarrow	C_2H_3^+	+	CH	8.50×10^{-11}	284
C^+	+	O_2	\rightarrow	O^+	+	CO	6.20×10^{-10}	284
C^+	+	O_2	\rightarrow	CO^+	+	O	3.80×10^{-10}	284
C^+	+	OH	\rightarrow	CO^+	+	H	7.70×10^{-10}	284
C^+	+	CO_2	\rightarrow	CO^+	+	CO	1.10×10^{-09}	284
C^+	+	H^-	\rightarrow	C	+	H	2.30×10^{-07}	284
C_2H_6^+	+	C_2H_4	\rightarrow	C_2H_4^+	+	C_2H_6	1.15×10^{-09}	284
C_2H_6^+	+	C_2H_2	\rightarrow	C_2H_5^+	+	C_2H_3	2.47×10^{-10}	284
C_2H_6^+	+	H	\rightarrow	C_2H_5^+	+	H_2	1.00×10^{-10}	284

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$C_2H_6^+$	+	H_2O	\rightarrow	H_3O^+	+	C_2H_5	2.95×10^{-09}	284
$C_2H_5^+$	+	H	\rightarrow	$C_2H_4^+$	+	H_2	1.00×10^{-11}	284
$C_2H_5^+$	+	H_2O	\rightarrow	H_3O^+	+	C_2H_4	1.40×10^{-09}	284
$C_2H_4^+$	+	C_2H_3	\rightarrow	$C_2H_5^+$	+	C_2H_2	5.00×10^{-10}	284
$C_2H_4^+$	+	C_2H_3	\rightarrow	$C_2H_3^+$	+	C_2H_4	5.00×10^{-10}	284
$C_2H_4^+$	+	H	\rightarrow	$C_2H_3^+$	+	H_2	3.00×10^{-10}	284
$C_2H_4^+$	+	O	\rightarrow	CH_3^+	+	CHO	1.08×10^{-10}	284
$C_2H_3^+$	+	C_2H_6	\rightarrow	$C_2H_5^+$	+	C_2H_4	2.91×10^{-10}	284
$C_2H_3^+$	+	C_2H_4	\rightarrow	$C_2H_5^+$	+	C_2H_2	8.90×10^{-10}	284
$C_2H_3^+$	+	C_2H_3	\rightarrow	$C_2H_5^+$	+	C_2H	5.00×10^{-10}	284
$C_2H_3^+$	+	C_2H	\rightarrow	$C_2H_2^+$	+	C_2H_2	3.30×10^{-10}	284
$C_2H_3^+$	+	H	\rightarrow	$C_2H_2^+$	+	H_2	6.80×10^{-11}	284
$C_2H_3^+$	+	H_2O	\rightarrow	H_3O^+	+	C_2H_2	1.11×10^{-09}	284
$C_2H_2^+$	+	CH_4	\rightarrow	$C_2H_3^+$	+	CH_3	4.10×10^{-09}	81
$C_2H_2^+$	+	C_2H_6	\rightarrow	$C_2H_5^+$	+	C_2H_3	1.31×10^{-10}	285
$C_2H_2^+$	+	C_2H_6	\rightarrow	$C_2H_4^+$	+	C_2H_4	2.48×10^{-10}	284
$C_2H_2^+$	+	C_2H_4	\rightarrow	$C_2H_4^+$	+	C_2H_2	4.14×10^{-10}	284
$C_2H_2^+$	+	C_2H_3	\rightarrow	$C_2H_3^+$	+	C_2H_2	3.30×10^{-10}	284
$C_2H_2^+$	+	H_2	\rightarrow	$C_2H_3^+$	+	H	1.00×10^{-11}	284
$C_2H_2^+$	+	H_2O	\rightarrow	H_3O^+	+	C_2H	2.20×10^{-10}	284
C_2H^+	+	CH_4	\rightarrow	$C_2H_2^+$	+	CH_3	3.74×10^{-10}	284
C_2H^+	+	CH_2	\rightarrow	CH_3^+	+	C_2	4.40×10^{-10}	284
C_2H^+	+	CH	\rightarrow	CH_2^+	+	C_2	3.20×10^{-10}	284
C_2H^+	+	H_2	\rightarrow	$C_2H_2^+$	+	H	1.10×10^{-09}	284
C_2^+	+	CH_4	\rightarrow	$C_2H_2^+$	+	CH_2	1.82×10^{-10}	284
C_2^+	+	CH_4	\rightarrow	C_2H^+	+	CH_3	2.38×10^{-10}	284

C_2^+	+	CH_2	\rightarrow	CH_2^+	+	C_2	4.50×10^{-10}	284
C_2^+	+	CH	\rightarrow	CH^+	+	C_2	3.20×10^{-10}	284
C_2^+	+	C	\rightarrow	C^+	+	C_2	1.10×10^{-10}	284
C_2^+	+	H_2	\rightarrow	C_2H^+	+	H	1.10×10^{-09}	284
C_2^+	+	O	\rightarrow	CO^+	+	C	3.10×10^{-10}	284
C_2^+	+	O_2	\rightarrow	CO^+	+	CO	8.00×10^{-10}	284
C_2^+	+	H_2O	\rightarrow	C_2H^+	+	OH	4.40×10^{-10}	284
C_2^+	+	OH	\rightarrow	OH^+	+	C_2	6.50×10^{-10}	284
H_3^+	+	CH_4	\rightarrow	CH_5^+	+	H_2	2.40×10^{-09}	284
H_3^+	+	CH_3	\rightarrow	CH_4^+	+	H_2	2.10×10^{-09}	284
H_3^+	+	CH_2	\rightarrow	CH_3^+	+	H_2	1.70×10^{-09}	284
H_3^+	+	CH	\rightarrow	CH_2^+	+	H_2	1.20×10^{-09}	284
H_3^+	+	C	\rightarrow	CH^+	+	H_2	2.00×10^{-09}	284
H_3^+	+	C_2H_6	\rightarrow	$C_2H_5^+$	+	$2H_2$	2.40×10^{-09}	284
H_3^+	+	C_2H_5	\rightarrow	$C_2H_6^+$	+	H_2	1.40×10^{-09}	284
H_3^+	+	C_2H_4	\rightarrow	$C_2H_5^+$	+	H_2	1.15×10^{-09}	284
H_3^+	+	C_2H_4	\rightarrow	$C_2H_3^+$	+	$2H_2$	1.15×10^{-09}	284
H_3^+	+	C_2H_3	\rightarrow	$C_2H_4^+$	+	H_2	2.00×10^{-09}	284
H_3^+	+	C_2H_2	\rightarrow	$C_2H_3^+$	+	H_2	3.50×10^{-09}	284
H_3^+	+	C_2H	\rightarrow	$C_2H_2^+$	+	H_2	1.70×10^{-09}	284
H_3^+	+	C_2	\rightarrow	C_2H^+	+	H_2	1.80×10^{-09}	284
H_3^+	+	O	\rightarrow	OH^+	+	H_2	8.40×10^{-10}	284
H_3^+	+	O	\rightarrow	H_2O^+	+	H	3.60×10^{-10}	284
H_3^+	+	OH	\rightarrow	H_2O^+	+	H_2	1.30×10^{-09}	284
H_3^+	+	H_2O	\rightarrow	H_3O^+	+	H_2	5.90×10^{-09}	284
H_3^+	+	H^-	\rightarrow	H_2	+	H_2	2.30×10^{-07}	284

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H_2^+	+	CH_4	\rightarrow	CH_5^+	+	H	1.14×10^{-10}	284
H_2^+	+	CH_4	\rightarrow	CH_4^+	+	H_2	1.40×10^{-09}	284
H_2^+	+	CH_4	\rightarrow	CH_3^+	+	$H_2 + H$	2.30×10^{-09}	284
H_2^+	+	CH_2	\rightarrow	CH_3^+	+	H	1.00×10^{-09}	284
H_2^+	+	CH_2	\rightarrow	CH_2^+	+	H_2	1.00×10^{-09}	284
H_2^+	+	CH	\rightarrow	CH_2^+	+	H	7.10×10^{-10}	284
H_2^+	+	CH	\rightarrow	CH^+	+	H_2	7.10×10^{-10}	284
H_2^+	+	C	\rightarrow	CH^+	+	H	2.40×10^{-09}	284
H_2^+	+	C_2H_6	\rightarrow	$C_2H_6^+$	+	H_2	2.94×10^{-10}	284
H_2^+	+	C_2H_6	\rightarrow	$C_2H_5^+$	+	$H_2 + H$	1.37×10^{-09}	284
H_2^+	+	C_2H_6	\rightarrow	$C_2H_4^+$	+	$2H_2$	2.35×10^{-09}	284
H_2^+	+	C_2H_6	\rightarrow	$C_2H_3^+$	+	$2H_2 + H$	6.86×10^{-10}	285
H_2^+	+	C_2H_6	\rightarrow	$C_2H_2^+$	+	$3H_2$	1.96×10^{-10}	285
H_2^+	+	C_2H_4	\rightarrow	$C_2H_4^+$	+	H_2	2.21×10^{-09}	284
H_2^+	+	C_2H_4	\rightarrow	$C_2H_3^+$	+	$H_2 + H$	1.81×10^{-09}	284
H_2^+	+	C_2H_4	\rightarrow	$C_2H_2^+$	+	$2H_2$	8.82×10^{-10}	284
H_2^+	+	C_2H_2	\rightarrow	$C_2H_3^+$	+	H	4.80×10^{-10}	284
H_2^+	+	C_2H_2	\rightarrow	$C_2H_2^+$	+	H_2	4.82×10^{-09}	284
H_2^+	+	C_2H	\rightarrow	$C_2H_2^+$	+	H	1.00×10^{-09}	284
H_2^+	+	C_2H	\rightarrow	C_2H^+	+	H_2	1.00×10^{-09}	284
H_2^+	+	C_2	\rightarrow	C_2H^+	+	H	1.10×10^{-09}	284
H_2^+	+	C_2	\rightarrow	C_2^+	+	H_2	1.10×10^{-09}	284
H_2^+	+	H_2	\rightarrow	H_3^+	+	H	2.08×10^{-09}	284
H_2^+	+	H	\rightarrow	H^+	+	H_2	6.40×10^{-10}	284
H_2^+	+	O	\rightarrow	OH^+	+	H	1.50×10^{-09}	284
H_2^+	+	O_2	\rightarrow	O_2^+	+	H_2	8.00×10^{-10}	284

H_2^+	+	OH	\rightarrow	OH^+	+	H_2	7.60×10^{-10}	284
H_2^+	+	OH	\rightarrow	H_2O^+	+	H	7.60×10^{-10}	284
H_2^+	+	H_2O	\rightarrow	H_2O^+	+	H_2	3.90×10^{-09}	284
H_2^+	+	H_2O	\rightarrow	H_3O^+	+	H	3.40×10^{-09}	284
H_2^+	+	CO	\rightarrow	CO^+	+	H_2	6.44×10^{-10}	284
H_2^+	+	H^-	\rightarrow	H_2	+	H	2.30×10^{-07}	284
H^+	+	CH_4	\rightarrow	CH_4^+	+	H	1.50×10^{-09}	284
H^+	+	CH_4	\rightarrow	CH_3^+	+	H_2	2.30×10^{-09}	284
H^+	+	CH_3	\rightarrow	CH_3^+	+	H	3.40×10^{-09}	284
H^+	+	CH_2	\rightarrow	CH_2^+	+	H	1.40×10^{-09}	284
H^+	+	CH_2	\rightarrow	CH^+	+	H_2	1.40×10^{-09}	284
H^+	+	CH	\rightarrow	CH^+	+	H	1.90×10^{-09}	284
H^+	+	C_2H_6	\rightarrow	$C_2H_5^+$	+	H_2	1.30×10^{-09}	285
H^+	+	C_2H_6	\rightarrow	$C_2H_4^+$	+	$H_2 + H$	1.40×10^{-09}	284
H^+	+	C_2H_6	\rightarrow	$C_2H_3^+$	+	$2H_2$	2.80×10^{-09}	284
H^+	+	C_2H_5	\rightarrow	$C_2H_4^+$	+	H_2	1.65×10^{-09}	284
H^+	+	C_2H_5	\rightarrow	$C_2H_3^+$	+	$H_2 + H$	3.06×10^{-09}	284
H^+	+	C_2H_4	\rightarrow	$C_2H_4^+$	+	H	1.00×10^{-09}	284
H^+	+	C_2H_4	\rightarrow	$C_2H_3^+$	+	H_2	3.00×10^{-09}	284
H^+	+	C_2H_4	\rightarrow	$C_2H_2^+$	+	$H_2 + H$	1.00×10^{-09}	284
H^+	+	C_2H_3	\rightarrow	$C_2H_3^+$	+	H	2.00×10^{-09}	284
H^+	+	C_2H_3	\rightarrow	$C_2H_2^+$	+	H_2	2.00×10^{-09}	284
H^+	+	C_2H_2	\rightarrow	$C_2H_2^+$	+	H	5.40×10^{-10}	284
H^+	+	C_2H	\rightarrow	C_2H^+	+	H	1.50×10^{-09}	284
H^+	+	C_2H	\rightarrow	C_2^+	+	H_2	1.50×10^{-09}	284
H^+	+	C_2	\rightarrow	C_2^+	+	H	3.10×10^{-09}	284

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H^+	+	O	\rightarrow	O^+	+	H	3.44×10^{-10}	284		
H^+	+	O_2	\rightarrow	O_2^+	+	H	2.00×10^{-09}	284		
H^+	+	OH	\rightarrow	OH^+	+	H	2.10×10^{-09}	284		
H^+	+	H_2O	\rightarrow	H_2O^+	+	H	6.90×10^{-09}	284		
H^+	+	H^-	\rightarrow	H	+	H	2.30×10^{-07}	284		
H^-	+	CH_3	\rightarrow	CH_4	+	e^-	1.00×10^{-09}	284		
H^-	+	CH_2	\rightarrow	CH_3	+	e^-	1.00×10^{-09}	284		
H^-	+	CH	\rightarrow	CH_2	+	e^-	1.00×10^{-10}	284		
H^-	+	C	\rightarrow	CH	+	e^-	1.00×10^{-09}	284		
H^-	+	C_2H	\rightarrow	C_2H_2	+	e^-	1.00×10^{-09}	284		
H^-	+	C_2	\rightarrow	C_2H	+	e^-	1.00×10^{-09}	284		
H^-	+	H	\rightarrow	H_2	+	e^-	1.30×10^{-09}	284		
H^-	+	O	\rightarrow	OH	+	e^-	1.00×10^{-09}	284		
H^-	+	OH	\rightarrow	H_2O	+	e^-	1.00×10^{-10}	284		
H^-	+	H_2O	\rightarrow	OH^-	+	H_2	3.80×10^{-09}	284		
H^-	+	O^+	\rightarrow	H	+	O	2.30×10^{-07}	284		
H^-	+	H_3O^+	\rightarrow	H_2	+	OH	+	H	2.30×10^{-07}	284
H^-	+	H_3O^+	\rightarrow	H_2O	+	H_2	2.30×10^{-07}	284		
O^+	+	CH_4	\rightarrow	CH_4^+	+	O	8.90×10^{-10}	284		
O^+	+	CH_4	\rightarrow	CH_3^+	+	OH	1.10×10^{-10}	284		
O^+	+	CH_2	\rightarrow	CH_2^+	+	O	9.70×10^{-10}	284		
O^+	+	CH	\rightarrow	CH^+	+	O	3.50×10^{-10}	284		
O^+	+	CH	\rightarrow	CO^+	+	H	3.50×10^{-10}	284		
O^+	+	C_2H_4	\rightarrow	$C_2H_4^+$	+	O	7.00×10^{-11}	284		
O^+	+	C_2H_4	\rightarrow	$C_2H_3^+$	+	OH	2.10×10^{-10}	284		
O^+	+	C_2H_4	\rightarrow	$C_2H_2^+$	+	H_2O	1.12×10^{-09}	284		

O^+	+	C_2H_2	\rightarrow	$C_2H_2^+$	+	O	3.90×10^{-11}	284		
O^+	+	C_2H	\rightarrow	C_2H^+	+	O	4.60×10^{-10}	284		
O^+	+	C_2H	\rightarrow	CO^+	+	CH	4.60×10^{-10}	284		
O^+	+	C_2	\rightarrow	C_2^+	+	O	4.80×10^{-10}	284		
O^+	+	C_2	\rightarrow	CO^+	+	C	4.80×10^{-10}	284		
O^+	+	H_2	\rightarrow	OH^+	+	H	1.70×10^{-09}	284		
O^+	+	H	\rightarrow	H^+	+	O	5.82×10^{-10}	284		
O^+	+	O	+	O_2	\rightarrow	O_2^+	+	O_2	1.00×10^{-29}	195
O^+	+	O_2	\rightarrow	O_2^+	+	O	2.00×10^{-11}	195		
O^+	+	O_3	\rightarrow	O_2^+	+	O_2	1.00×10^{-10}	241		
O^+	+	OH	\rightarrow	OH^+	+	O	3.60×10^{-10}	284		
O^+	+	OH	\rightarrow	O_2^+	+	H	3.60×10^{-10}	284		
O^+	+	H_2O	\rightarrow	H_2O^+	+	O	3.20×10^{-09}	284		
O^+	+	CO_2	\rightarrow	O_2^+	+	CO	9.40×10^{-10}	284		
O^+	+	CO	\rightarrow	CO^+	+	O	1.15×10^{-18}	284		
O^+	+	O^-	\rightarrow	O	+	O	4.00×10^{-08}	287		
O^+	+	O^-	+	O	\rightarrow	O_2	+	O	2.00×10^{-25}	195
O^+	+	O^-	+	O_2	\rightarrow	O_2	+	O_2	2.00×10^{-25}	195
O^+	+	O_2^-	\rightarrow	O	+	O_2	2.70×10^{-07}	287		
O^+	+	O_2^-	+	O_2	\rightarrow	O_3	+	O_2	2.00×10^{-25}	195
O^+	+	O_3^-	\rightarrow	O_3	+	O	1.00×10^{-07}	195		
O_2^+	+	CH_2	\rightarrow	CH_2^+	+	O_2	4.30×10^{-10}	284		
O_2^+	+	CH	\rightarrow	CH^+	+	O_2	3.10×10^{-10}	284		
O_2^+	+	C	\rightarrow	CO^+	+	O	5.20×10^{-11}	284		
O_2^+	+	C	\rightarrow	C^+	+	O_2	5.20×10^{-11}	284		
O_2^+	+	C_2H_4	\rightarrow	$C_2H_4^+$	+	O_2	6.80×10^{-10}	284		

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O_2^+	+	C_2H_2	\rightarrow	$C_2H_2^+$	+	O_2	1.11×10^{-09}	284				
O_2^+	+	C_2	\rightarrow	C_2^+	+	O_2	4.10×10^{-10}	284				
O_2^+	+	C_2	\rightarrow	CO^+	+	CO	4.10×10^{-10}	284				
O_2^+	+	O_2	+	O_2	\rightarrow	O_4^+	+	O_2	2.40×10^{-30}	241		
O_2^+	+	O^-	\rightarrow	O	+	O_2	2.60×10^{-08}	287				
O_2^+	+	O^-	\rightarrow	O	+	O	+	O	2.60×10^{-08}	287		
O_2^+	+	O^-	+	O_2	\rightarrow	O_3	+	O_2	2.00×10^{-25}	195		
O_2^+	+	O_2^-	\rightarrow	O_2	+	O_2	2.00×10^{-07}	287				
O_2^+	+	O_2^-	\rightarrow	O_2	+	O	+	O	1.00×10^{-07}	195		
O_2^+	+	O_2^-	+	O_2	\rightarrow	O_2	+	O_2	+	O_2	2.00×10^{-25}	195
O_2^+	+	O_3^-	\rightarrow	O_2	+	O_3	2.00×10^{-07}	195				
O_2^+	+	O_3^-	\rightarrow	O	+	O	+	O_3	1.00×10^{-07}	195		
O_4^+	+	O	\rightarrow	O_2^+	+	O_3	3.00×10^{-10}	241				
O_4^+	+	O_2	\rightarrow	O_2^+	+	O_2	+	O_2	1.73×10^{-13}	241		
O^-	+	CH_4	\rightarrow	OH^-	+	CH_3	1.00×10^{-10}	284				
O^-	+	C	\rightarrow	CO	+	e^-	5.00×10^{-10}	284				
O^-	+	H_2	\rightarrow	H_2O	+	e^-	7.00×10^{-10}	284				
O^-	+	H_2	\rightarrow	OH^-	+	H	3.00×10^{-11}	284				
O^-	+	H	\rightarrow	OH	+	e^-	5.00×10^{-10}	284				
O^-	+	O	\rightarrow	O_2	+	e^-	2.30×10^{-10}	287				
O^-	+	O_2	\rightarrow	O	+	O_2	+	e^-	$k = f(E/N)$	195		
O^-	+	O_2	\rightarrow	O_2^-	+	O	$k = f(E/N)$	195				
O^-	+	O_2	\rightarrow	O_3	+	e^-	5.00×10^{-15}	195				
O^-	+	O_2	+	O_2	\rightarrow	O_3^-	+	O_2	1.10×10^{-30}	195		
O^-	+	O_3	\rightarrow	O_3^-	+	O	5.30×10^{-10}	195				
O^-	+	O_3	\rightarrow	O_2	+	O_2	+	e^-	3.00×10^{-10}	288		

O^-	+	CO	→	CO ₂	+	e ⁻	6.50x10 ⁻¹⁰	284
O ₂ ⁻	+	O	→	O ⁻	+	O ₂	3.30x10 ⁻¹⁰	195
O ₂ ⁻	+	O	→	O ₃	+	e ⁻	3.30x10 ⁻¹⁰	287
O ₂ ⁻	+	O ₂	→	O ₂	+	O ₂	+ e ⁻	2.18x10 ⁻¹⁸ 195
O ₂ ⁻	+	O ₂	+ O ₂	→	O ₄ ⁻	+	O ₂	3.50x10 ⁻³¹ 241
O ₂ ⁻	+	O ₃	→	O ₃ ⁻	+	O ₂	4.00x10 ⁻¹⁰	195
O ₃ ⁻	+	O	→	O ⁻	+	O ₃	1.00x10 ⁻¹³	288
O ₃ ⁻	+	O	→	O ₂	+	O ₂	+ e ⁻	3.00x10 ⁻¹⁰ 241
O ₃ ⁻	+	O	→	O ₂ ⁻	+	O ₂	3.20x10 ⁻¹⁰	241
O ₃ ⁻	+	O ₂	→	O ₃	+	O ₂	+ e ⁻	2.30x10 ⁻¹¹ 195
O ₃ ⁻	+	O ₃	→	O ₂	+	O ₂	+ O ₂	+ e ⁻ 1.00x10 ⁻¹² 288
O ₄ ⁻	+	O	→	O ₃ ⁻	+	O ₂	4.00x10 ⁻¹⁰	241
O ₄ ⁻	+	O	→	O ⁻	+	O ₂	+ O ₂	3.00x10 ⁻¹⁰ 241
O ₄ ⁻	+	O ₂	→	O ₂ ⁻	+	O ₂	+ O ₂	3.08x10 ⁻¹² 241
CO ₂ ⁺	+	CH ₄	→	CH ₄ ⁺	+	CO ₂	5.50x10 ⁻¹⁰	284
CO ₂ ⁺	+	C ₂ H ₄	→	C ₂ H ₄ ⁺	+	CO ₂	1.50x10 ⁻¹⁰	284
CO ₂ ⁺	+	C ₂ H ₂	→	C ₂ H ₂ ⁺	+	CO ₂	7.30x10 ⁻¹⁰	284
CO ₂ ⁺	+	O ₂	→	O ₂ ⁺	+	CO ₂	5.30x10 ⁻¹¹	284
CO ₂ ⁺	+	O	→	O ₂ ⁺	+	CO	1.64x10 ⁻¹⁰	284
CO ₂ ⁺	+	O	→	O ⁺	+	CO ₂	9.62x10 ⁻¹¹	284
CO ₂ ⁺	+	H ₂ O	→	H ₂ O ⁺	+	CO ₂	2.04x10 ⁻⁰⁹	284
CO ⁺	+	CH ₄	→	CH ₄ ⁺	+	CO	7.93x10 ⁻¹⁰	284
CO ⁺	+	CH ₂	→	CH ₂ ⁺	+	CO	4.30x10 ⁻¹⁰	284
CO ⁺	+	CH	→	CH ⁺	+	CO	3.20x10 ⁻¹⁰	284
CO ⁺	+	C	→	C ⁺	+	CO	1.10x10 ⁻¹⁰	284
CO ⁺	+	C ₂ H	→	C ₂ H ⁺	+	CO	3.90x10 ⁻¹⁰	284

Appendices Table A.4.

CO^+	+	C_2	\rightarrow	C_2^+	+	CO	8.40×10^{-10}	284
CO^+	+	H	\rightarrow	H^+	+	CO	7.50×10^{-10}	284
CO^+	+	O_2	\rightarrow	O_2^+	+	CO	1.20×10^{-10}	284
CO^+	+	O	\rightarrow	O^+	+	CO	1.40×10^{-10}	284
CO^+	+	CO_2	\rightarrow	CO_2^+	+	CO	1.00×10^{-9}	284
CO^+	+	H_2O	\rightarrow	H_2O^+	+	CO	1.72×10^{-9}	284
CO^+	+	OH	\rightarrow	OH^+	+	CO	3.10×10^{-10}	284
H_3O^+	+	CH_2	\rightarrow	CH_3^+	+	H_2O	9.40×10^{-10}	284
H_3O^+	+	CH	\rightarrow	CH_2^+	+	H_2O	6.80×10^{-10}	284
H_3O^+	+	C_2H_3	\rightarrow	C_2H_4^+	+	H_2O	2.00×10^{-9}	284
H_3O^+	+	C_2	\rightarrow	C_2H^+	+	H_2O	9.20×10^{-10}	284
H_2O^+	+	CH_4	\rightarrow	H_3O^+	+	CH_3	1.40×10^{-9}	284
H_2O^+	+	CH_2	\rightarrow	CH_3^+	+	OH	4.70×10^{-10}	284
H_2O^+	+	CH_2	\rightarrow	CH_2^+	+	H_2O	4.70×10^{-10}	284
H_2O^+	+	CH	\rightarrow	CH_2^+	+	OH	3.40×10^{-10}	284
H_2O^+	+	CH	\rightarrow	CH^+	+	H_2O	3.40×10^{-10}	284
H_2O^+	+	C	\rightarrow	CH^+	+	OH	1.10×10^{-9}	284
H_2O^+	+	C_2H_6	\rightarrow	H_3O^+	+	C_2H_5	1.33×10^{-9}	284
H_2O^+	+	C_2H_6	\rightarrow	C_2H_6^+	+	H_2O	6.40×10^{-11}	284
H_2O^+	+	C_2H_6	\rightarrow	C_2H_4^+	+	$\text{H}_2\text{O} + \text{H}_2$	1.92×10^{-10}	284
H_2O^+	+	C_2H_4	\rightarrow	C_2H_4^+	+	H_2O	1.50×10^{-9}	284
H_2O^+	+	C_2H_2	\rightarrow	C_2H_2^+	+	H_2O	1.90×10^{-9}	284
H_2O^+	+	C_2H	\rightarrow	C_2H_2^+	+	OH	4.40×10^{-10}	284
H_2O^+	+	C_2H	\rightarrow	C_2H^+	+	H_2O	4.40×10^{-10}	284
H_2O^+	+	C_2	\rightarrow	C_2H^+	+	OH	4.70×10^{-10}	284
H_2O^+	+	C_2	\rightarrow	C_2^+	+	H_2O	4.70×10^{-10}	284

H_2O^+	+	H_2	\rightarrow	H_3O^+	+	H	6.40×10^{-10}	284
H_2O^+	+	O_2	\rightarrow	O_2^+	+	H_2O	4.60×10^{-10}	284
H_2O^+	+	O	\rightarrow	O_2^+	+	H_2	4.00×10^{-11}	284
H_2O^+	+	H_2O	\rightarrow	H_3O^+	+	OH	2.10×10^{-09}	284
H_2O^+	+	OH	\rightarrow	H_3O^+	+	O	6.90×10^{-10}	284
OH^+	+	CH_4	\rightarrow	CH_5^+	+	O	1.95×10^{-10}	284
OH^+	+	CH_4	\rightarrow	H_3O^+	+	CH_2	1.31×10^{-09}	284
OH^+	+	CH_2	\rightarrow	CH_3^+	+	O	4.80×10^{-10}	284
OH^+	+	CH_2	\rightarrow	CH_2^+	+	OH	4.80×10^{-10}	284
OH^+	+	CH	\rightarrow	CH_2^+	+	O	3.50×10^{-10}	284
OH^+	+	CH	\rightarrow	CH^+	+	OH	3.50×10^{-10}	284
OH^+	+	C	\rightarrow	CH^+	+	O	1.20×10^{-09}	284
OH^+	+	C_2H_6	\rightarrow	H_3O^+	+	C_2H_4	1.60×10^{-10}	284
OH^+	+	C_2H_6	\rightarrow	C_2H_6^+	+	OH	4.80×10^{-11}	284
OH^+	+	C_2H_6	\rightarrow	C_2H_5^+	+	$\text{H}_2 + \text{O}$	3.20×10^{-10}	284
OH^+	+	C_2H_6	\rightarrow	C_2H_4^+	+	$\text{H}_2 + \text{OH}$	1.04×10^{-09}	284
OH^+	+	C_2H	\rightarrow	C_2H_2^+	+	O	4.50×10^{-10}	284
OH^+	+	C_2H	\rightarrow	C_2H^+	+	OH	4.50×10^{-10}	284
OH^+	+	C_2	\rightarrow	C_2H^+	+	O	4.80×10^{-10}	284
OH^+	+	C_2	\rightarrow	C_2^+	+	OH	4.80×10^{-10}	284
OH^+	+	H_2	\rightarrow	H_2O^+	+	H	1.01×10^{-09}	284
OH^+	+	O_2	\rightarrow	O_2^+	+	OH	5.90×10^{-10}	284
OH^+	+	O	\rightarrow	O_2^+	+	H	7.10×10^{-10}	284
OH^+	+	H_2O	\rightarrow	H_2O^+	+	OH	1.59×10^{-09}	284
OH^+	+	H_2O	\rightarrow	H_3O^+	+	O	1.30×10^{-09}	284
OH^+	+	OH	\rightarrow	H_2O^+	+	O	7.00×10^{-10}	284

Appendices Table A.4.

OH^-	+	CH_3	\rightarrow	CH_3OH	+	e^-	1.00×10^{-09}	²⁸⁴
OH^-	+	CH	\rightarrow	CH_2O	+	e^-	5.00×10^{-10}	²⁸⁴
OH^-	+	C	\rightarrow	CHO	+	e^-	5.00×10^{-10}	²⁸⁴
OH^-	+	H	\rightarrow	H_2O	+	e^-	1.40×10^{-09}	²⁸⁴

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